

A numerical investigation on the Discharges in Micromegas

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Motivation:

- The discharge phenomena in gaseous detectors is a complicated process.
- There are several factors responsible for it.

- The fine structures in MPGDs may give rise to localised high electric field.
- Such regions may influence the discharge in direct or indirect ways.

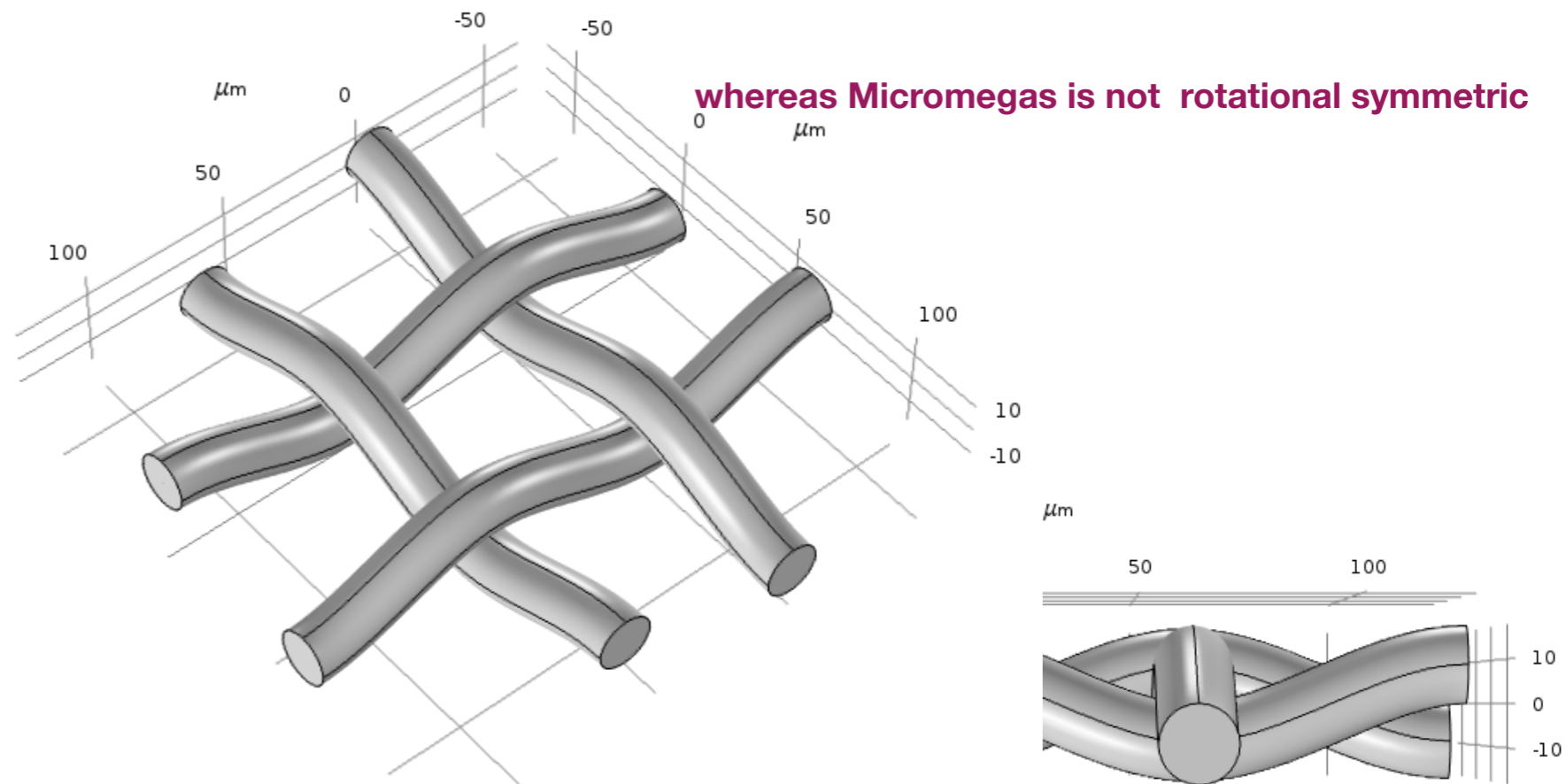
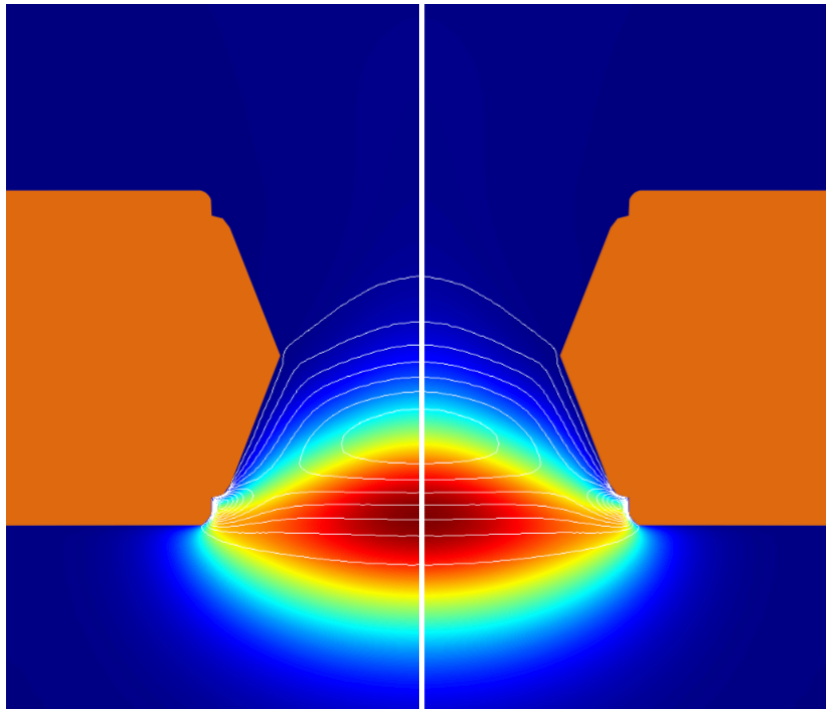
- This study aims to develop a numerical model for discharge
- To apply it for Micromegas geometry
- A systematic field study on different Micromegas geometry

Using COMSOL Multi-Physics for discharge modelling in full 3-D for Micromegas.

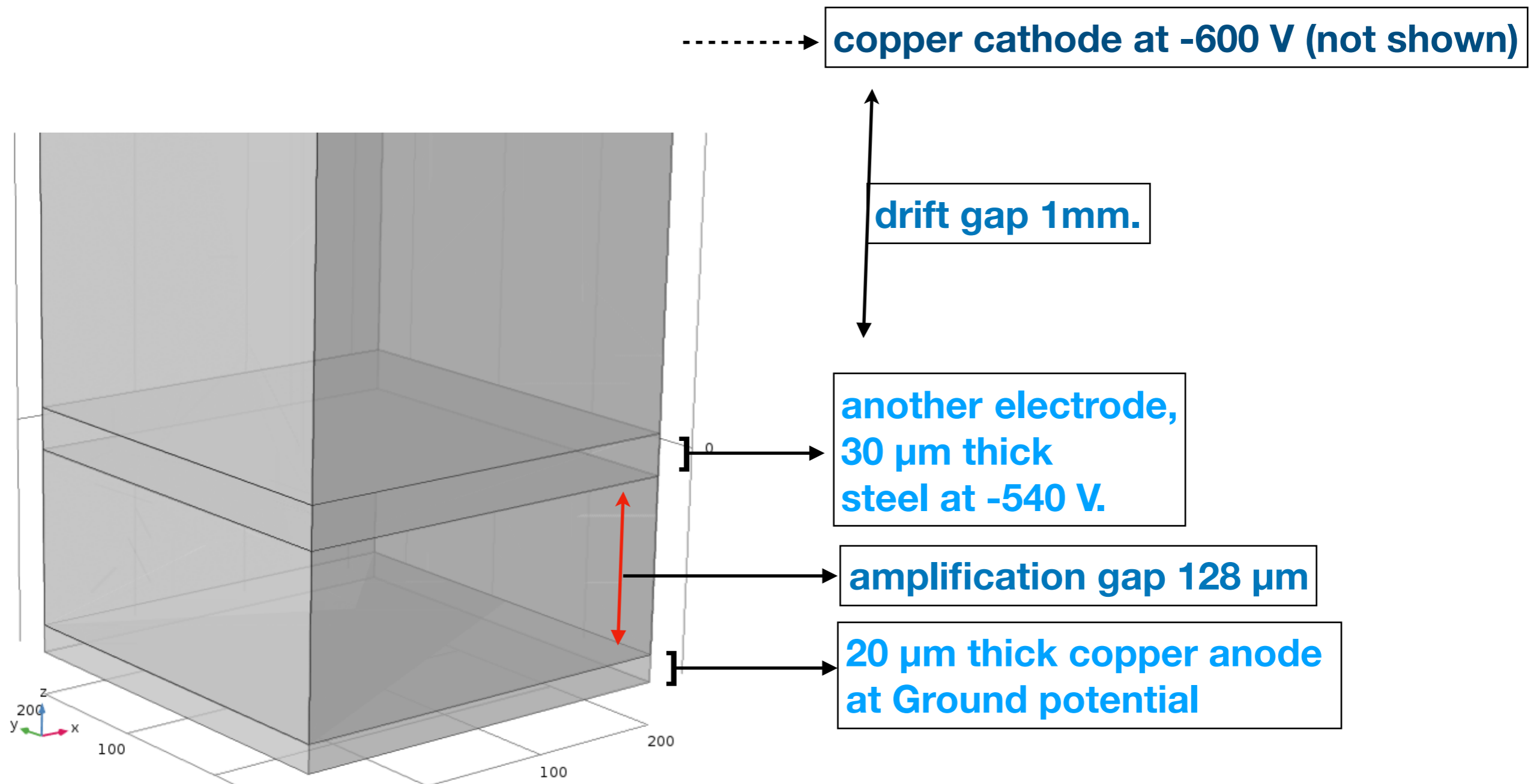
It worked quite good in 2D-axis symmetric geometry for GEM

But, Micromegas is not 2D-axis symmetric...

2D-axis symmetry is a good approximation for GEM



Let's start by solving the field in a parallel plate:

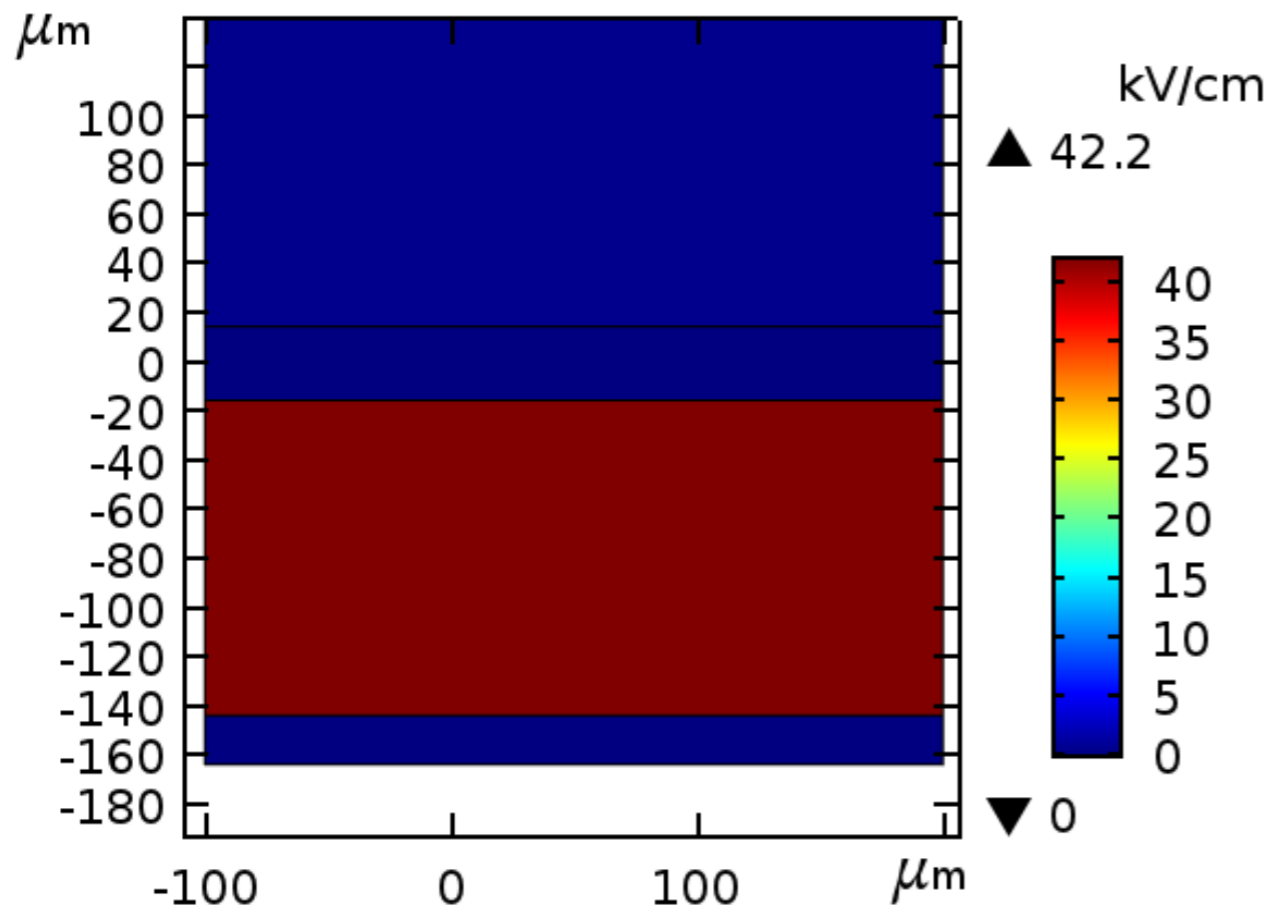


parallel plates

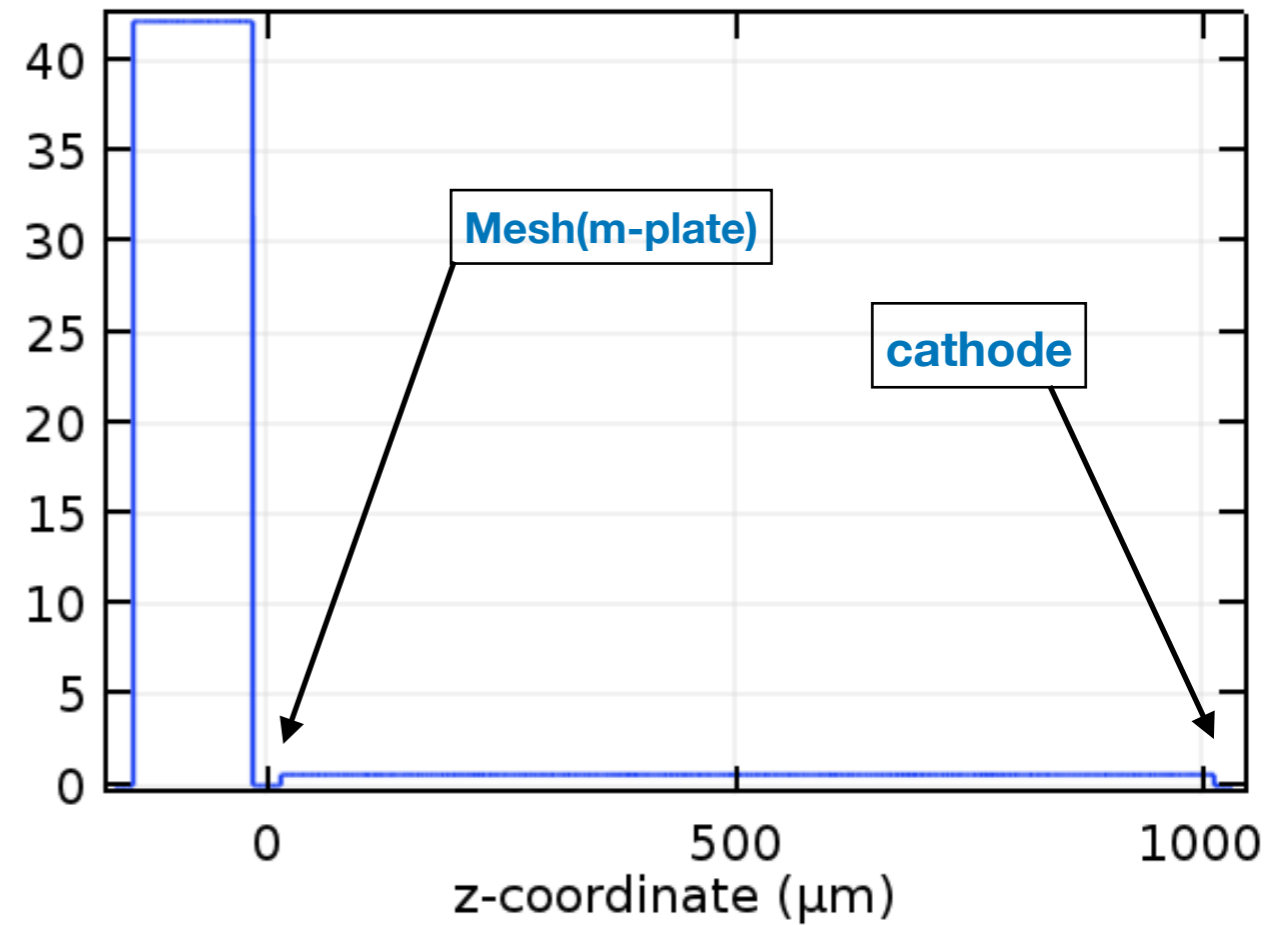
Electric field (on the YZ plane)

Along a line on the YZ plane, at X=Y= half pitch

Surface: Electric field (kV/cm)



Line Graph: Electric field (kV/cm)



The electric field is uniform through out.

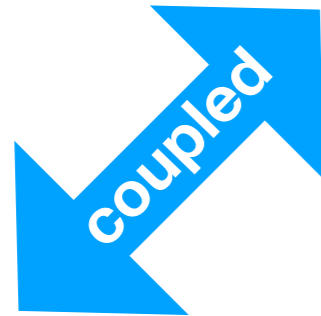
Building the discharge model

Building the physics model : (a simple approach)

Electrostatics
(stationary solution)

$$E = -\nabla V \quad (\text{electric field from given potential})$$

$$\nabla \cdot D = \rho_v \quad (\text{for space charge})$$



[Electrostatics]

[Transport of Diluted species]

$$\frac{\partial C_i}{\partial t} + \nabla \cdot (-D_i \nabla C_i) + u \cdot \nabla C_i = R_i$$

$$R_i = n_e u (\alpha - AC - X)$$

charge transport
and multiplication
(time dependent solution)

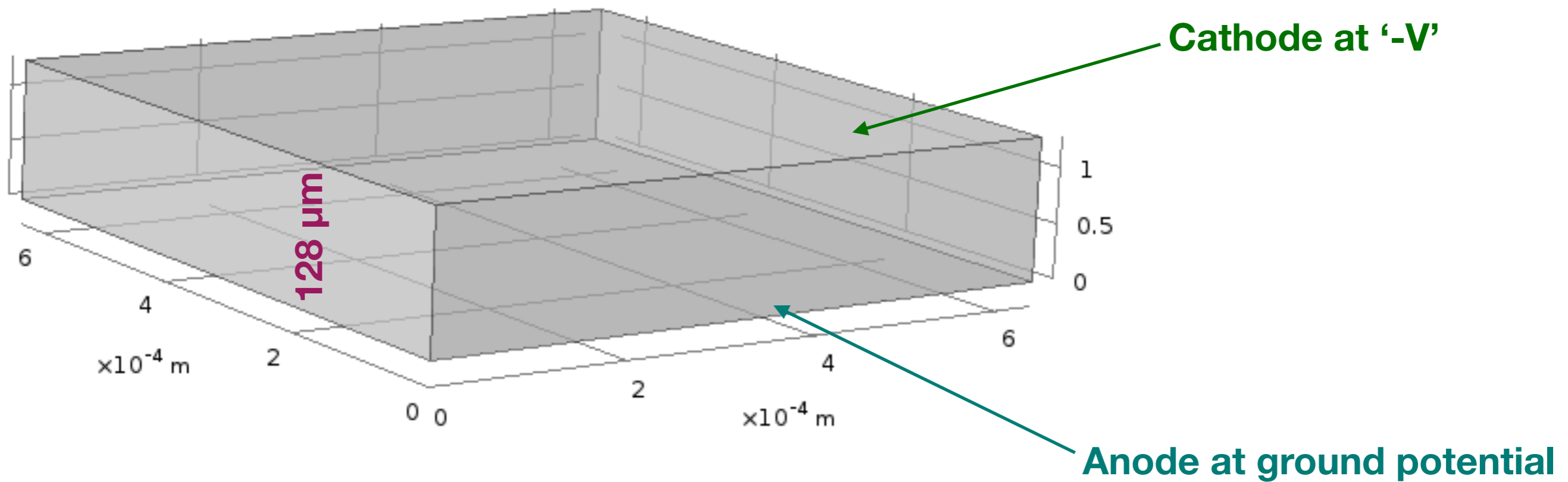
'i' is for electron and ion species
D_i = diffusion tensor in
C_i = number density.
u = electron drift velocity
R_i = production rate.

the transport parameters
depend of the electric field.
hence, to take into account
the space charge effect, the coupling
is important.

α is Townsend coefficient
AC is attachment coefficient
X is for recombination

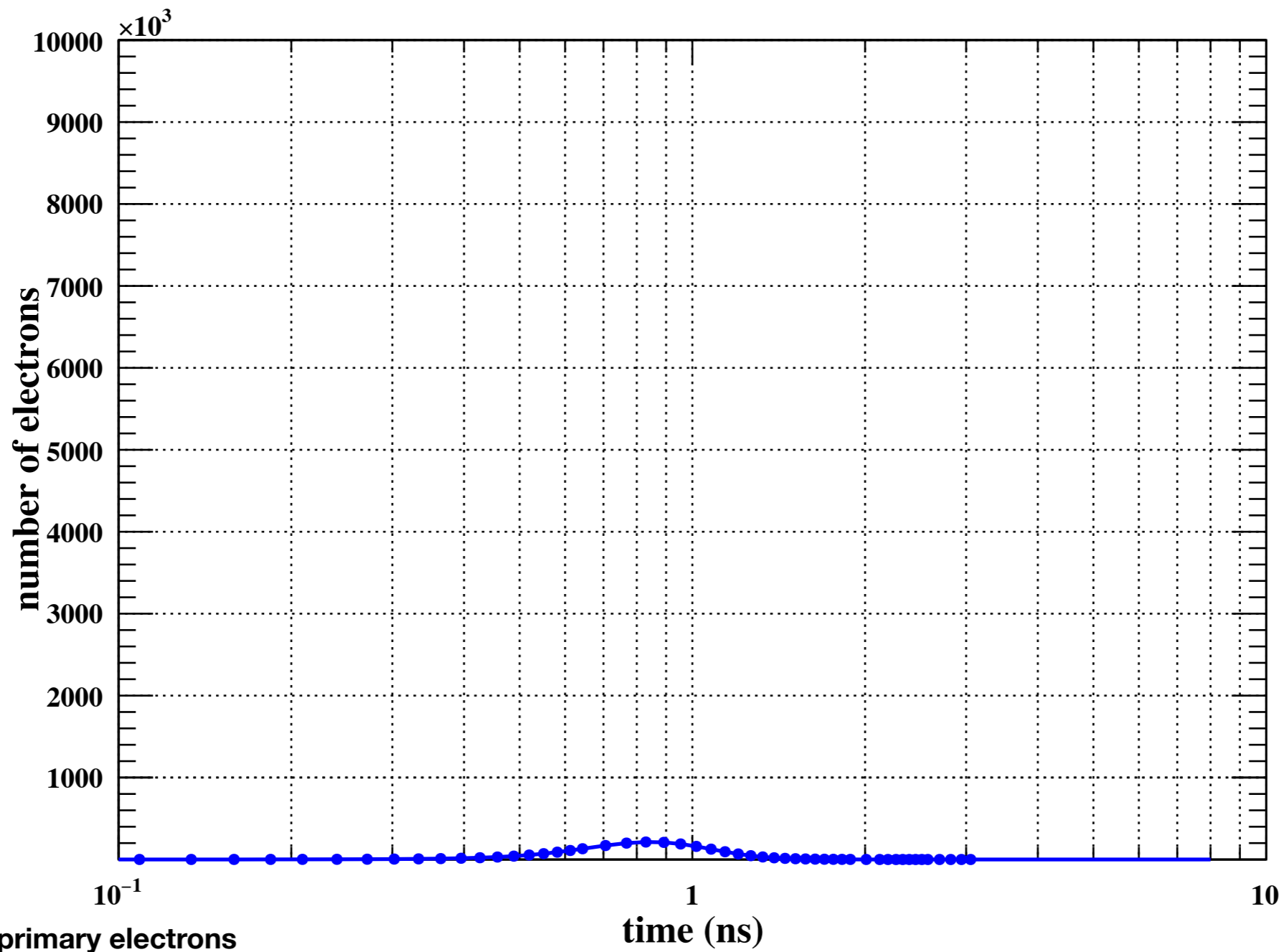
A full physical model can be found : RD51-Note-2011-005/14-03-2011, by P Fonte
However, the present model (diffusion assisted streamer) was well discussed in RD-51, Dec 2017

Solving it for parallel plates



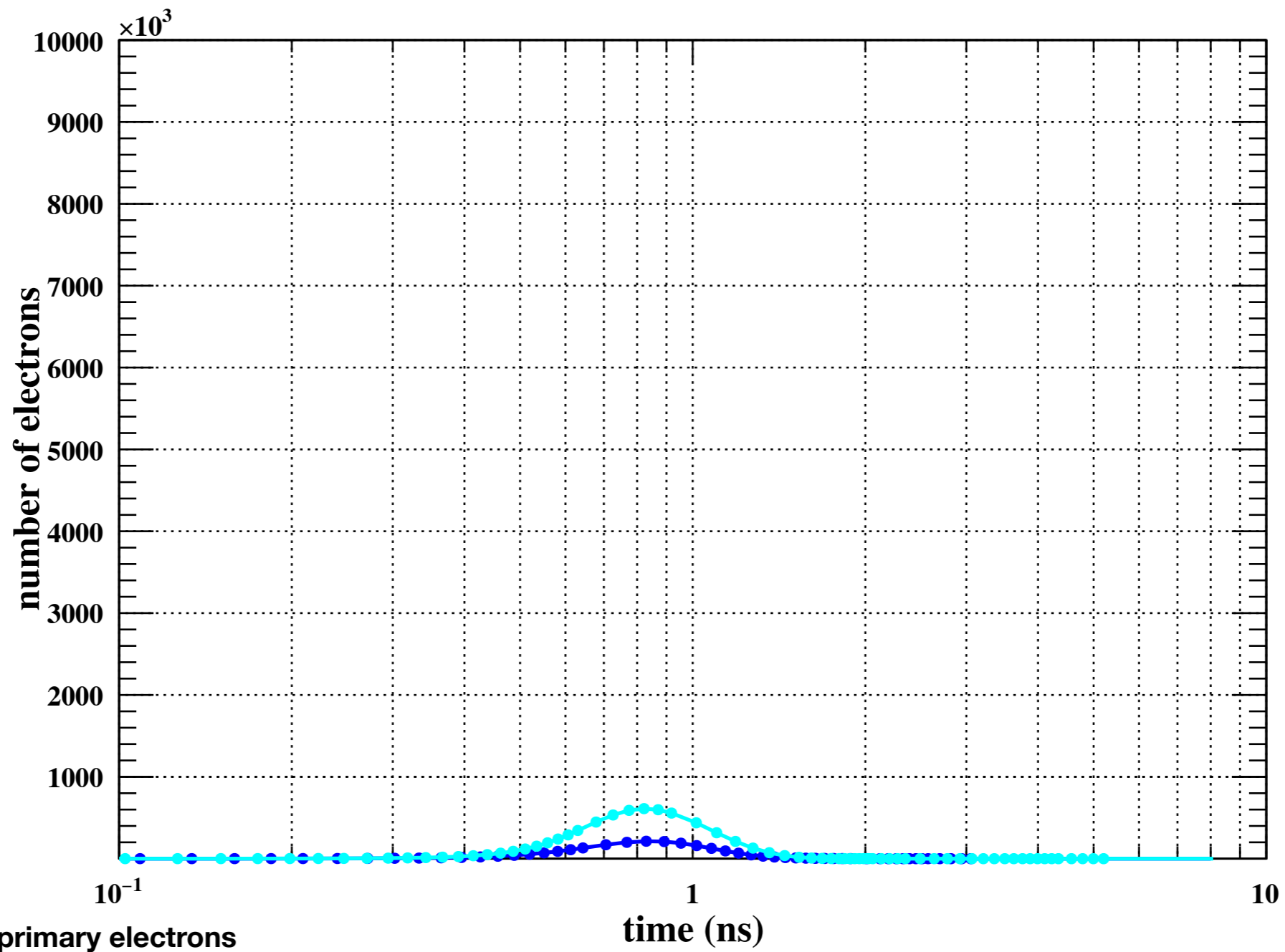
Gas Ar:CO₂=70:30, penning 50

at -700 V



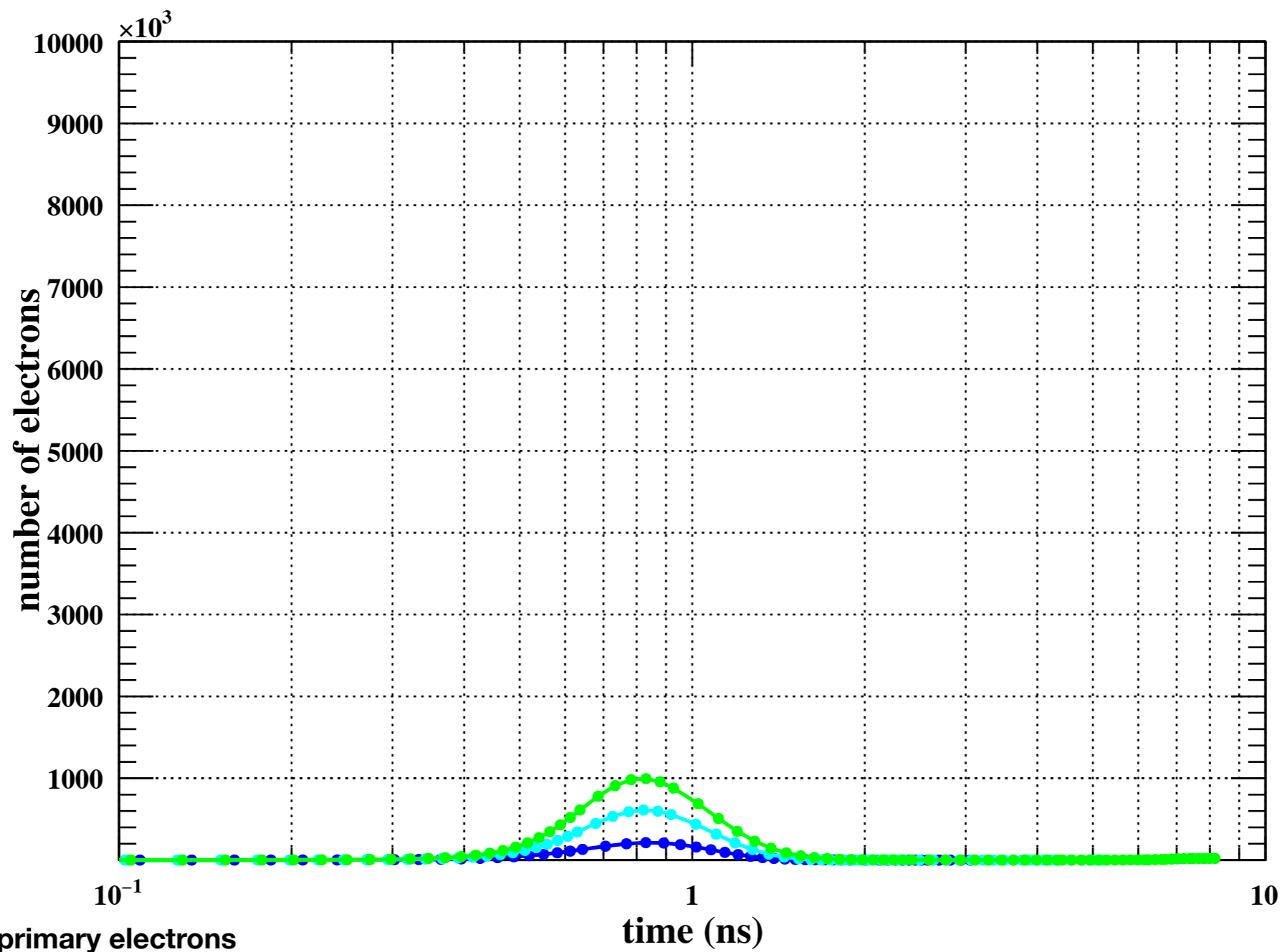
starts with 100 primary electrons

at -740 V



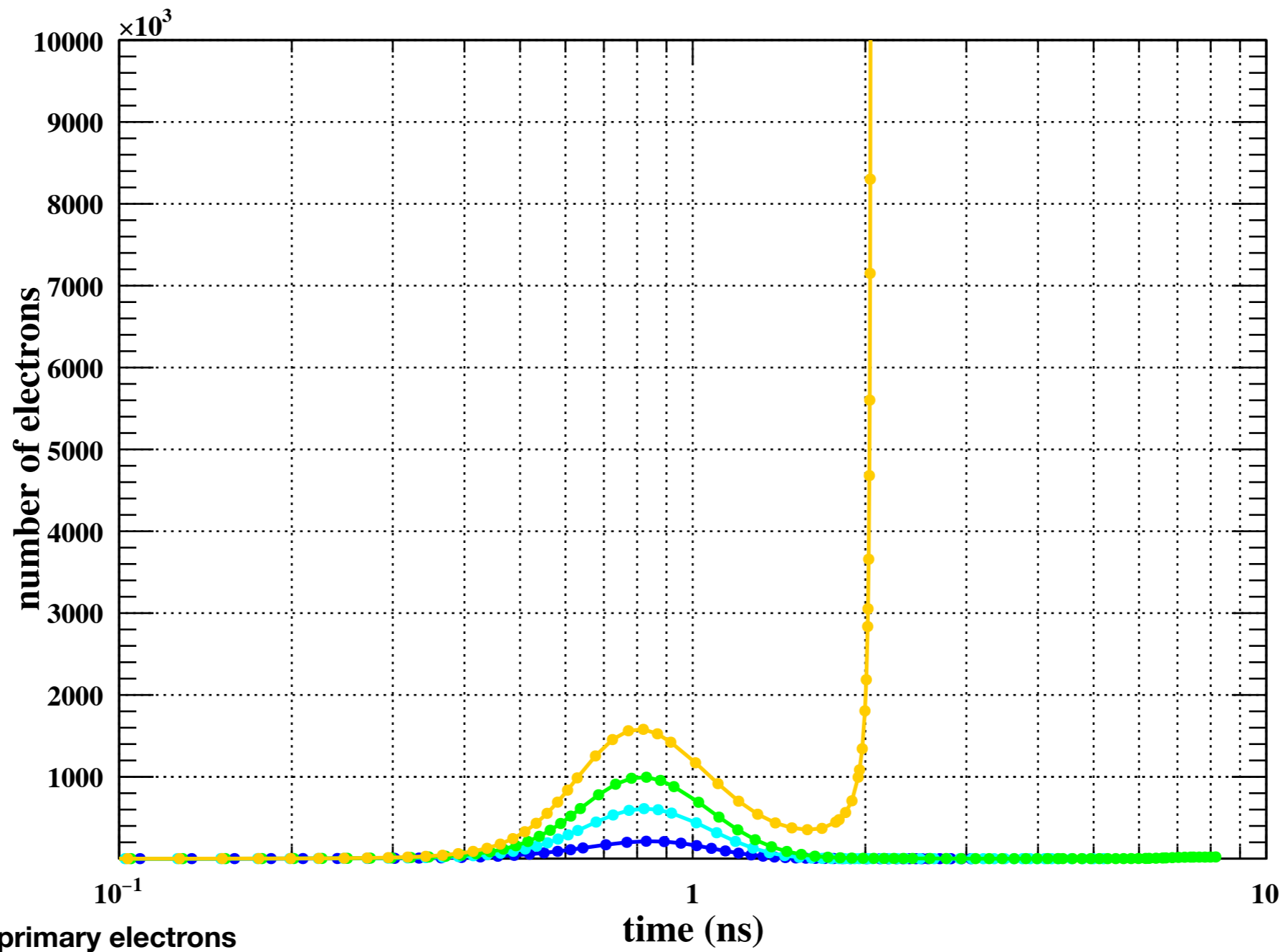
starts with 100 primary electrons

at -760 V



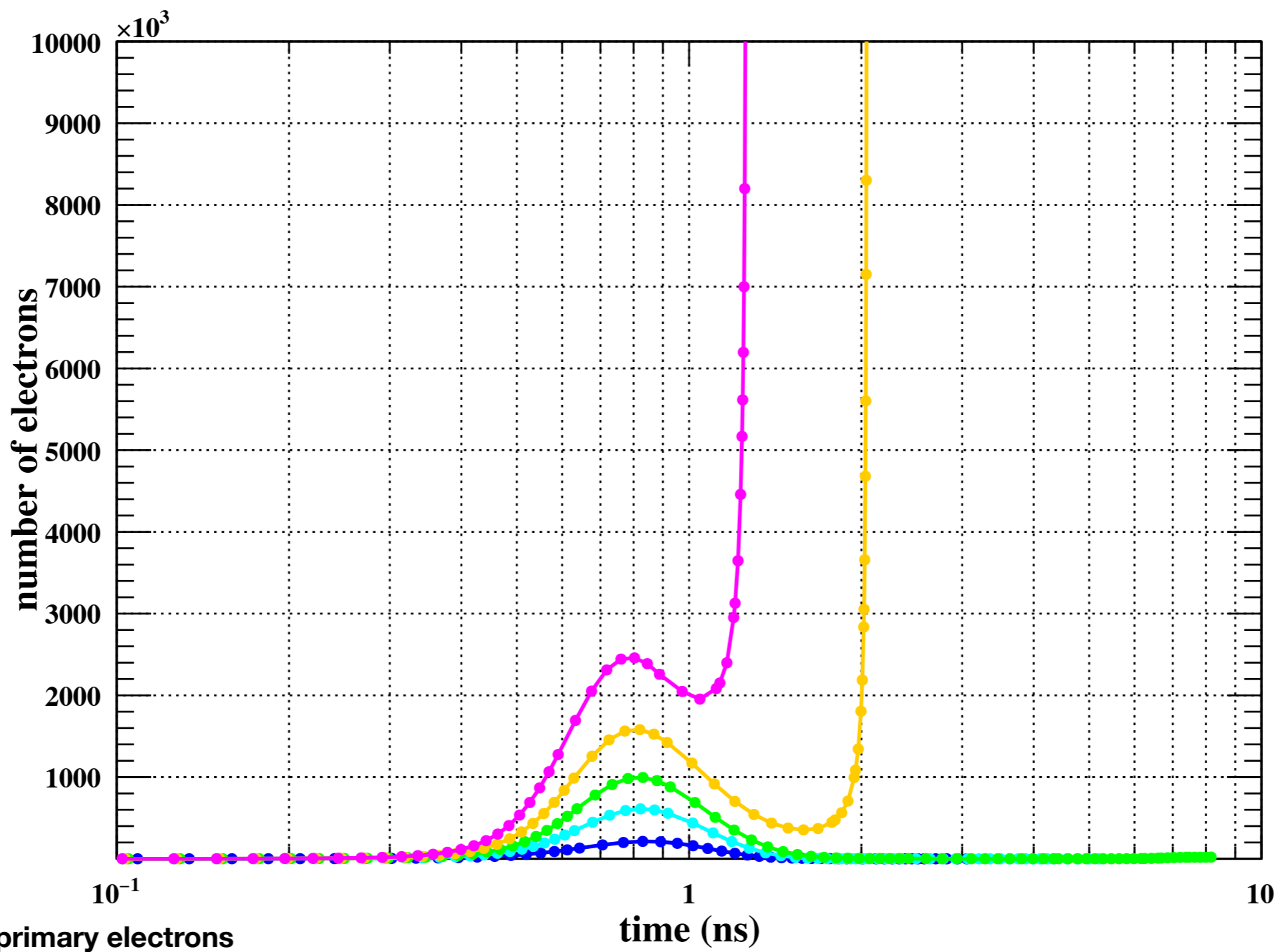
starts with 100 primary electrons

at -780 V



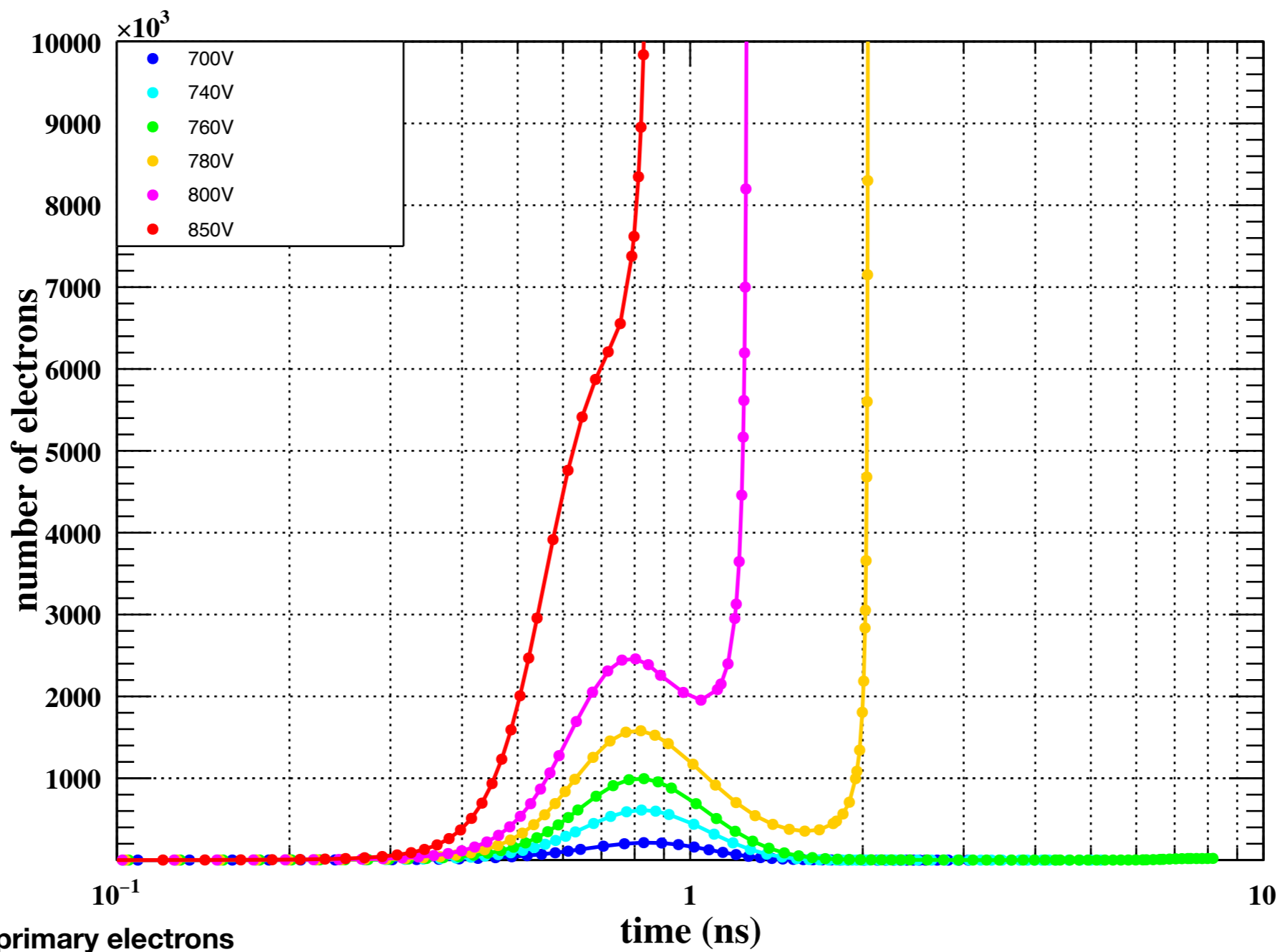
starts with 100 primary electrons

at -800 V



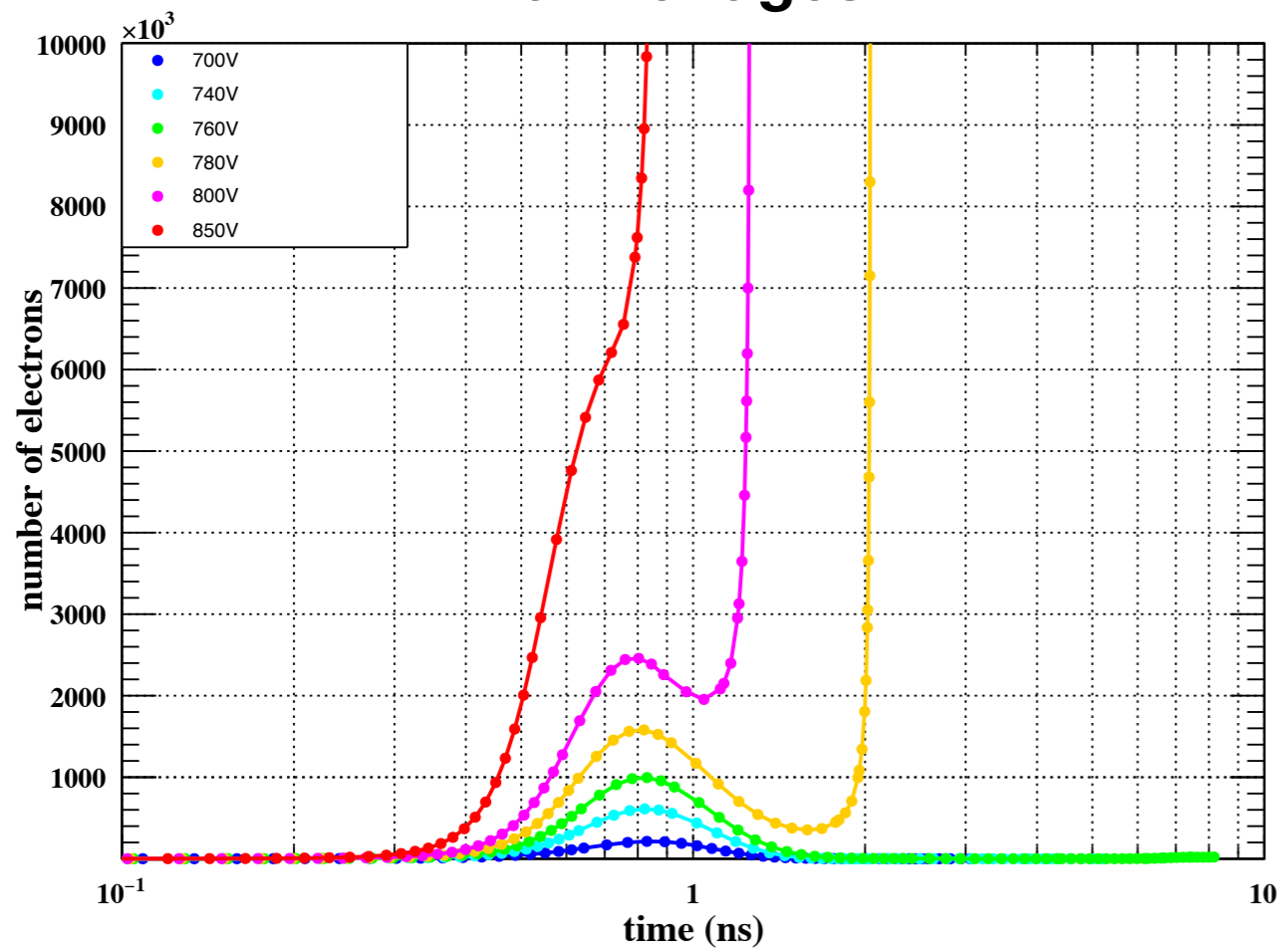
starts with 100 primary electrons

at -850 V



this we know

all voltages



starts with 100 primary electrons

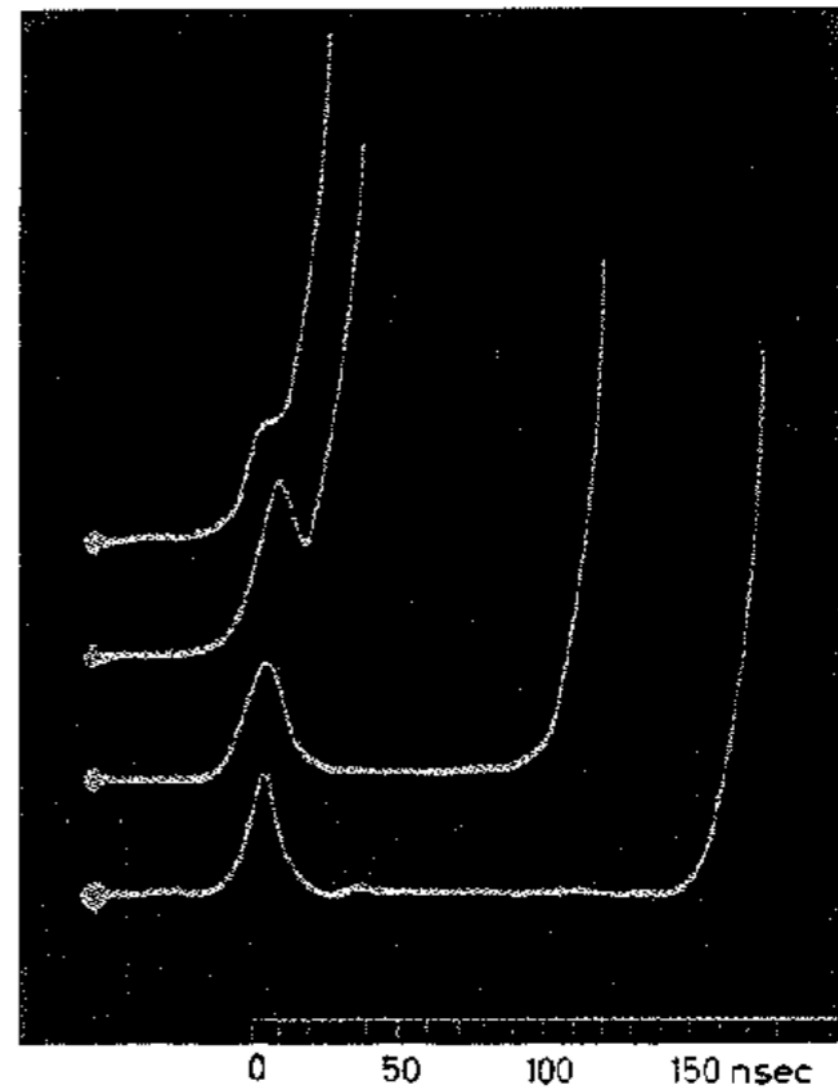
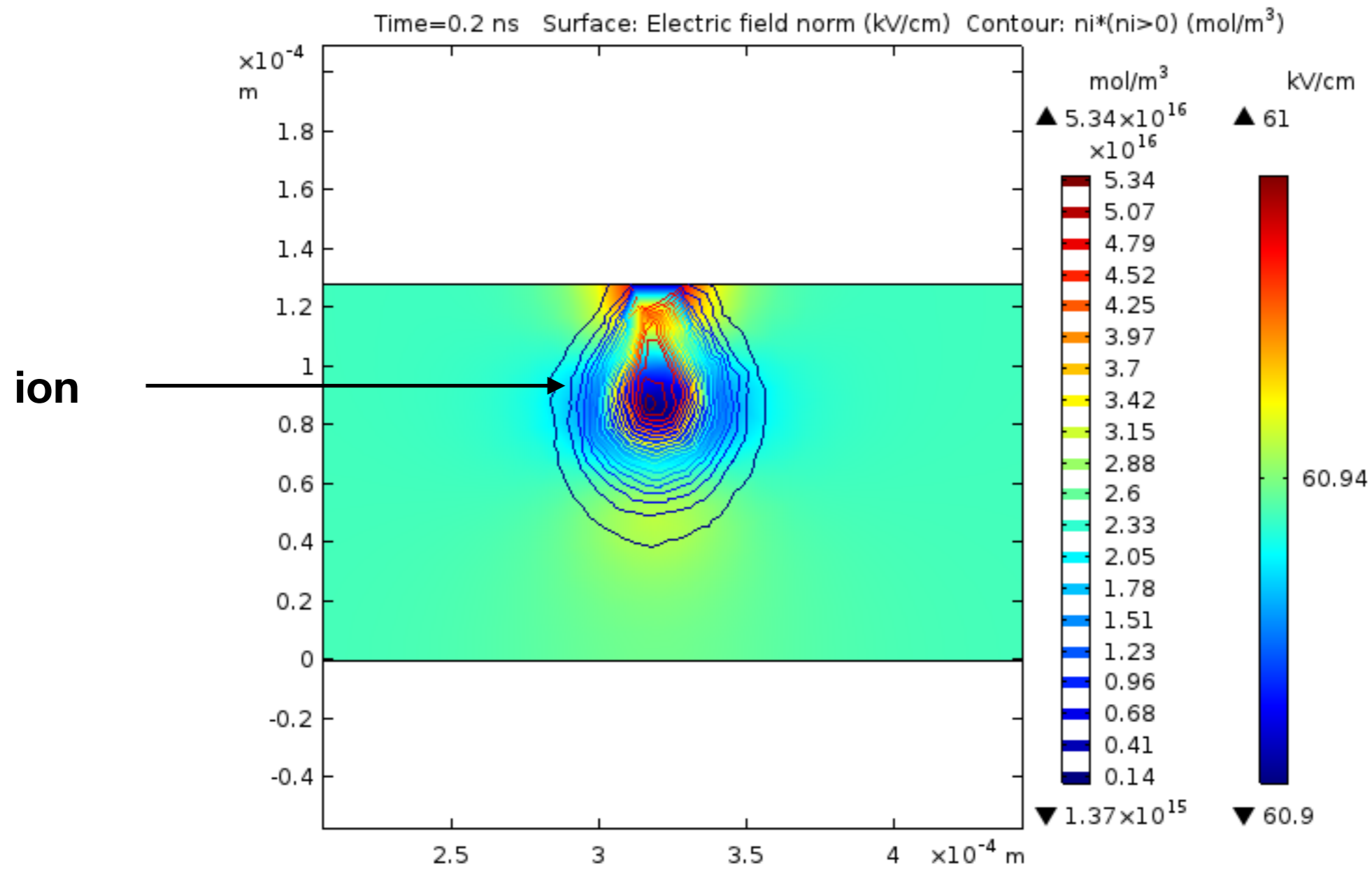
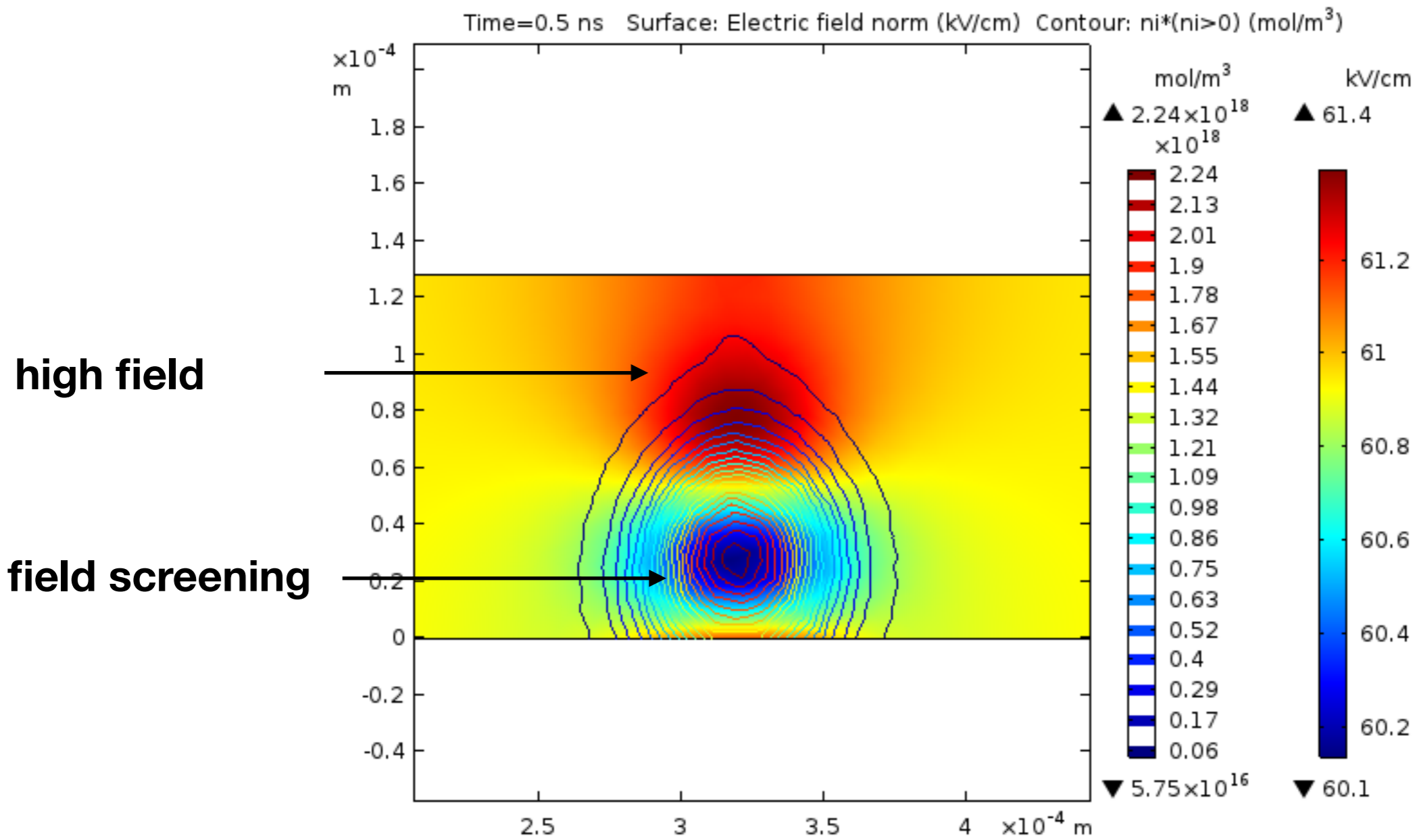


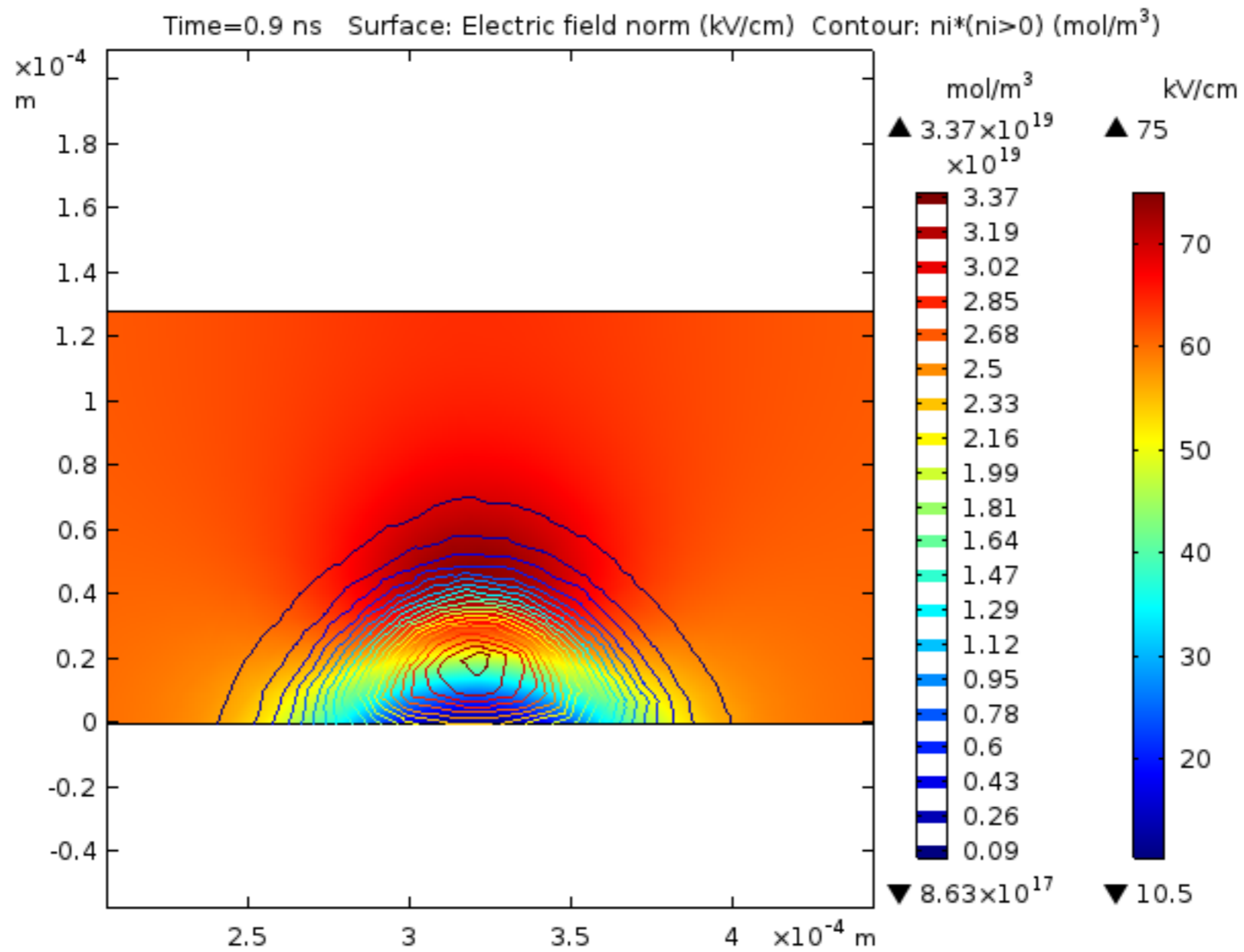
Figure 5.14. Current oscillograms of static breakdown in methylal. Optical method. $E/p = 64.4$, $pd = 230$ Torr cm, $d = 0.8$ cm, $T_{\dots} = 90$ nsec $RC = 5$ nsec^{3*}



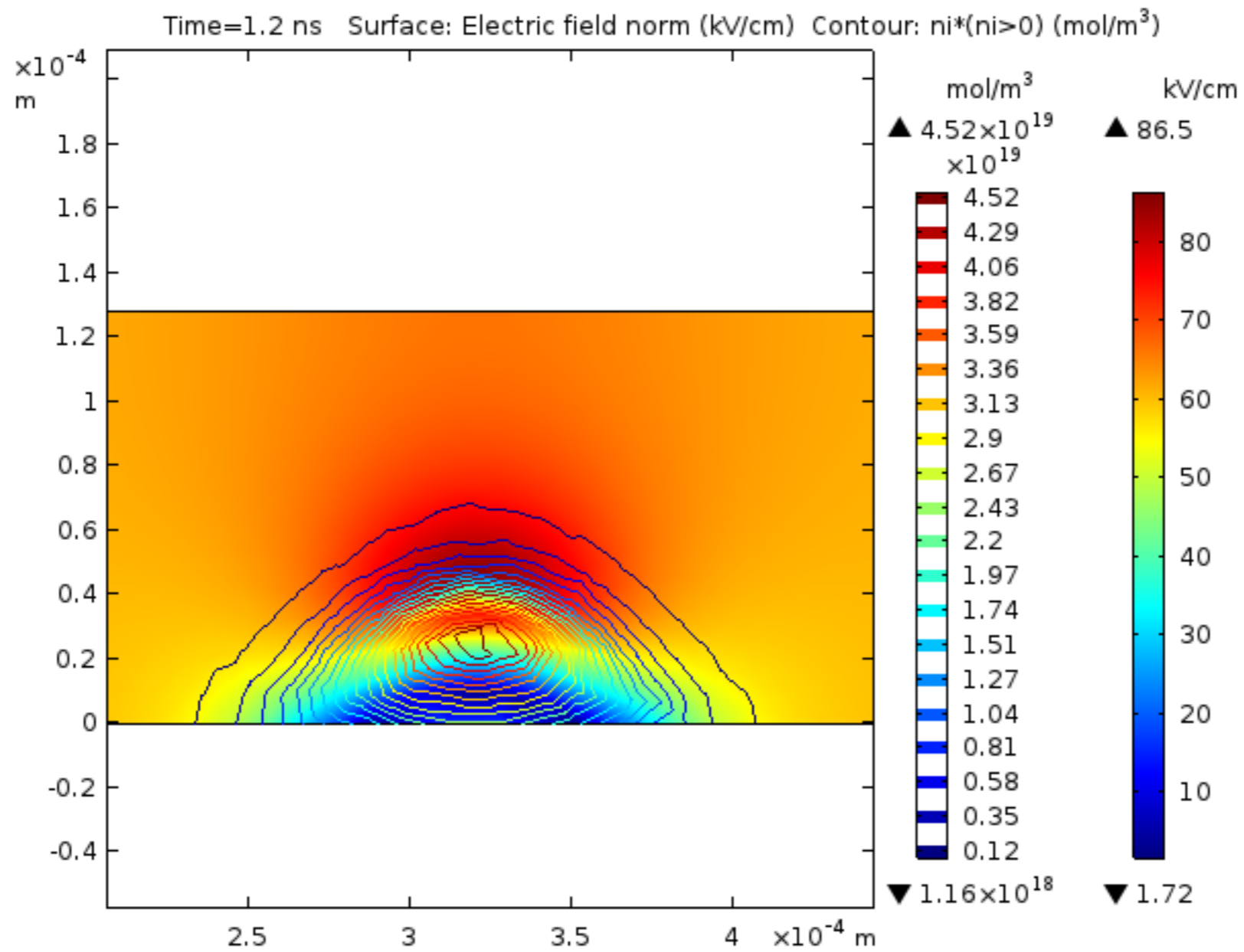
**How the space charge is changing the field;
applied voltage -780V (~61 kV/cm)**



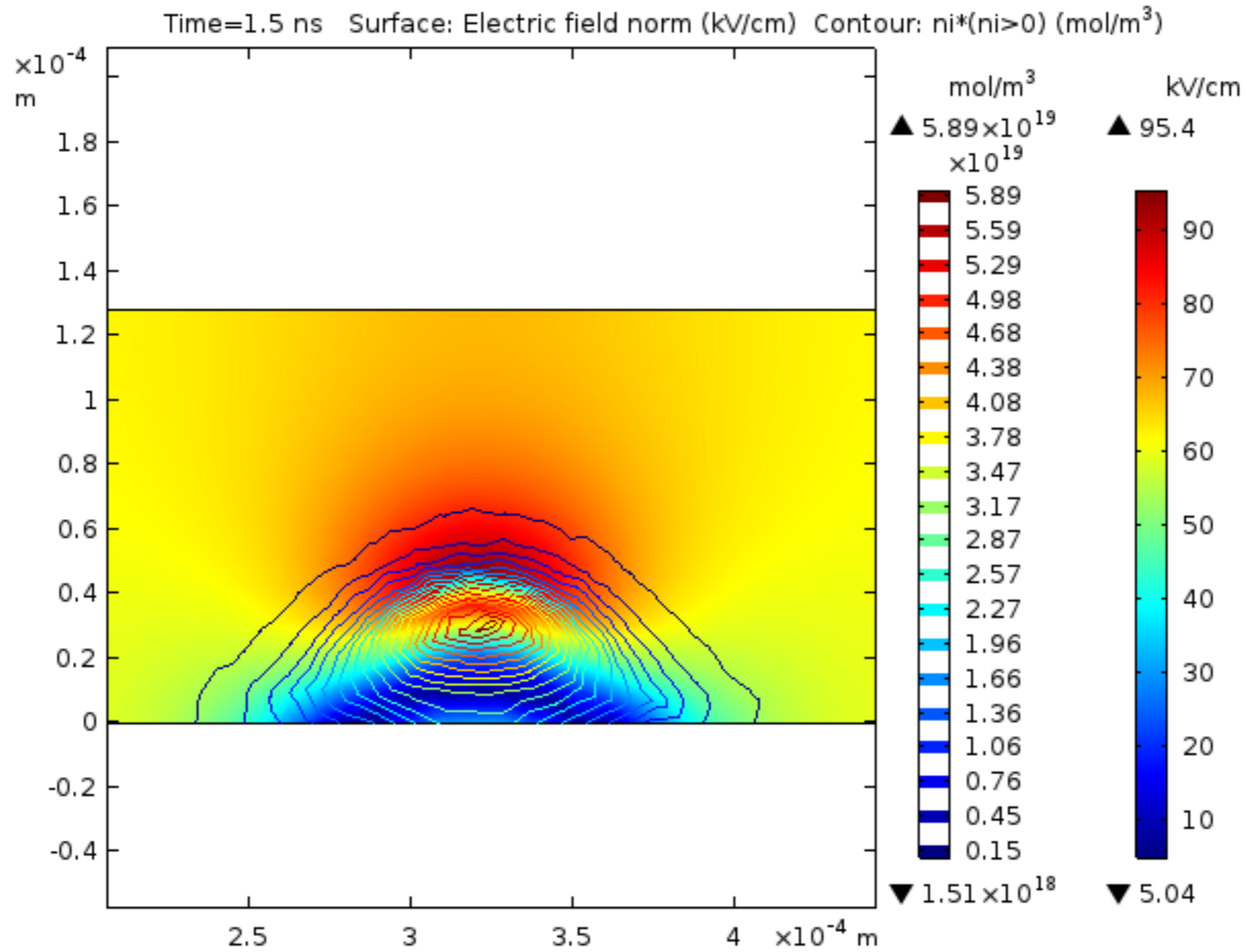
**How the space charge is changing the field;
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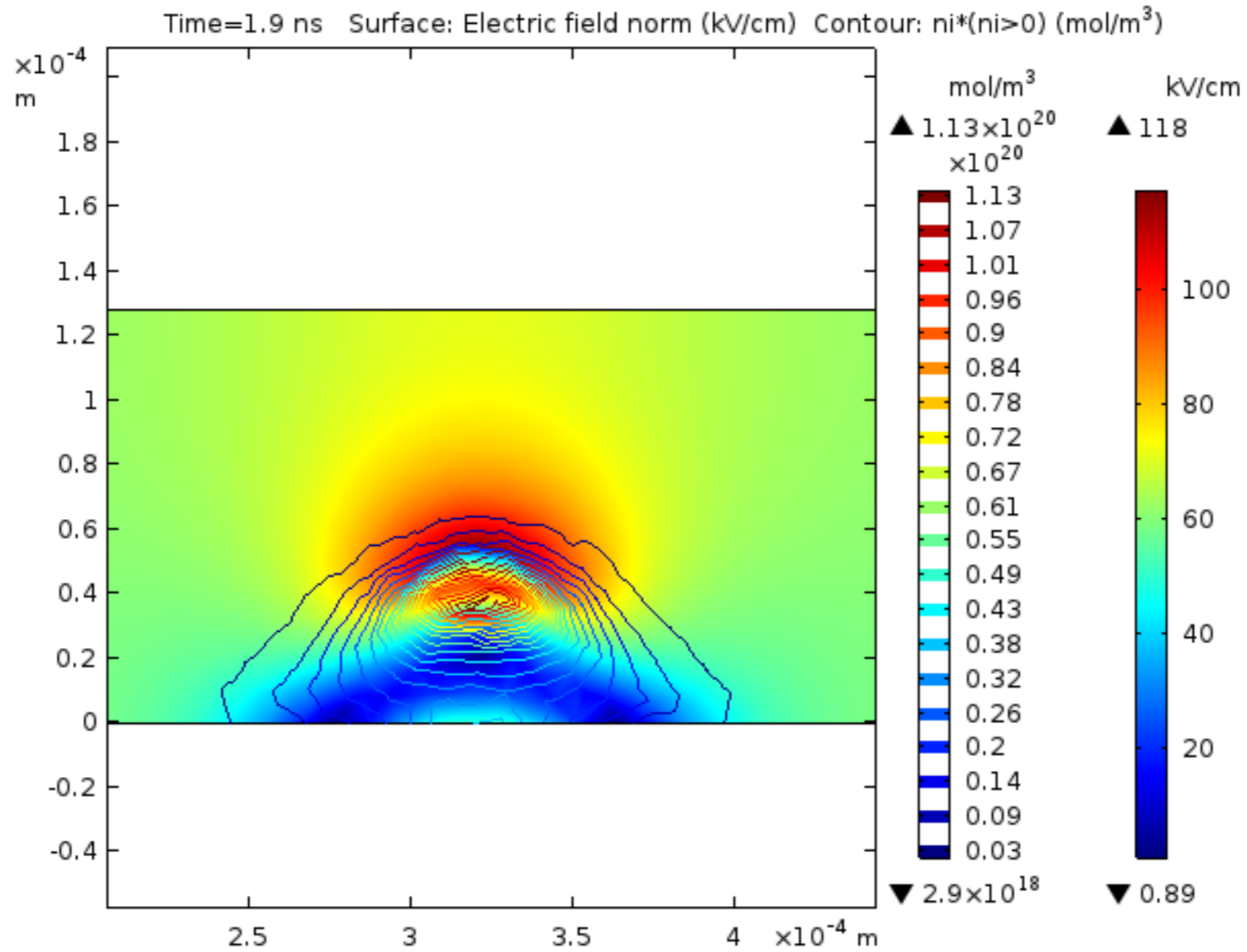
**How the space charge is changing the field;
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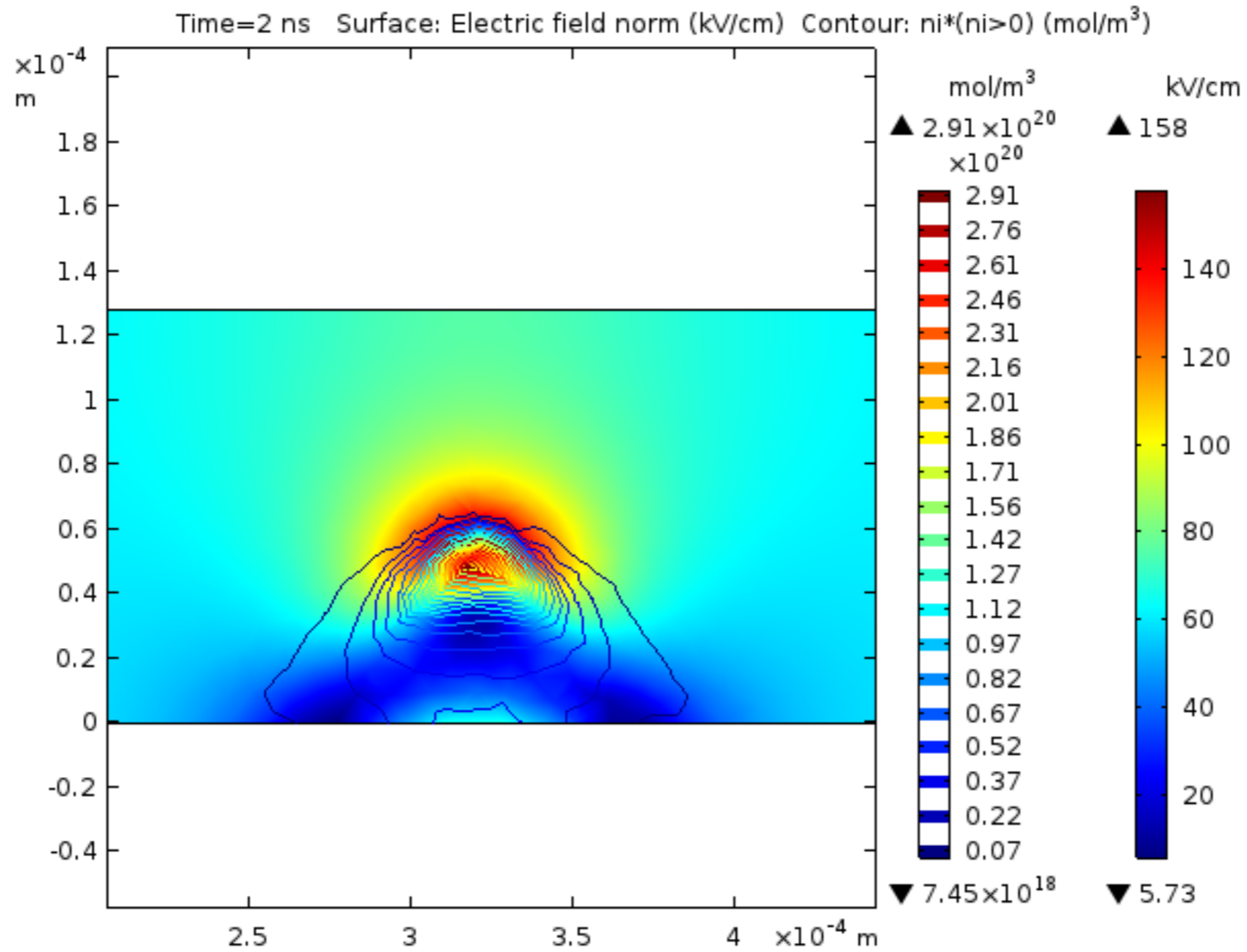
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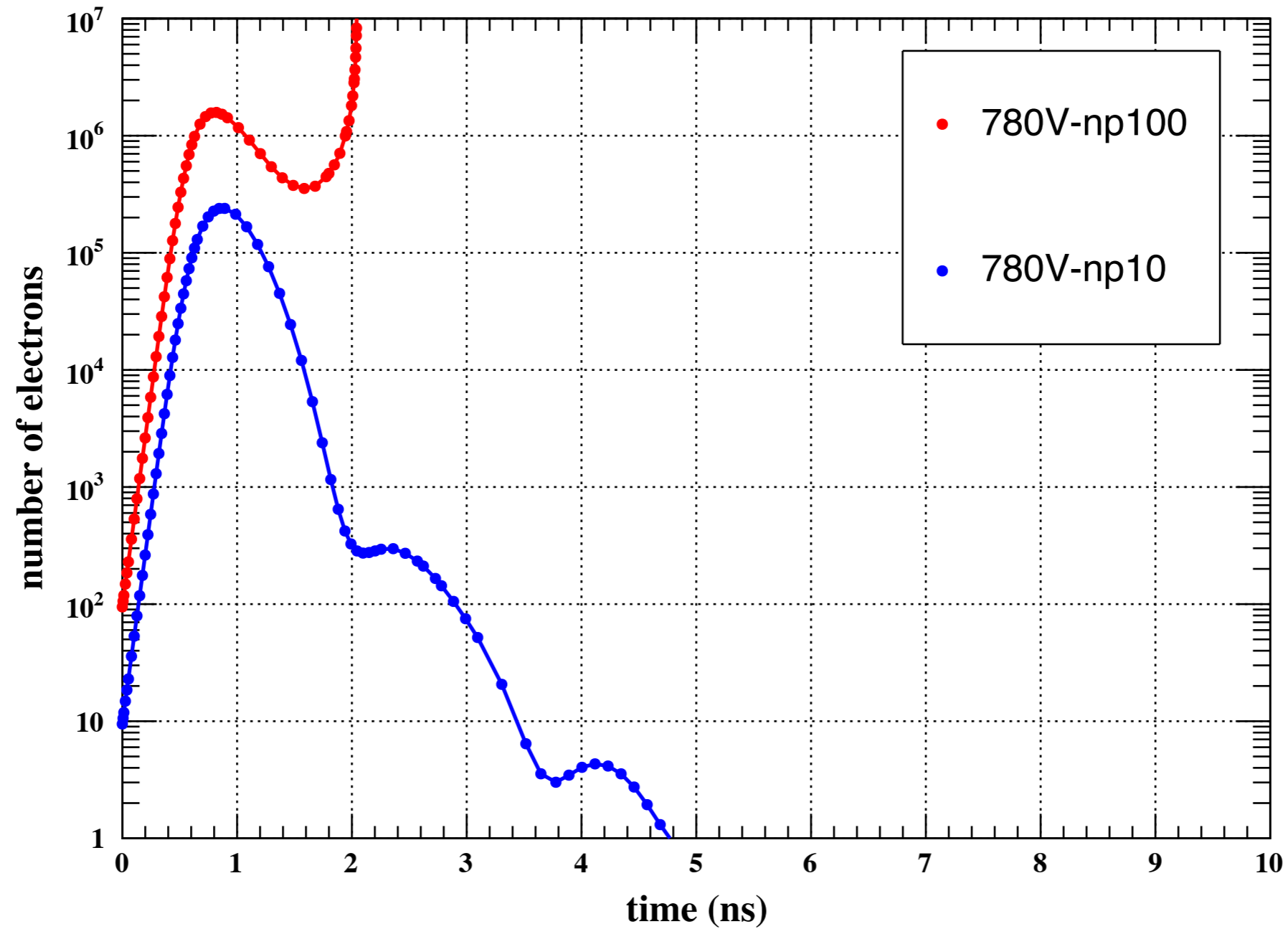


**How the space charge is changing the field;
applied voltage -780V (~61 kV/cm)**



**How the space charge is changing the field;
applied voltage -780V (~61 kV/cm)**

With different primaries



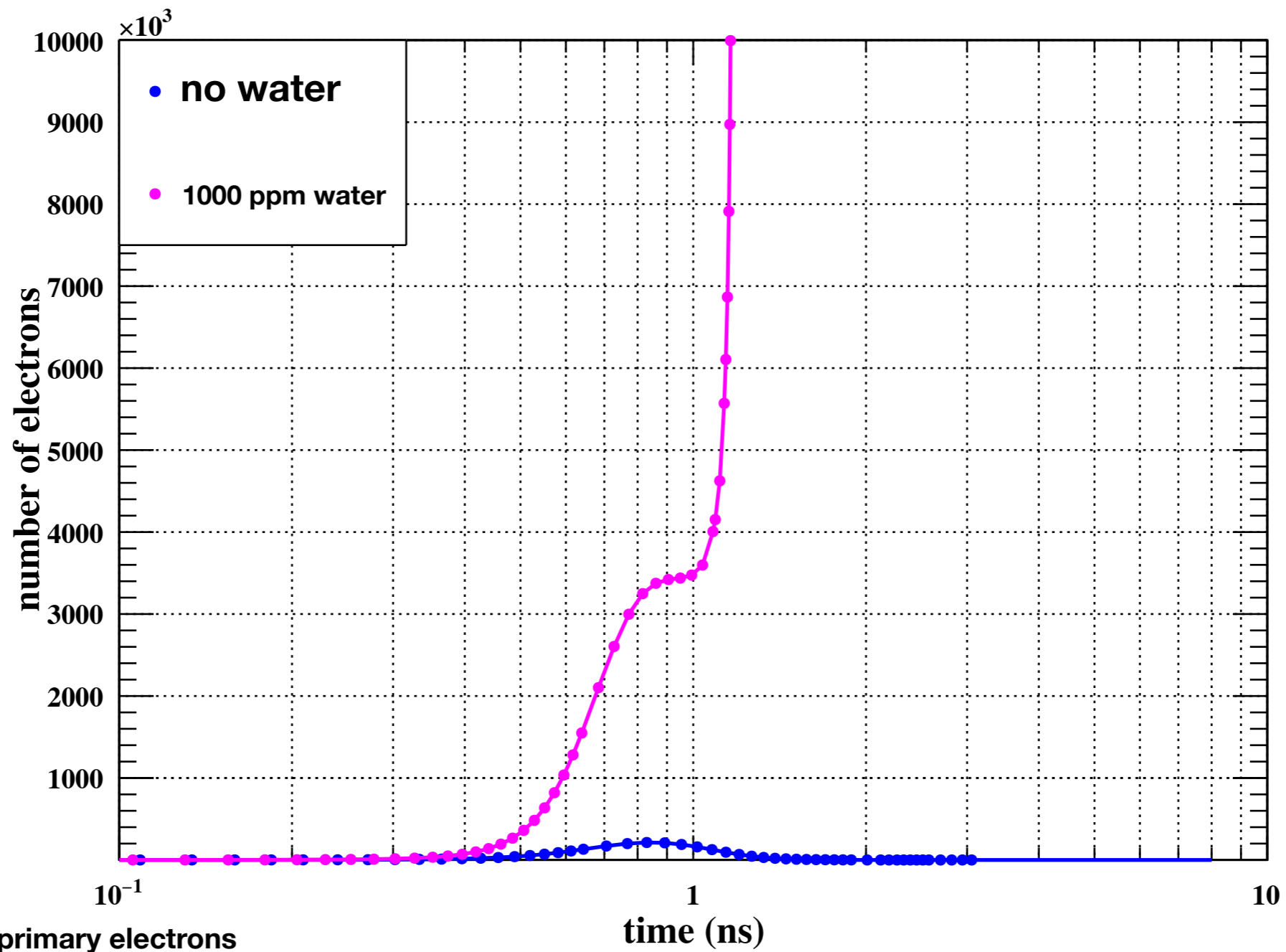
gain=16K

gain=25K

for field screening

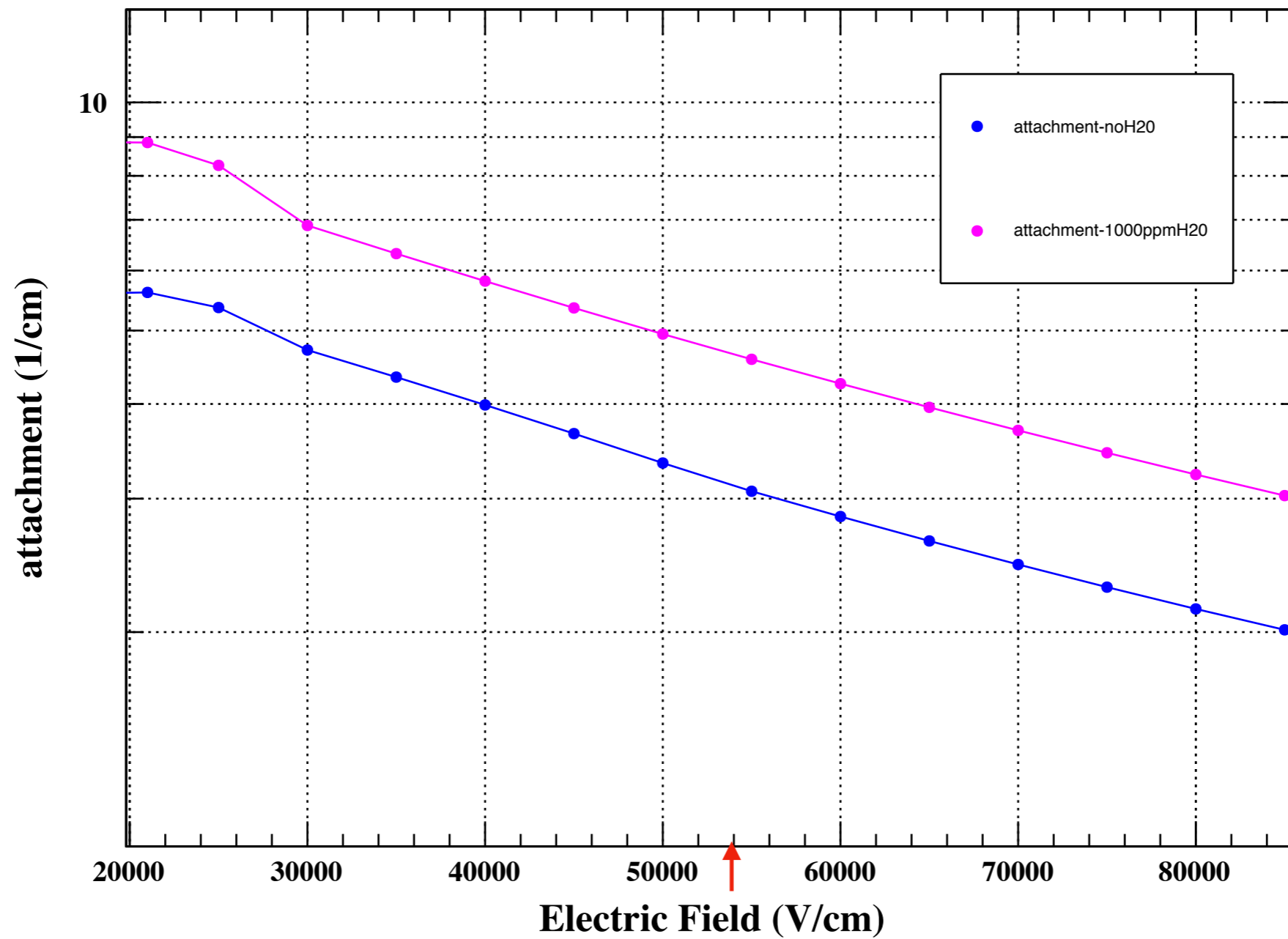
at 700 V

The effect of adding 1000 ppm of water (which is 4 % r.h.)

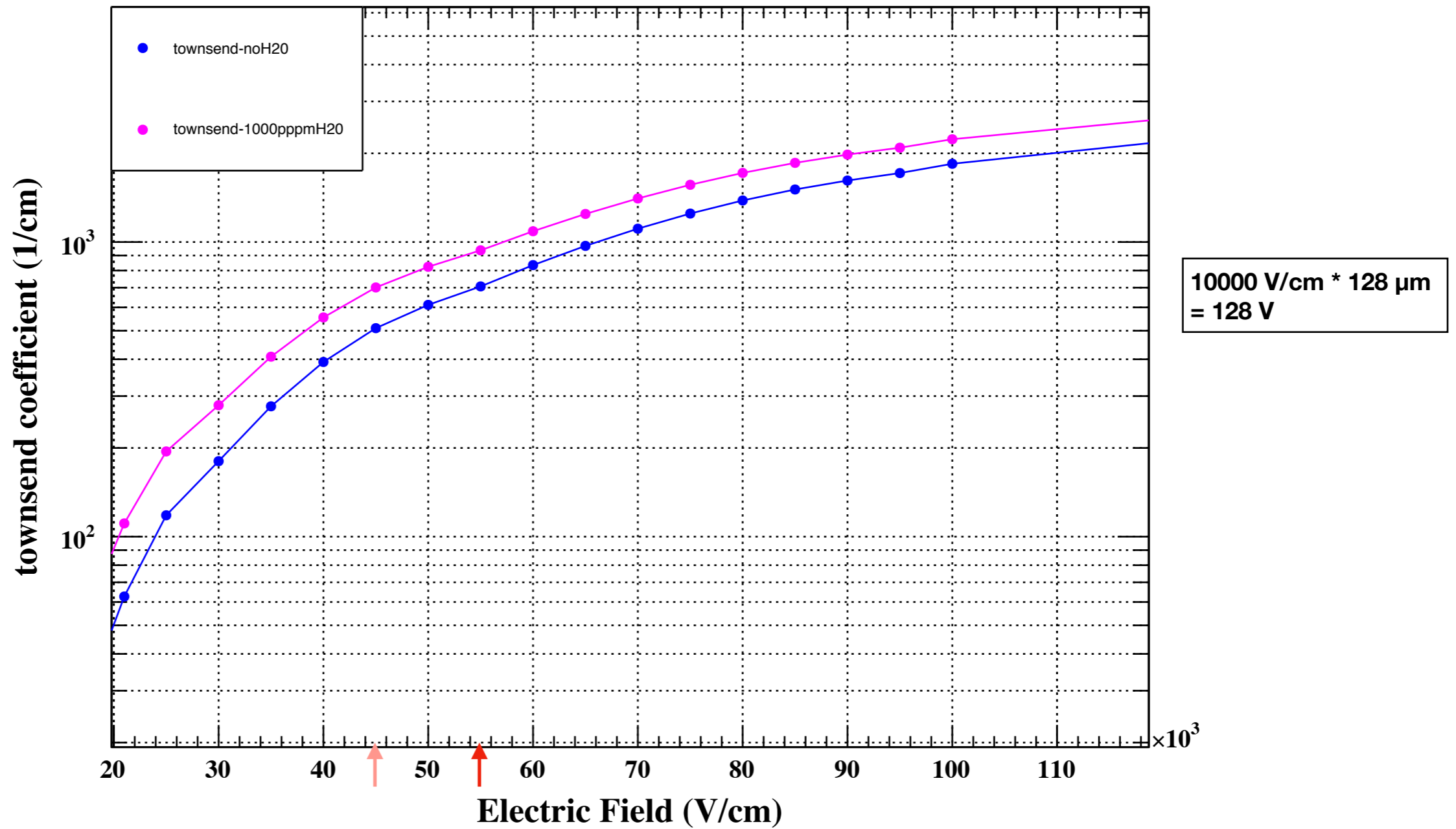


starts with 100 primary electrons

Ar:CO2=70:30

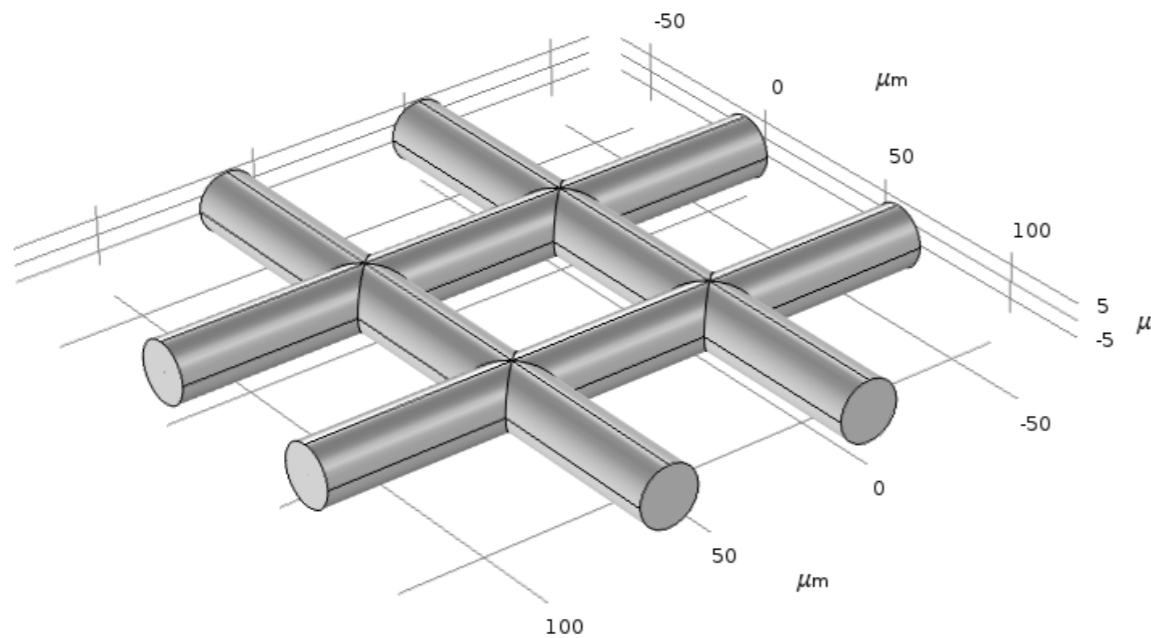


Ar:CO2=70:30



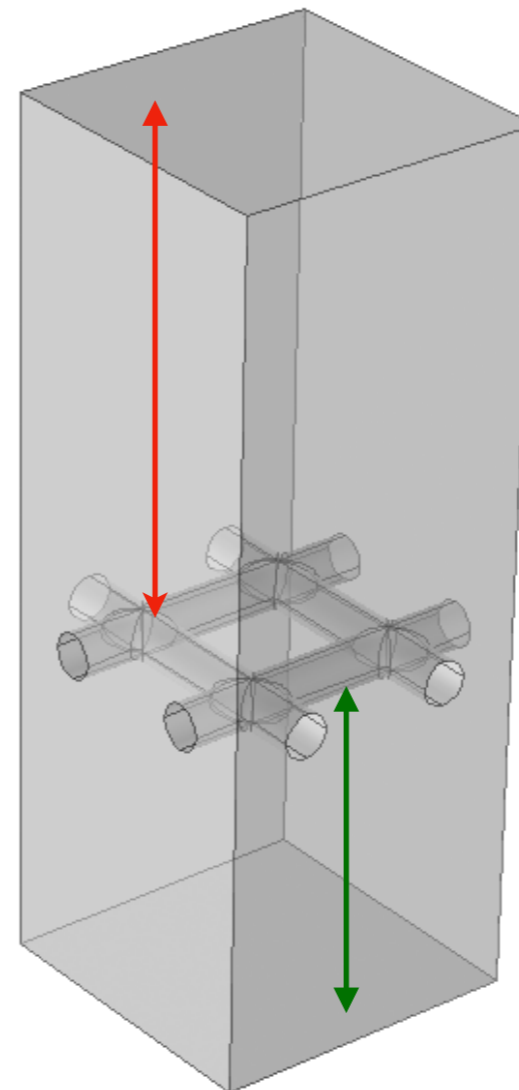
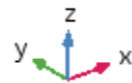
Solving this for Micromegas

18/45 Calendared-like :



The wires are taken as inter-penetrating

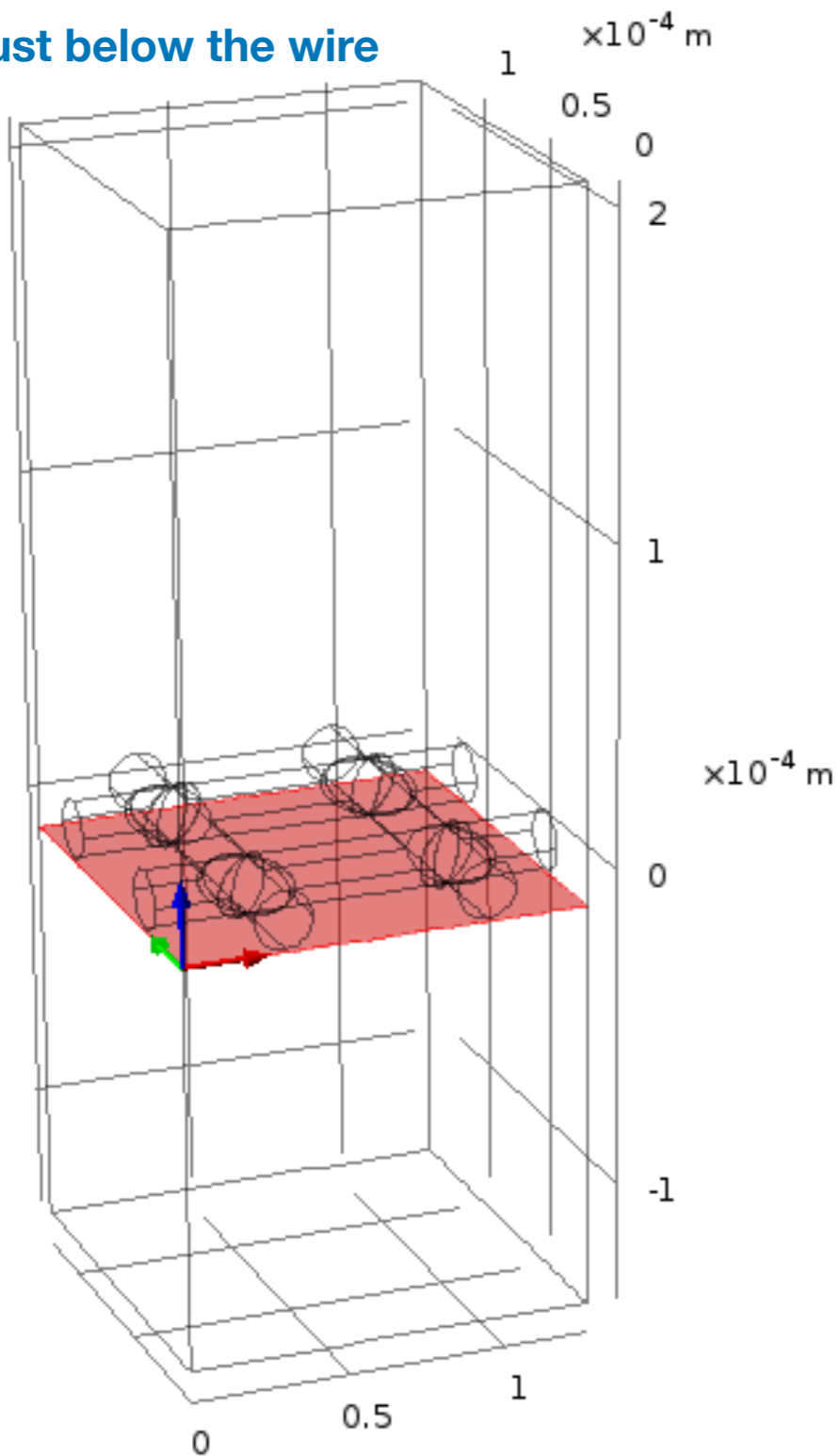
- Wire diameter 18 μm
- Edge to Edge 45 μm
- Axis to Axis 63 μm



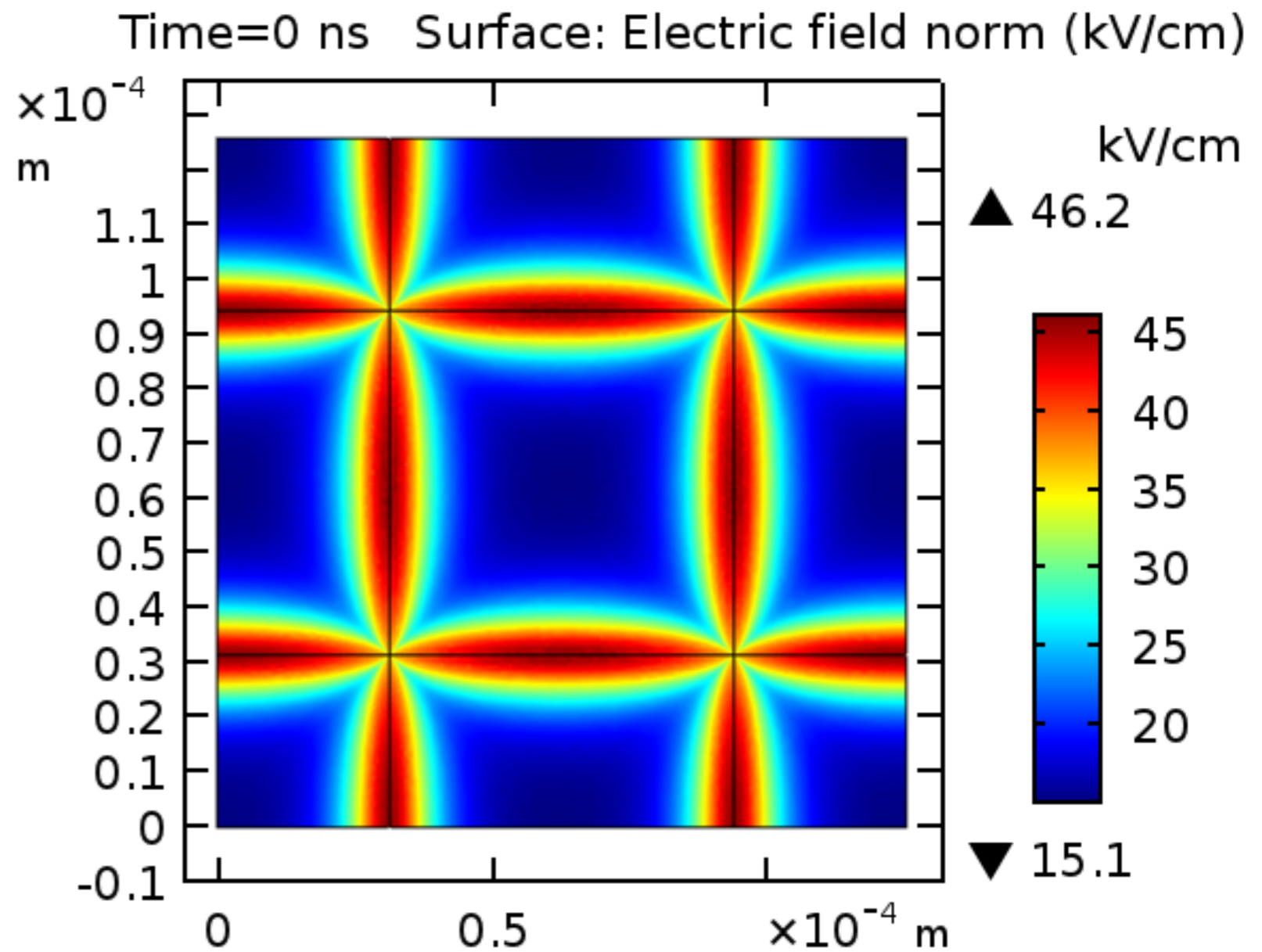
drift gap = 200 μm
amplification gap = 128 μm

mesh voltage = - 330 V
drift voltage = - 350 V

- just below the wire

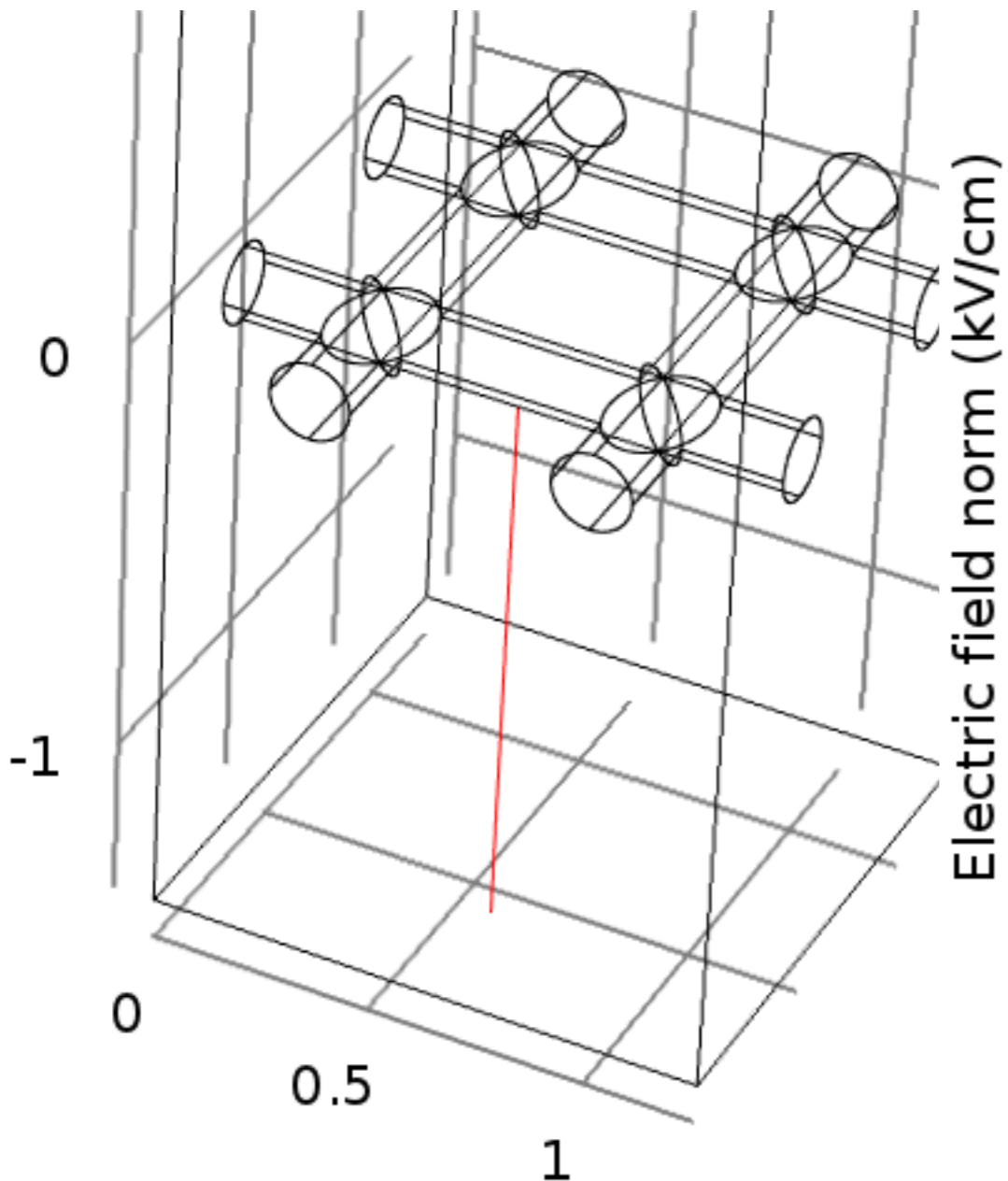


Result : Electric Field



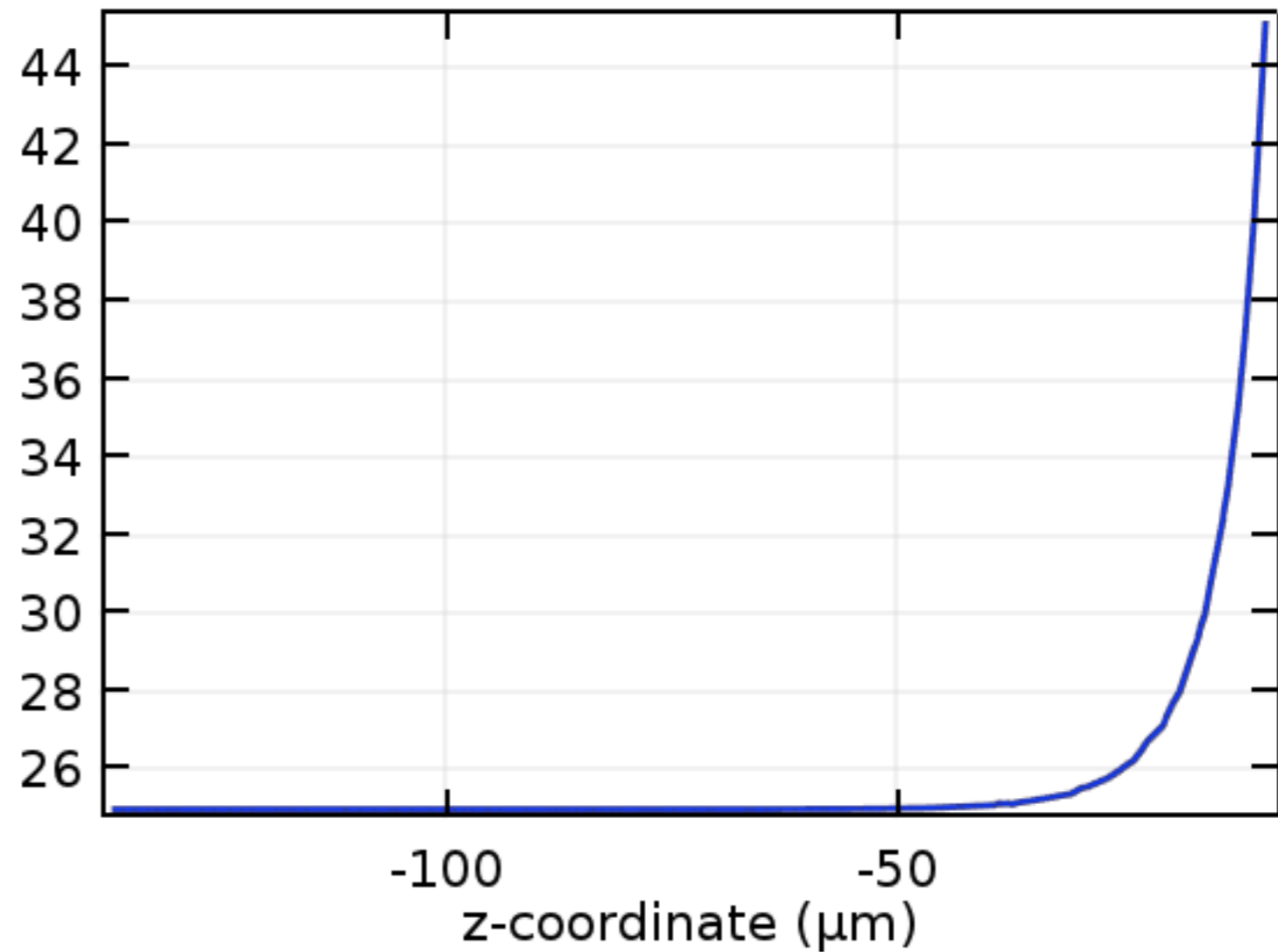
Results: Electric Field

along a perpendicular line just below the wire (18-45)



mesh voltage = -330 V

Line Graph: Electric field norm (kV/cm)



max field = 45.2 kV/cm ; average field = 24.9 kV/cm;

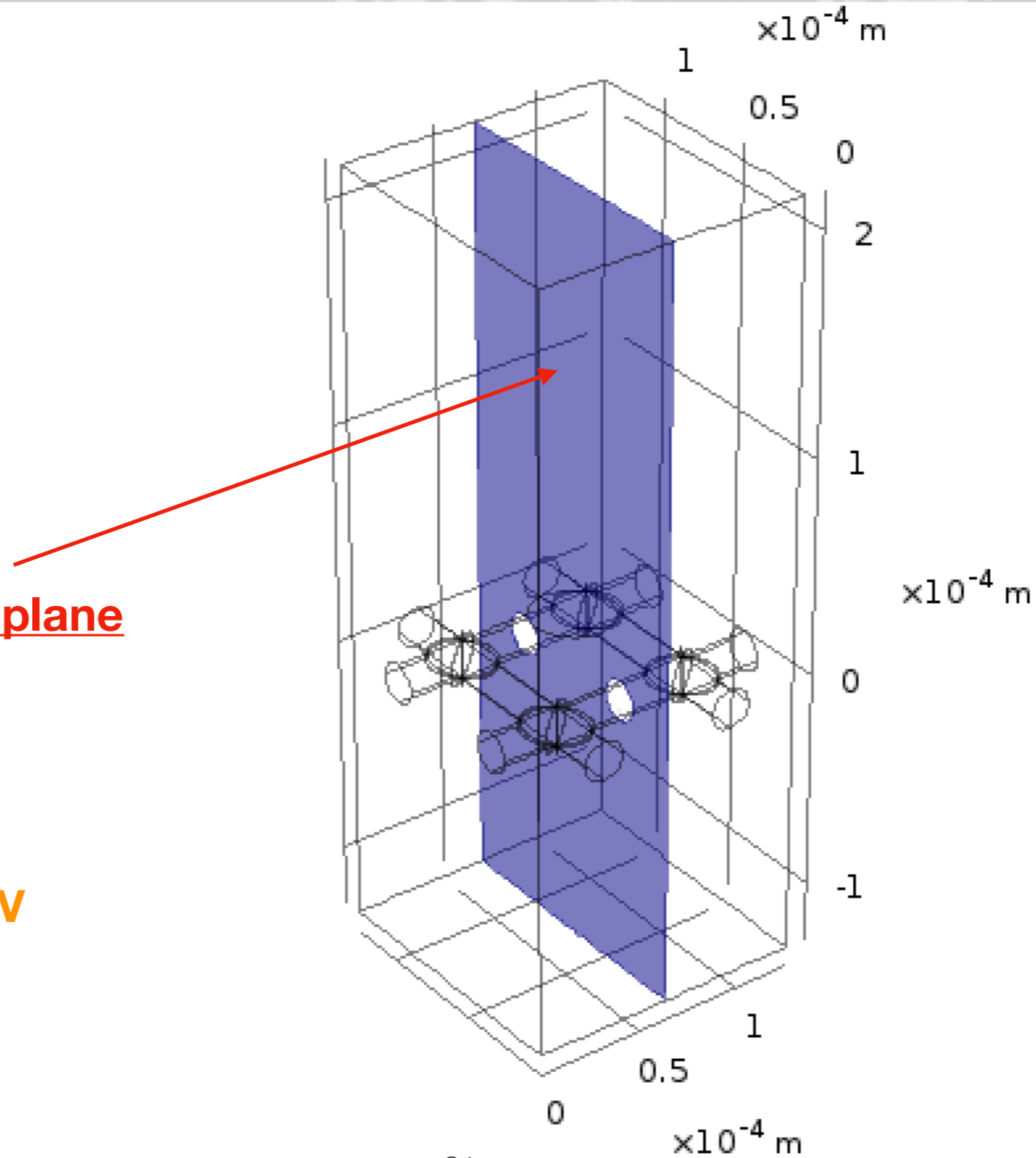


Results:

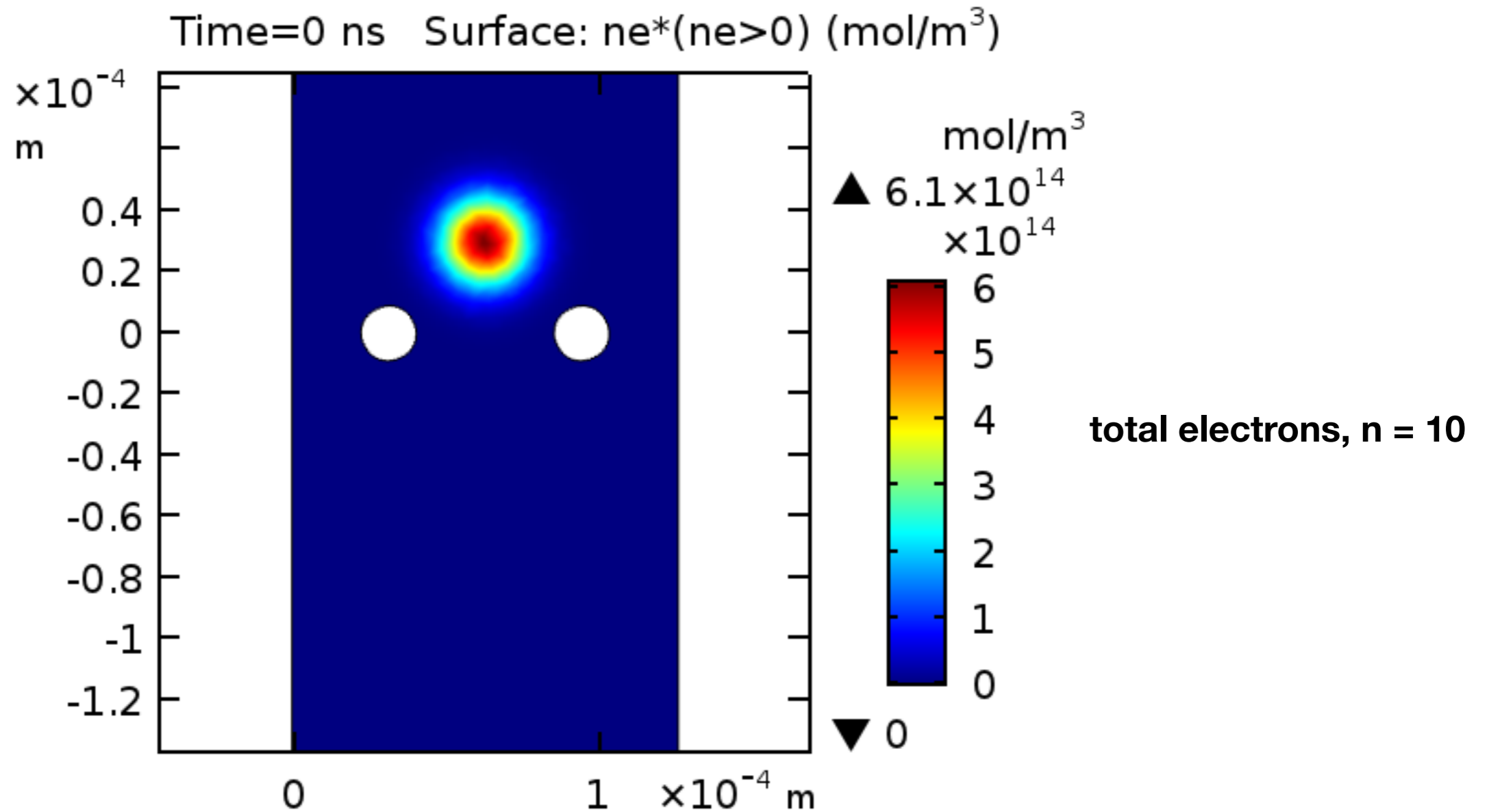
probing the charge
transport on a plane

The probing plane

mesh voltage = - 330 V
drift voltage = - 350 V

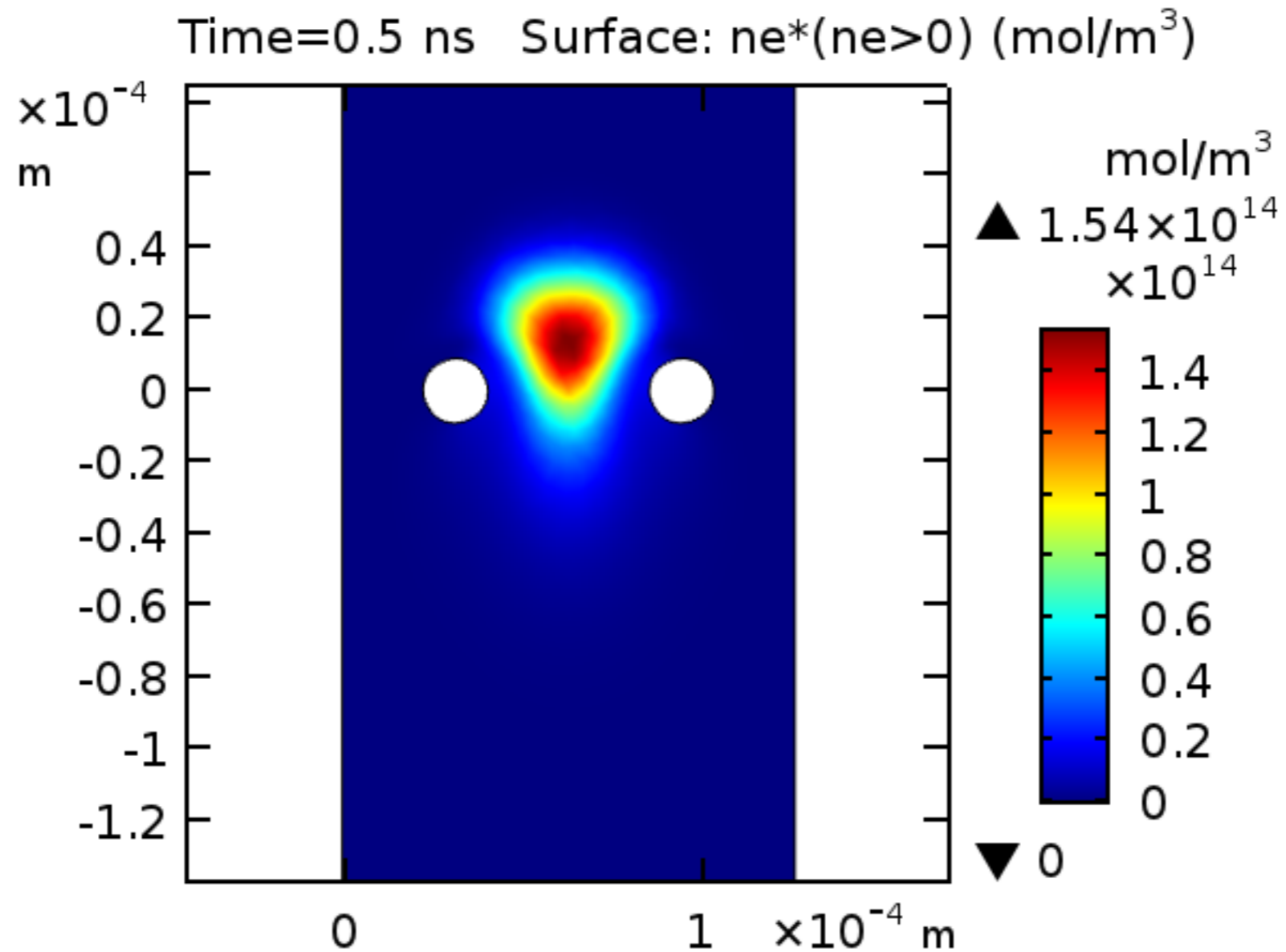


Results:



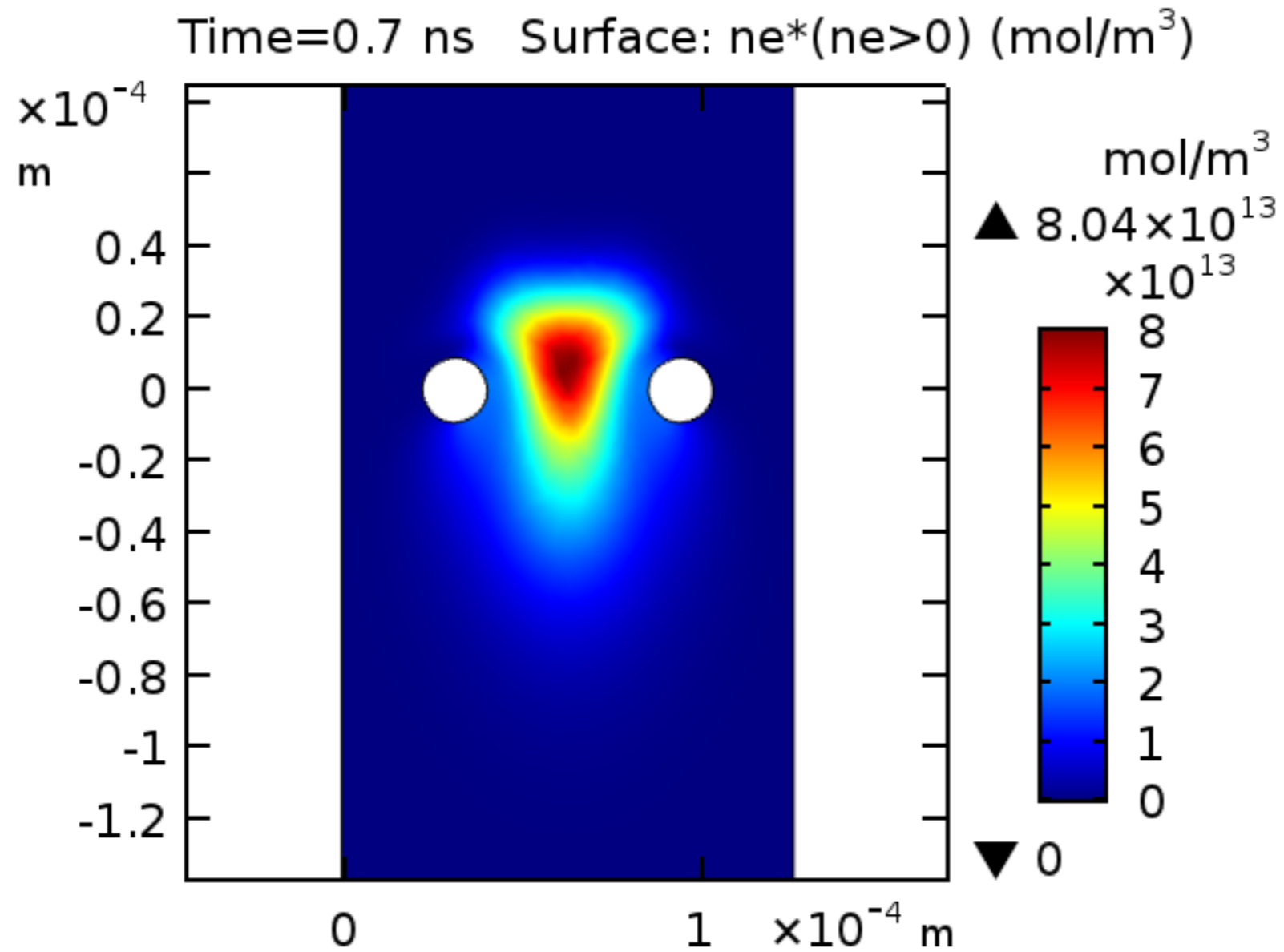
transport of
the electrons
and avalanche

Results:



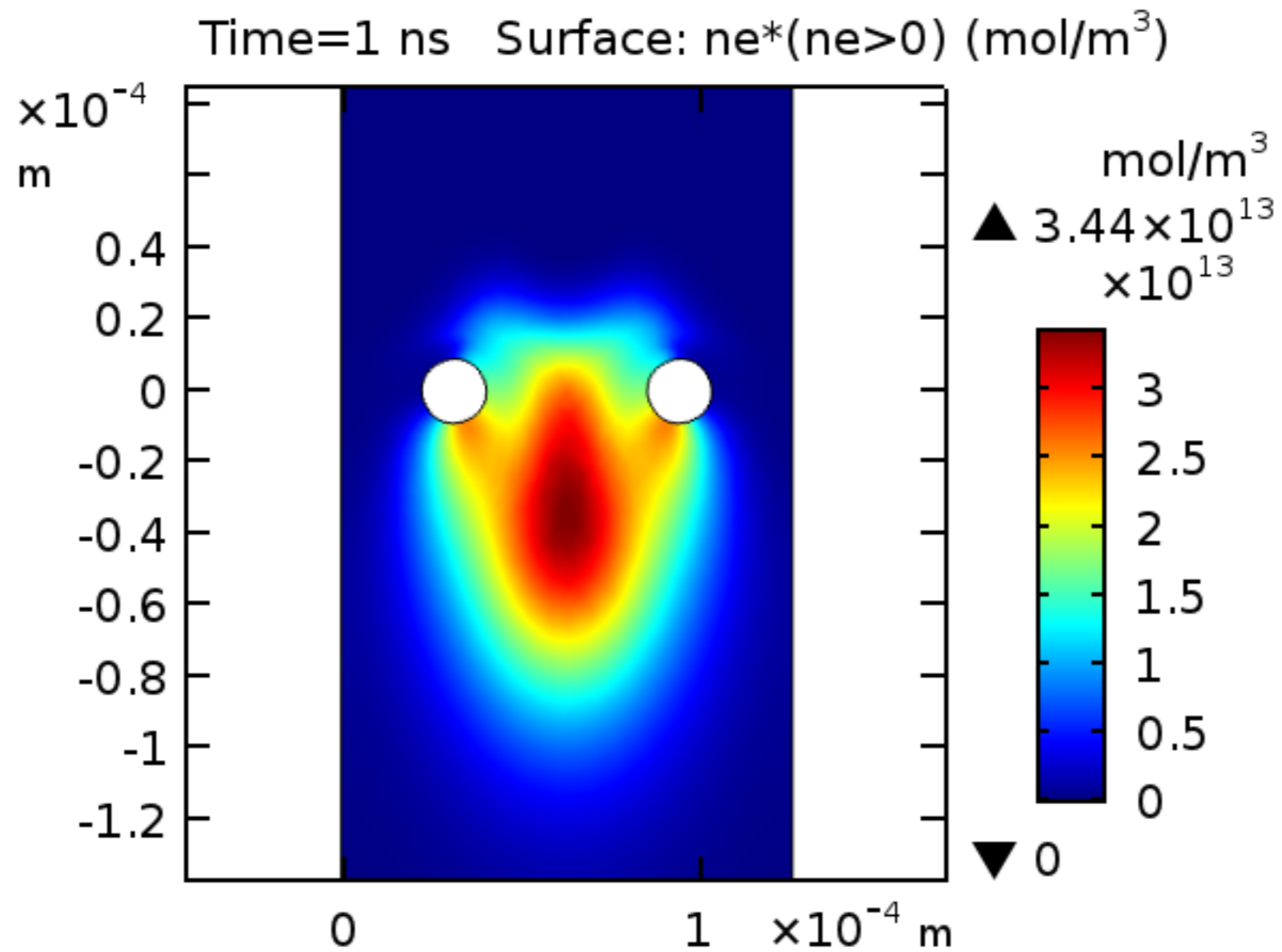
transport of
the electrons
and avalanche

Results:



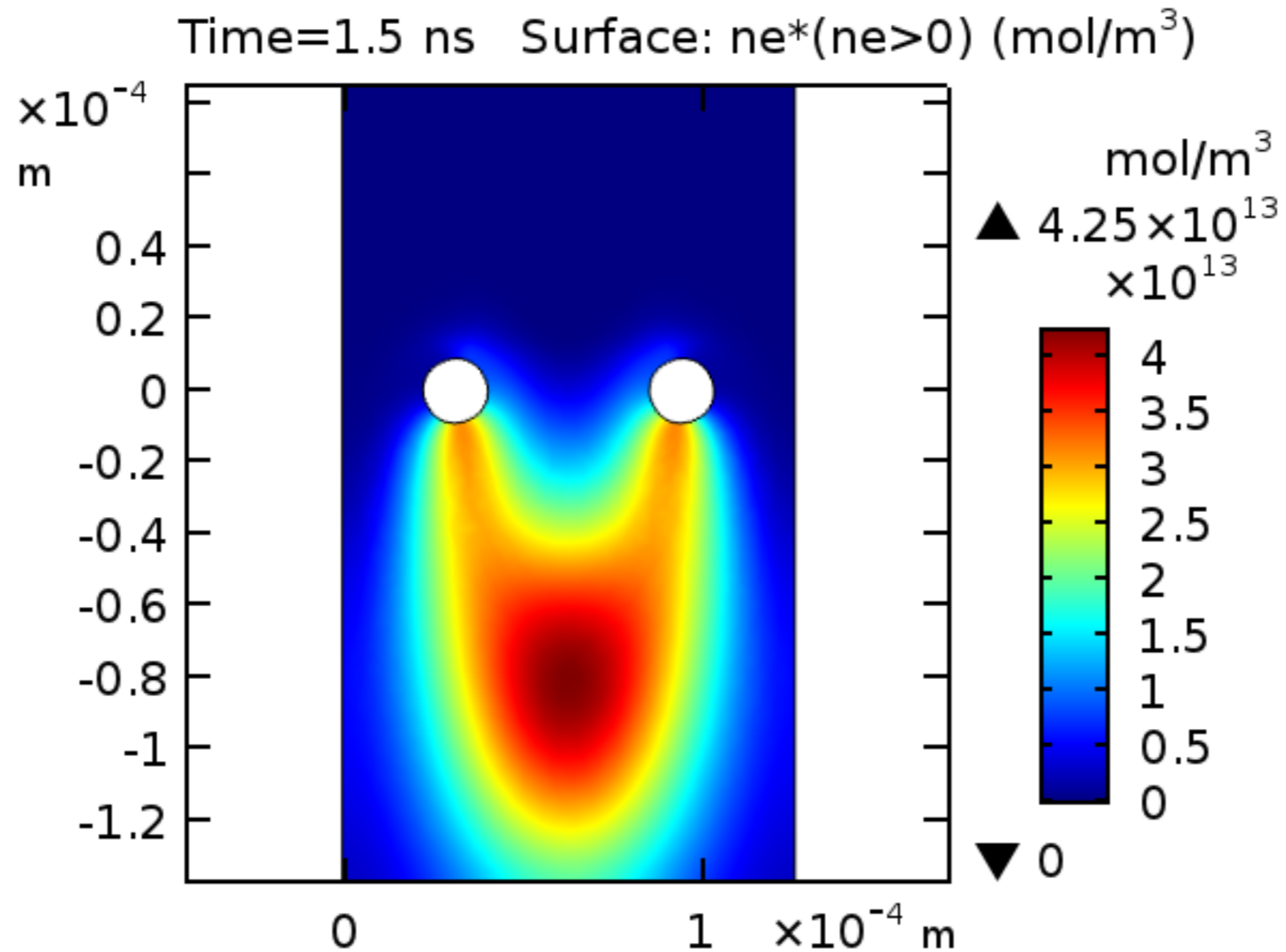
transport of
the electrons
and avalanche

Results:



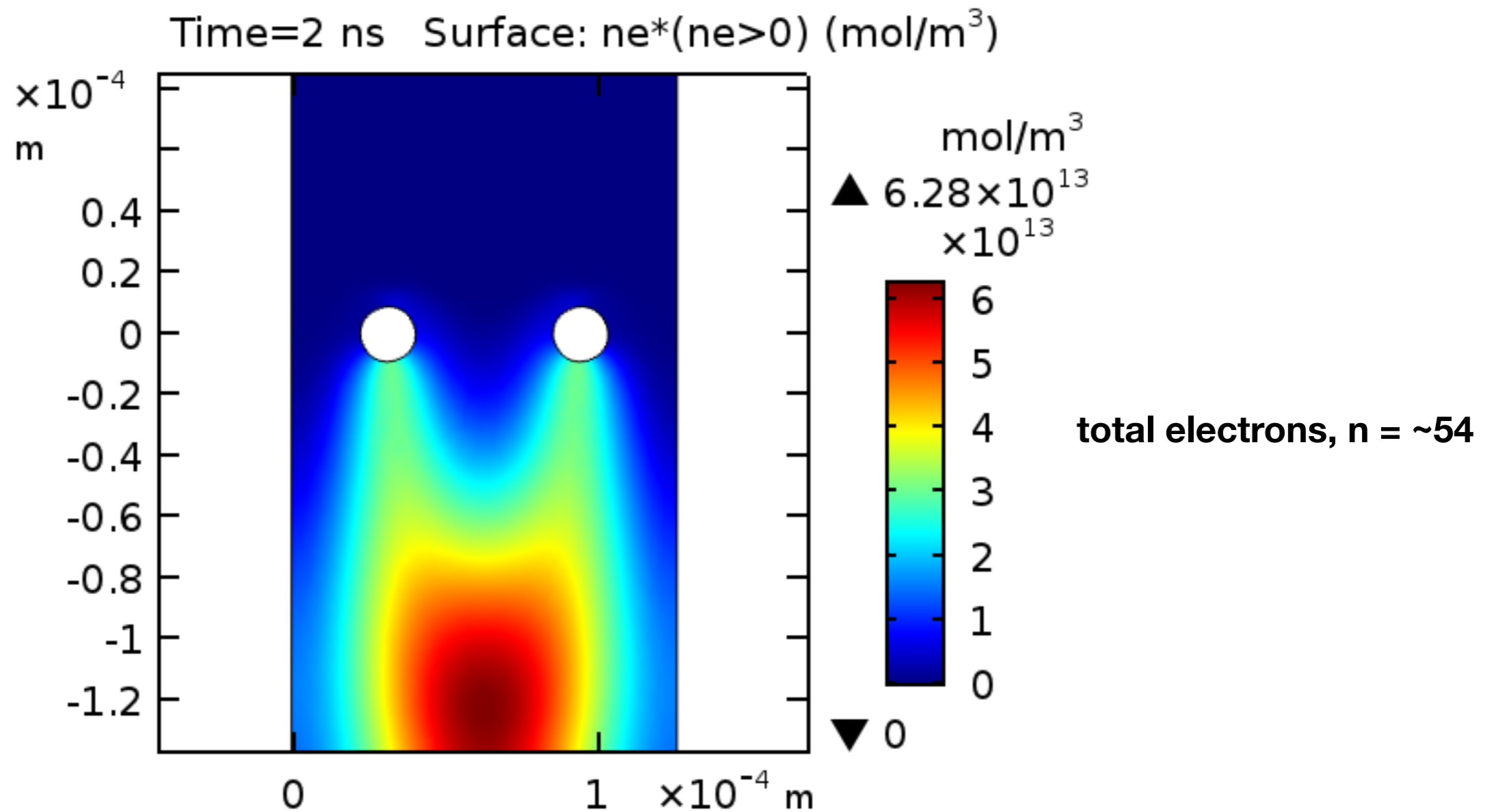
transport of
the electrons
and avalanche

Results:



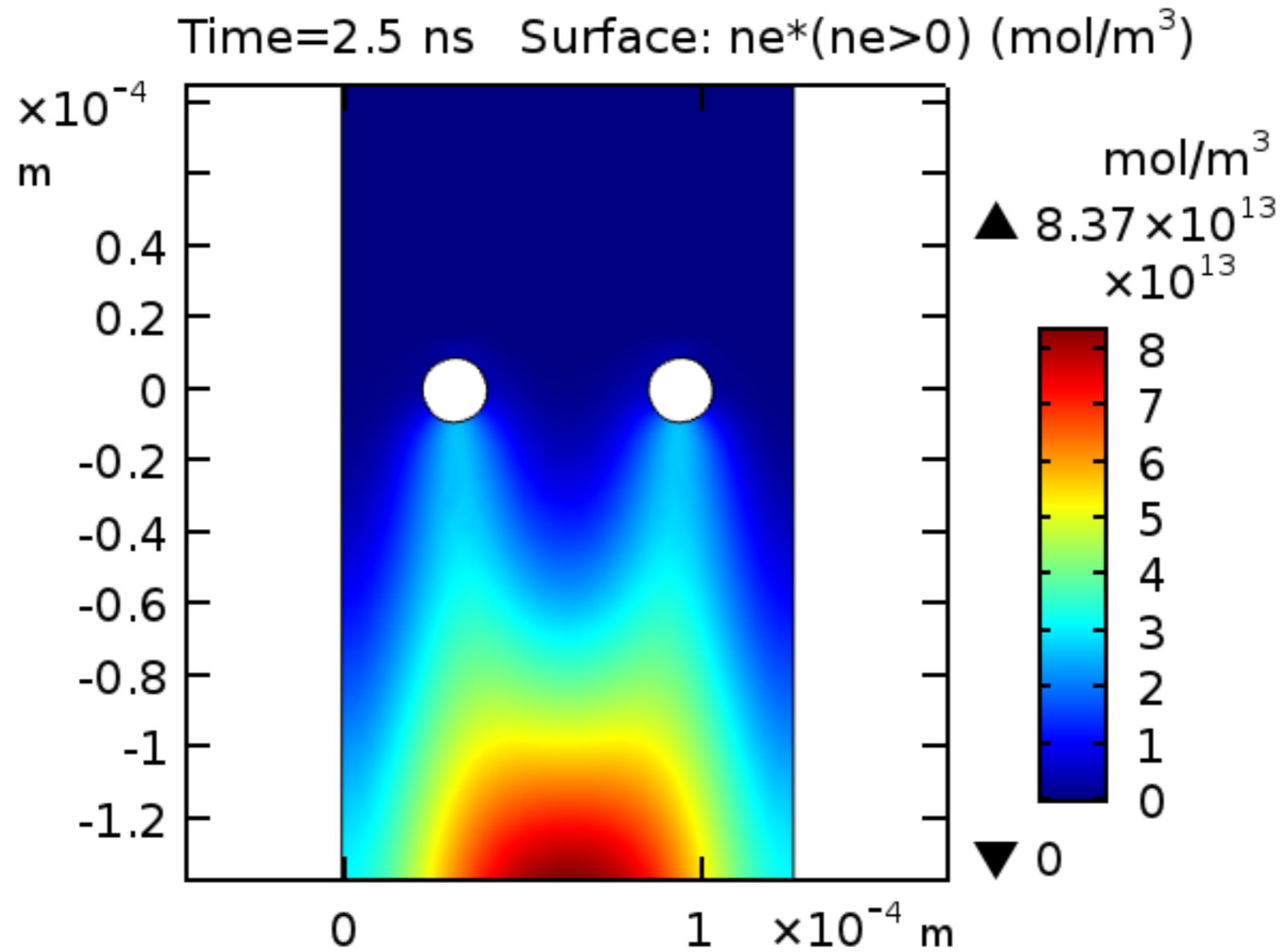
transport of
the electrons
and avalanche

Results:



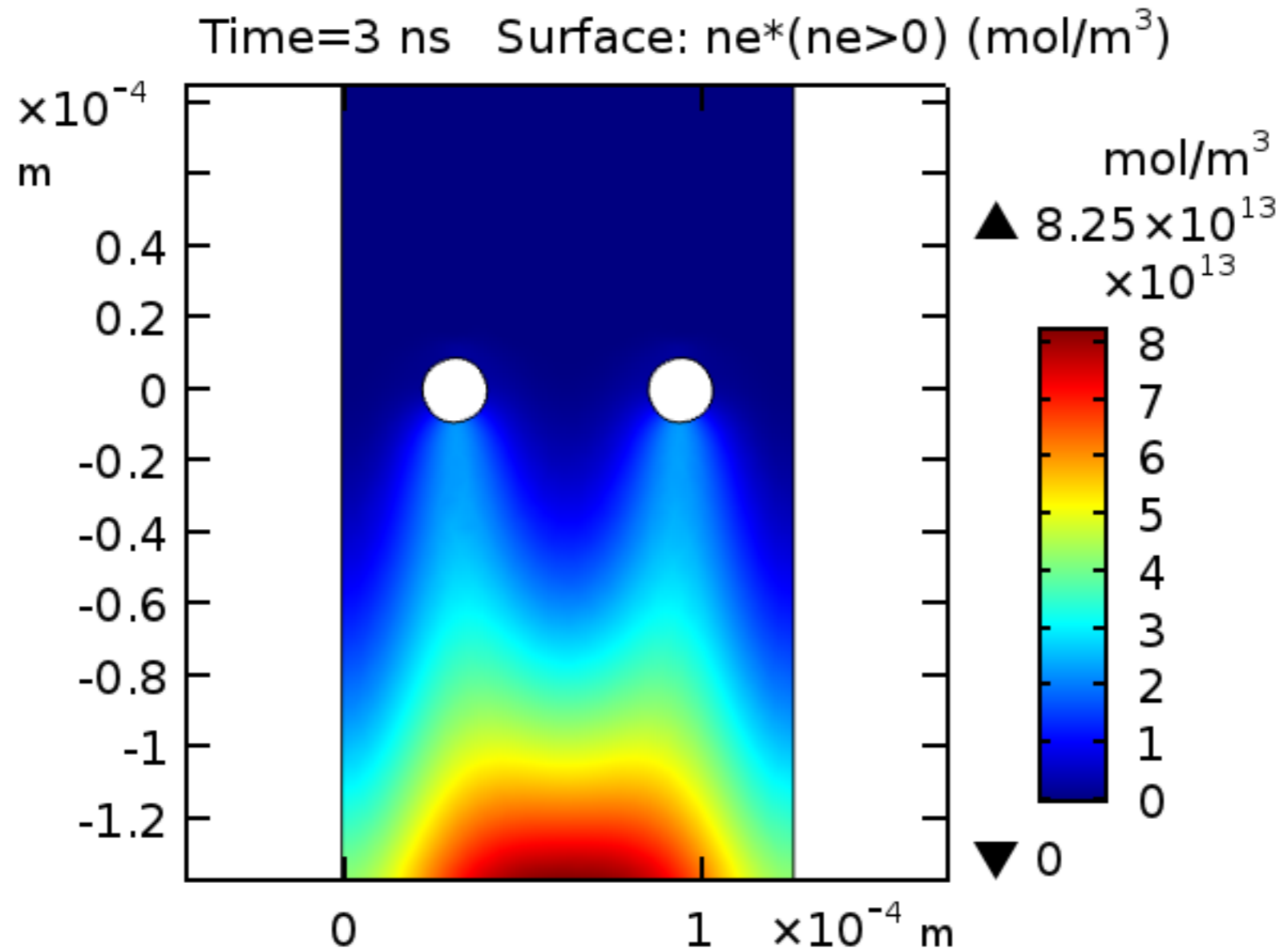
transport of
the electrons
and avalanche

Results:



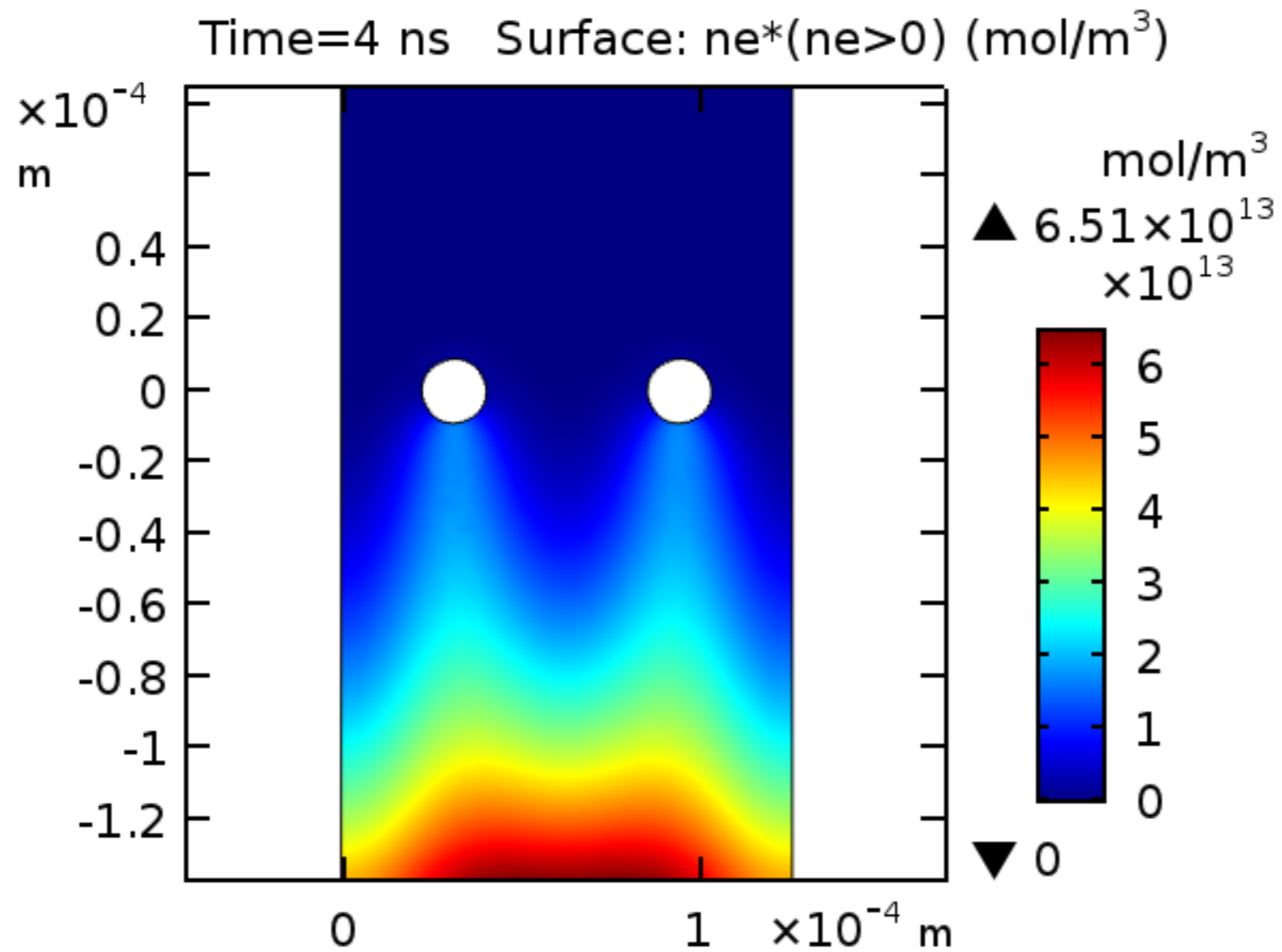
transport of
the electrons
and avalanche

Results:



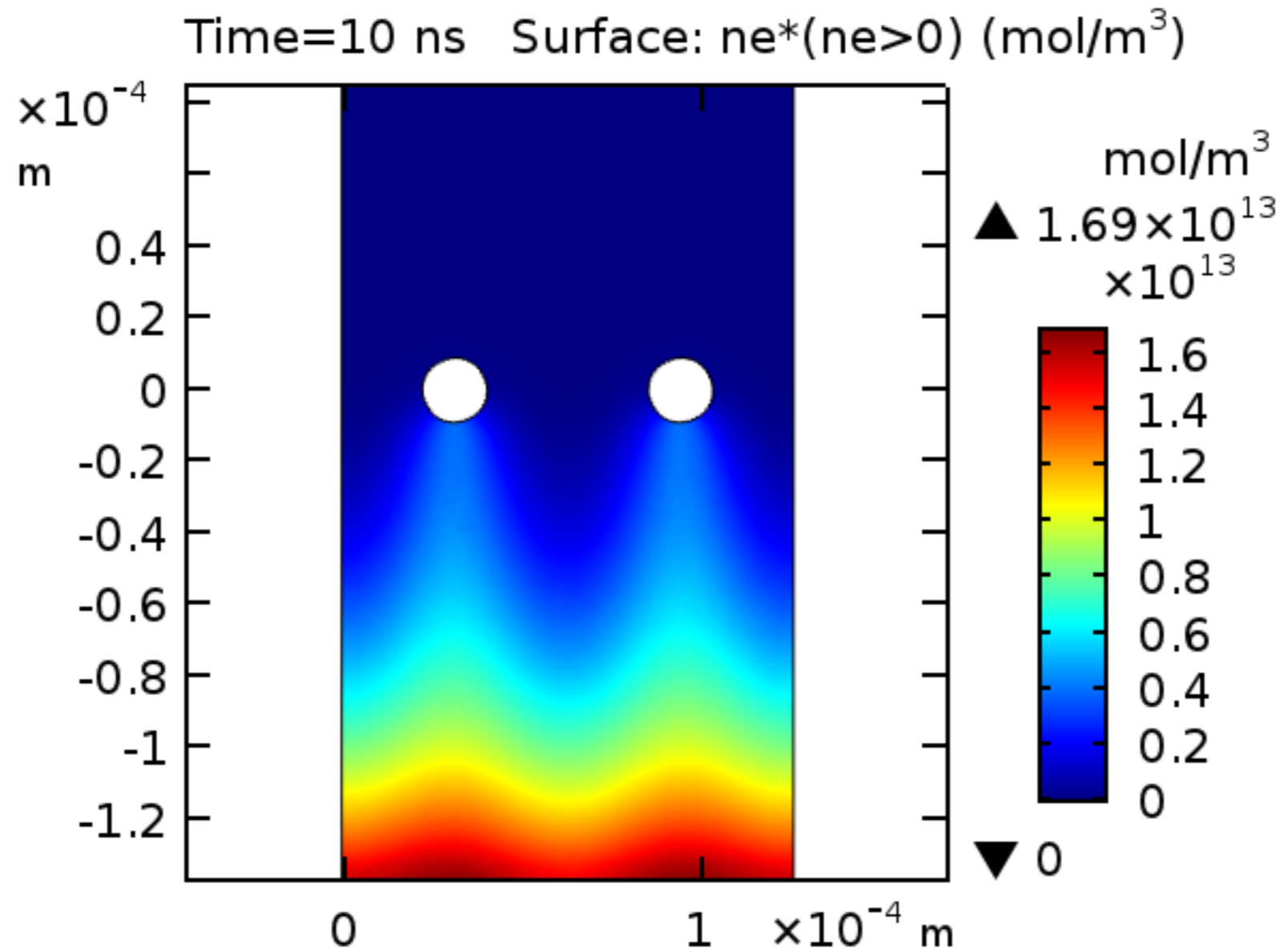
transport of
the electrons
and avalanche

Results:



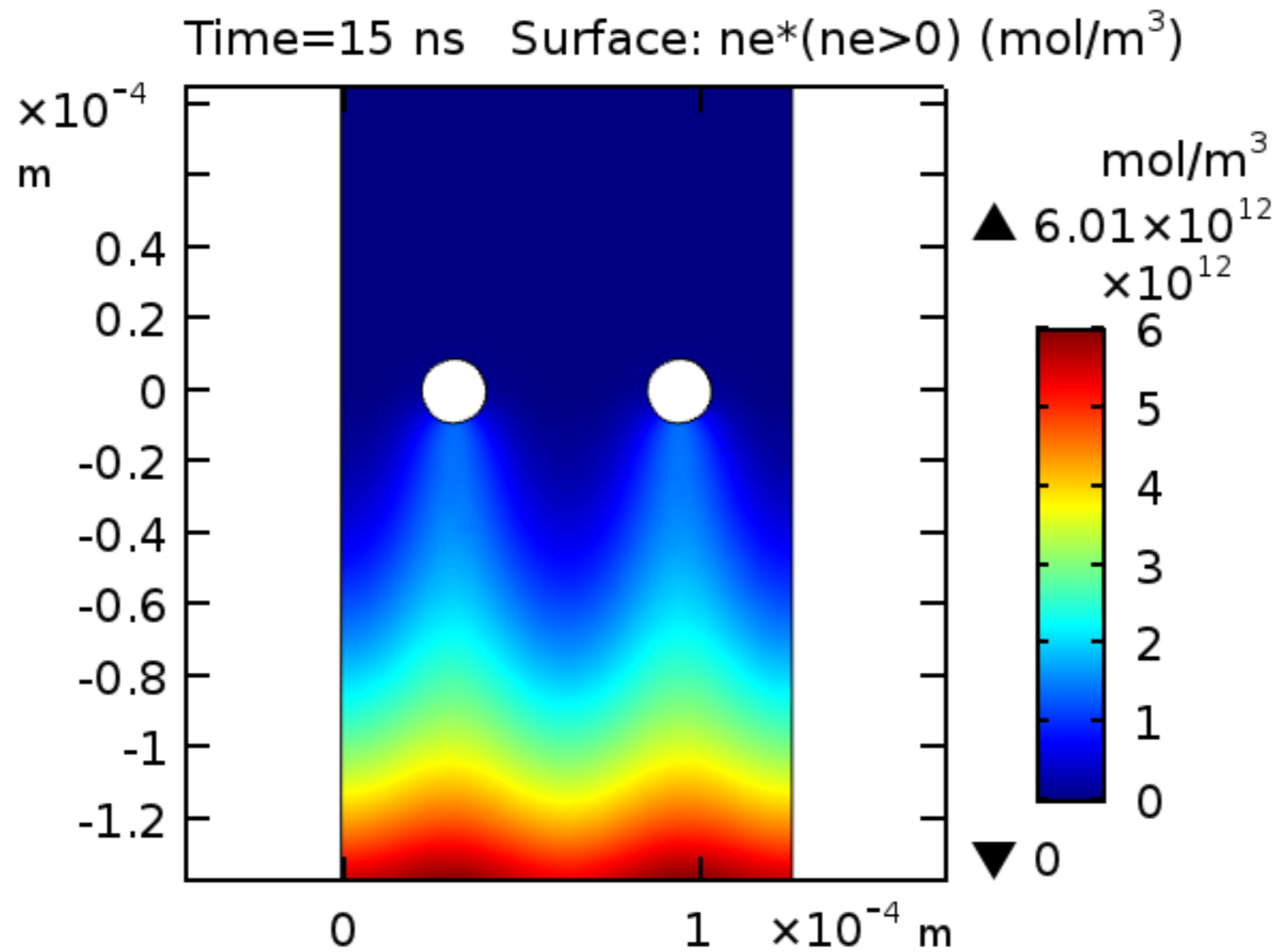
transport of
the electrons
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Results:



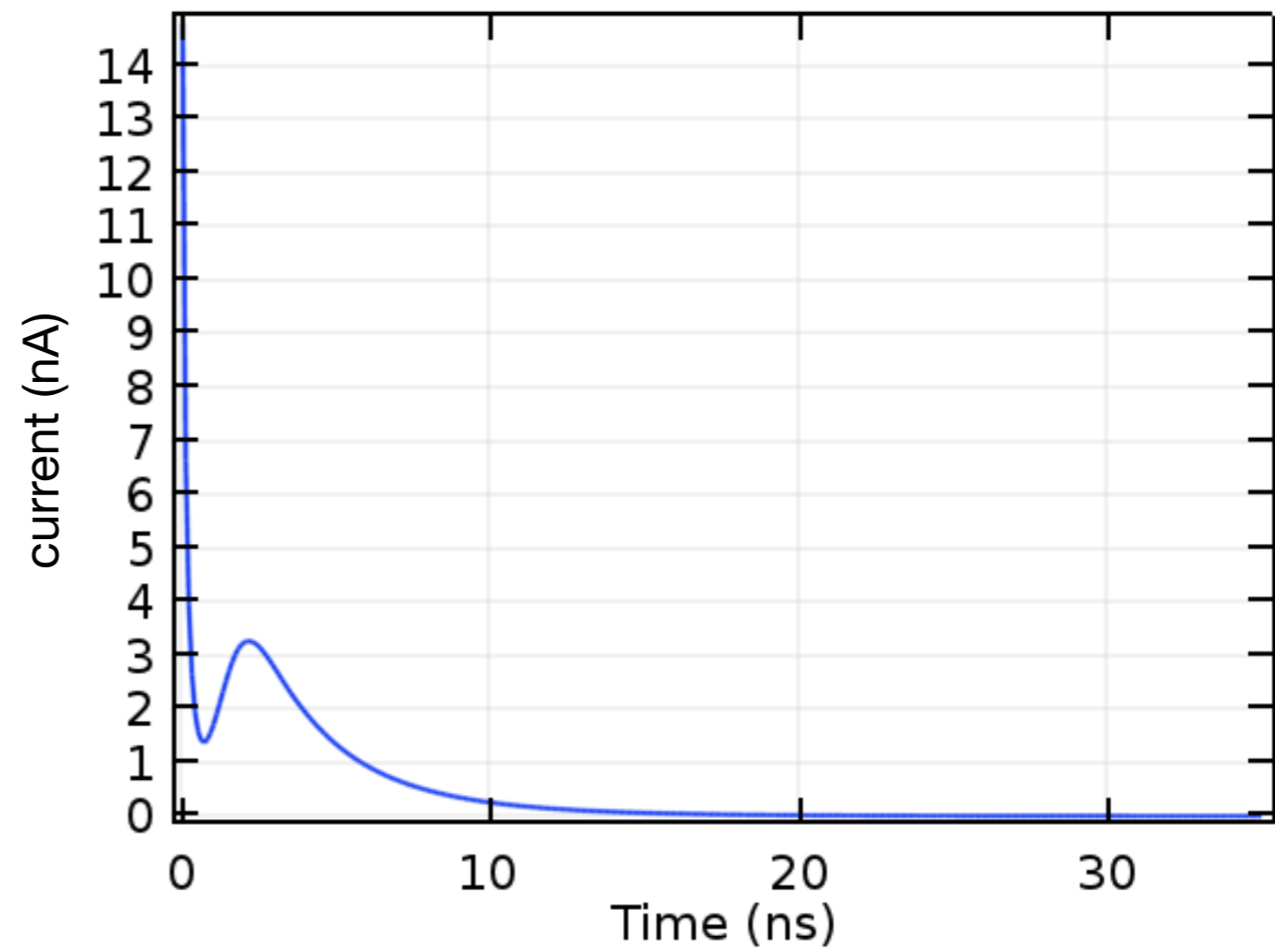
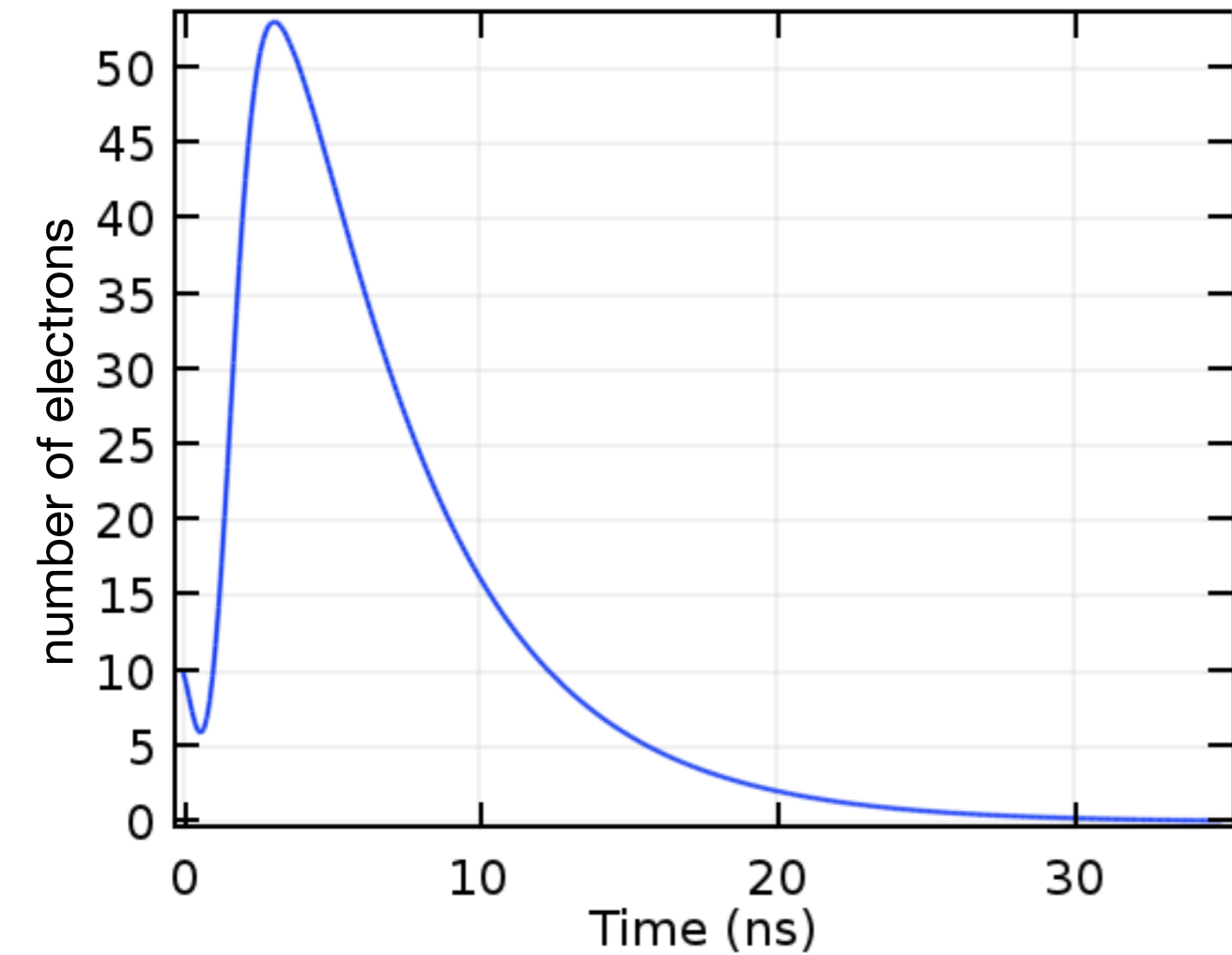
transport of
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Results:



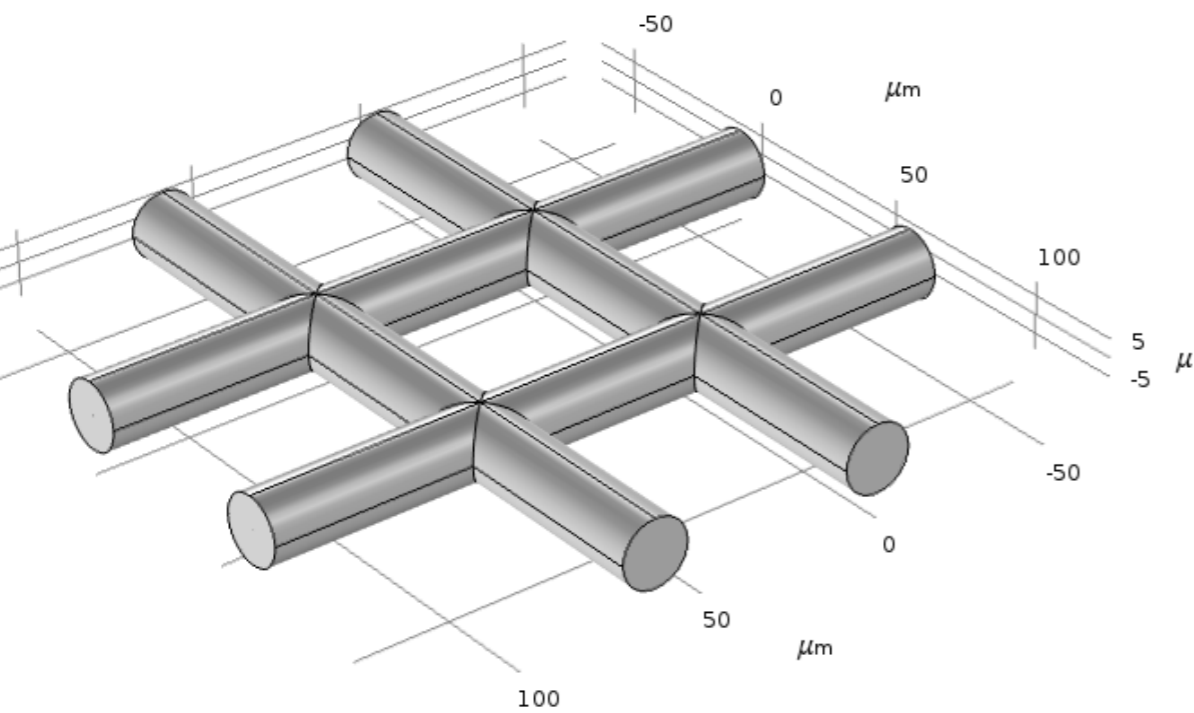
transport of
the electrons
and avalanche

Results: total electron production over time (mesh = -330 V)

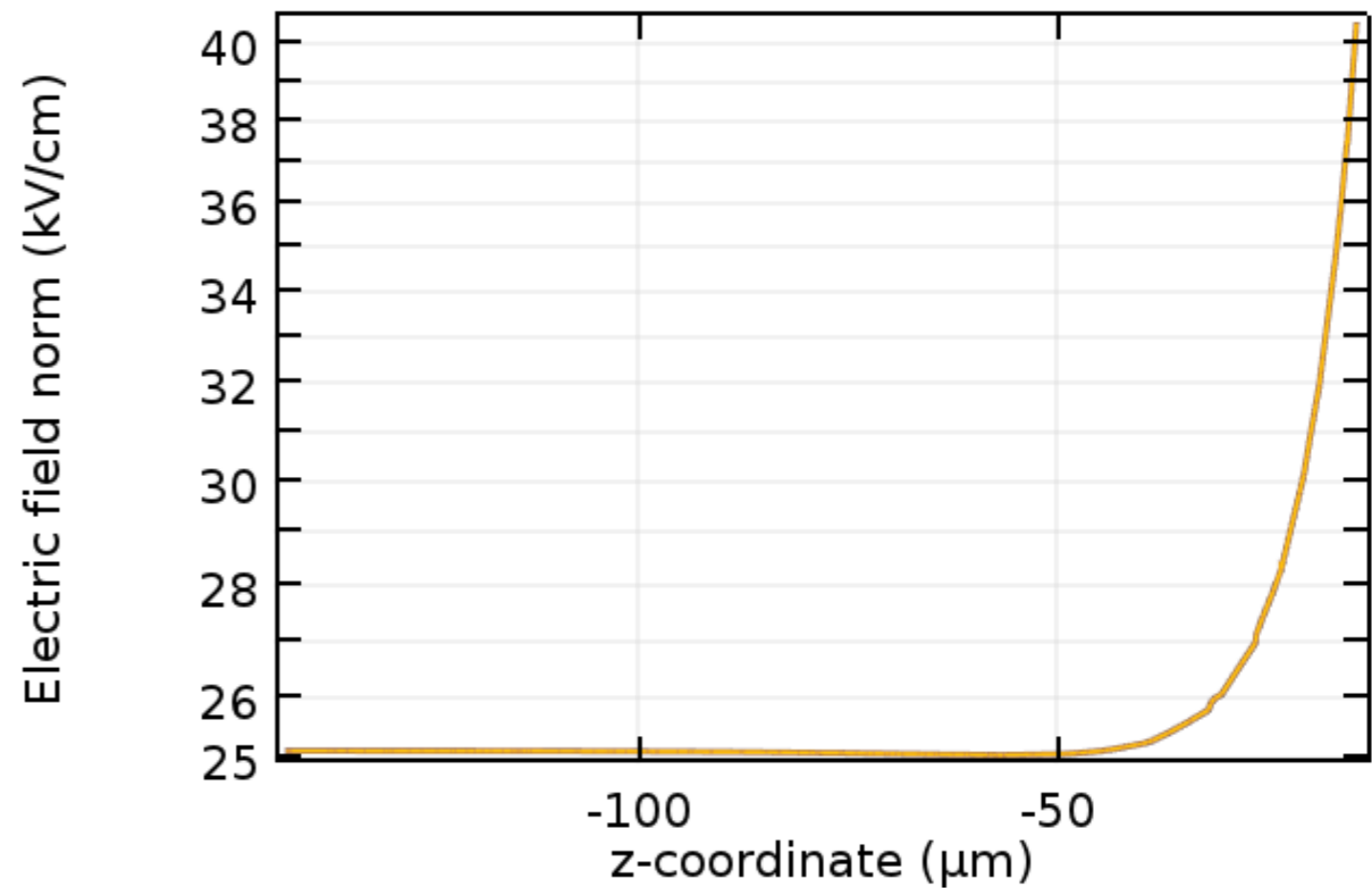


(current or production rate)

28/50 - Calendared-like :



Line Graph: Electric field norm (kV/cm)

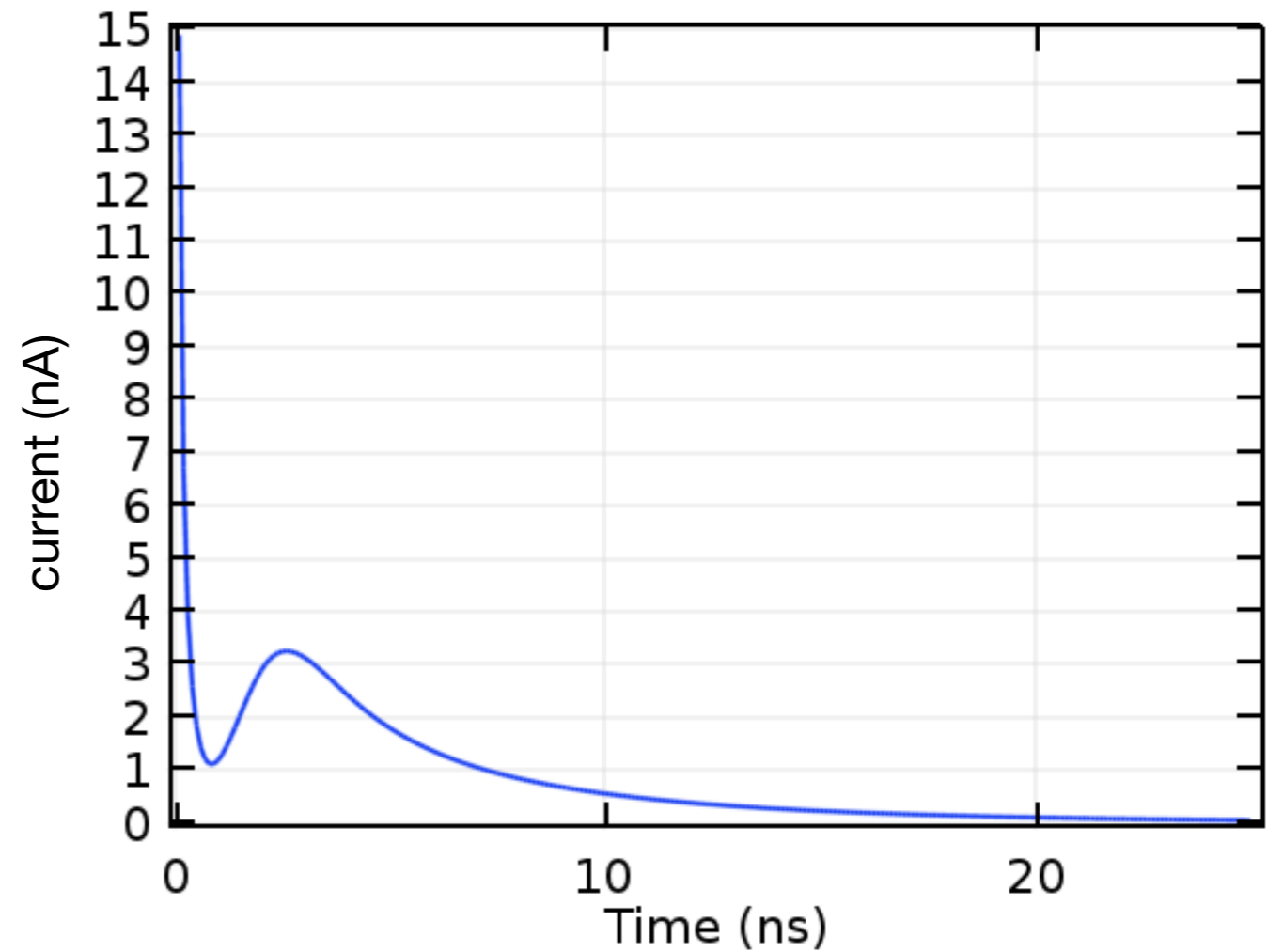
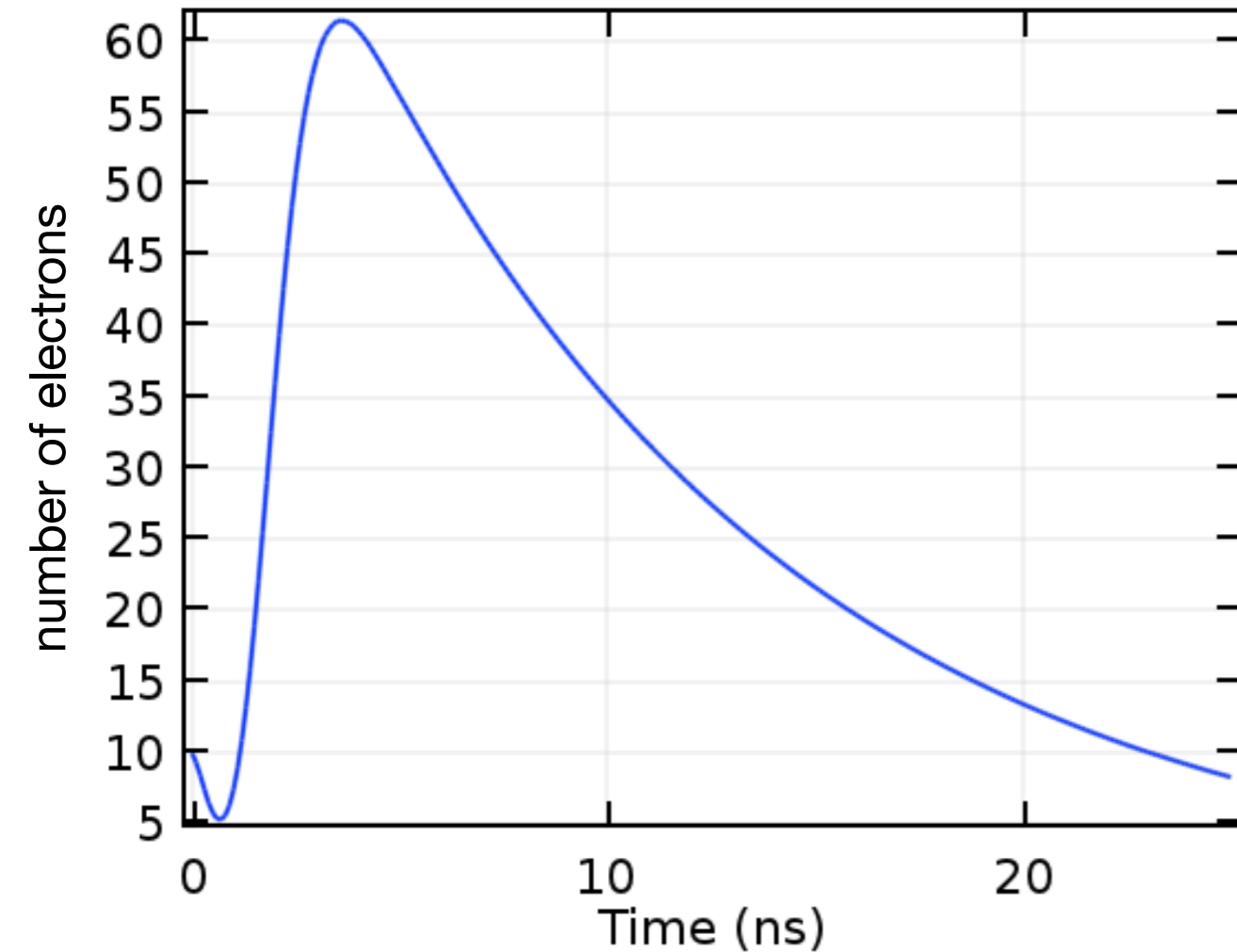


mesh voltage = -330 V

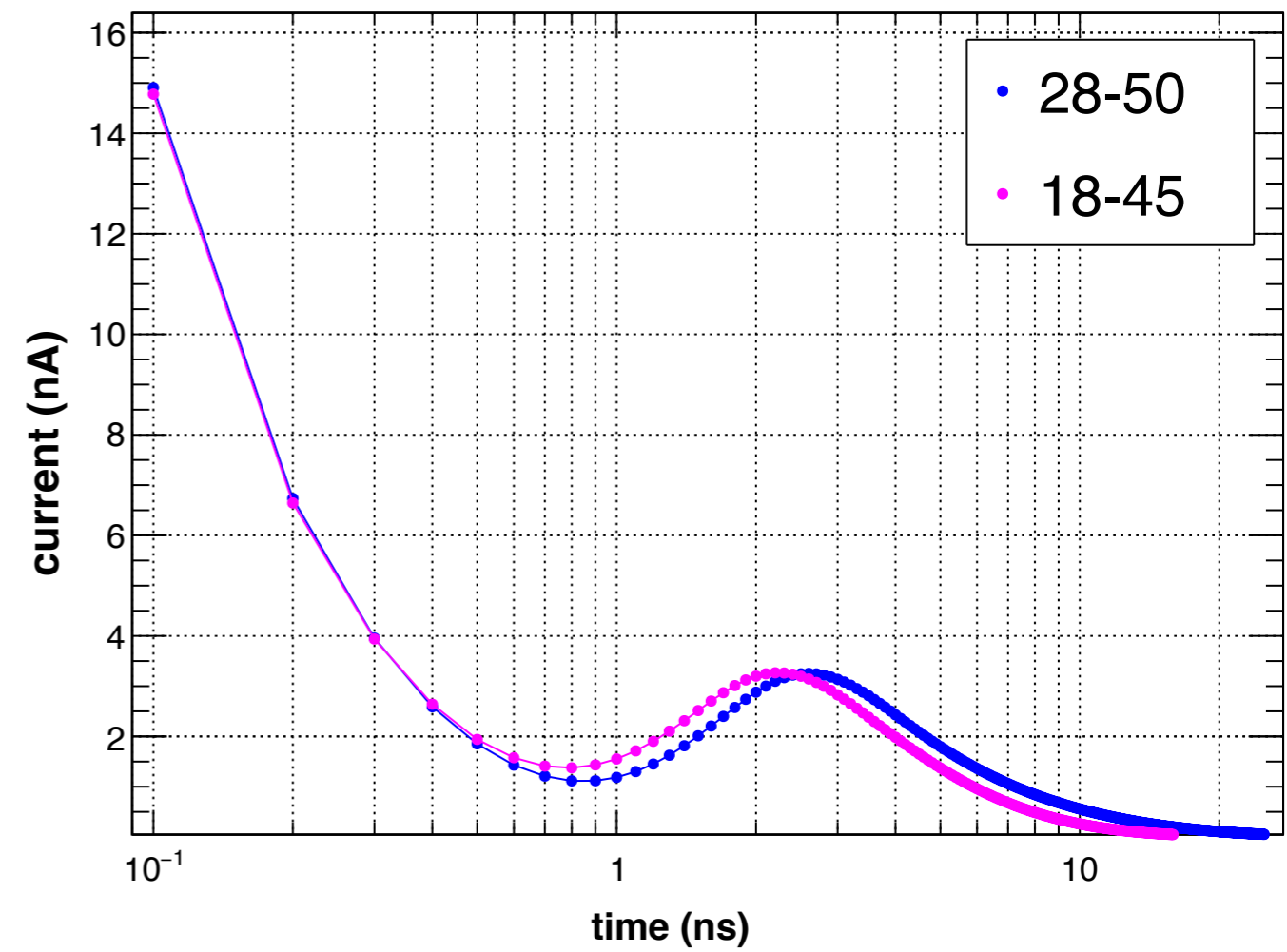
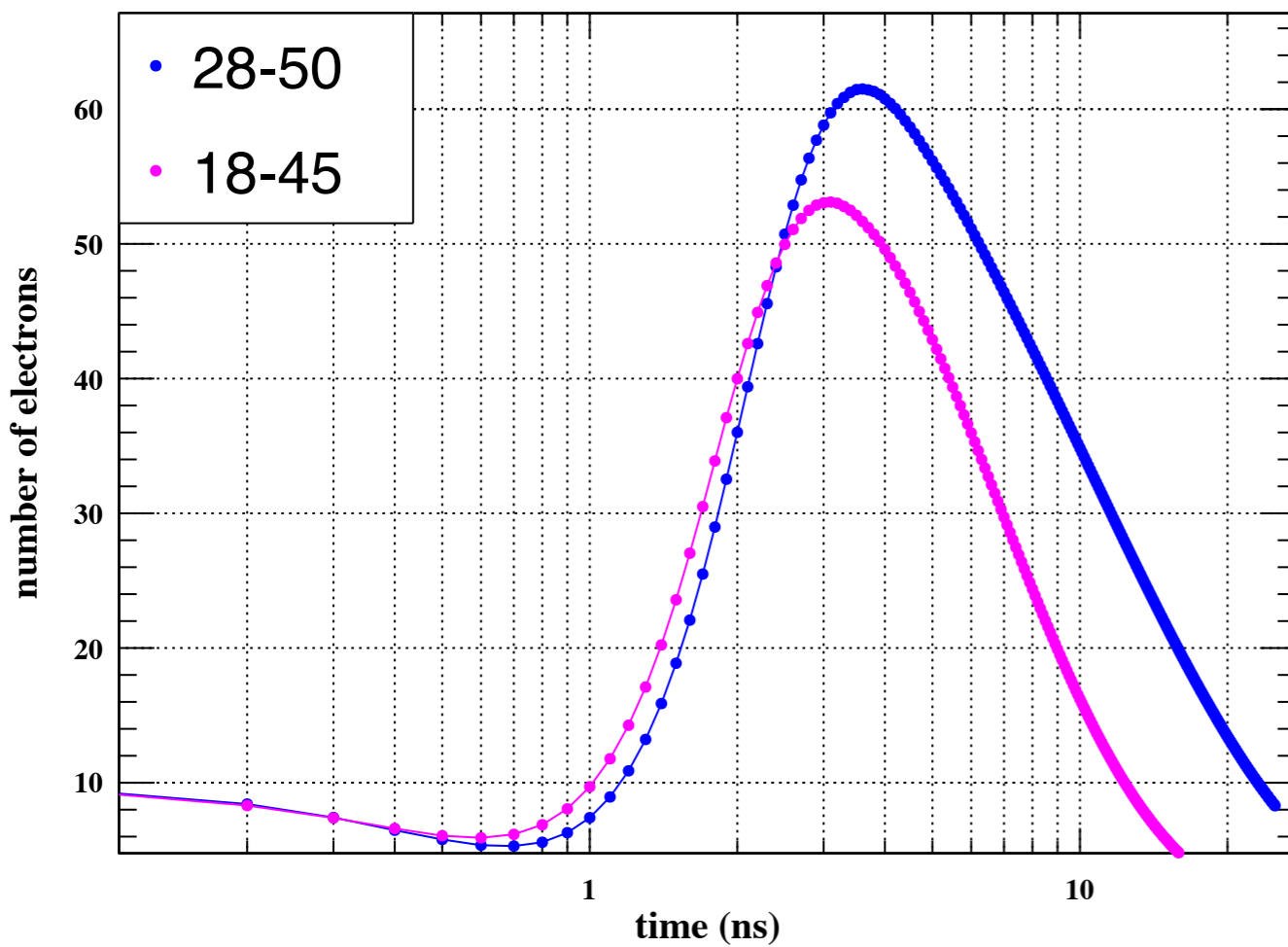
max field = 40.6 kV/cm ; average field = 25.1 kV/cm ;

Results: total electron production over time

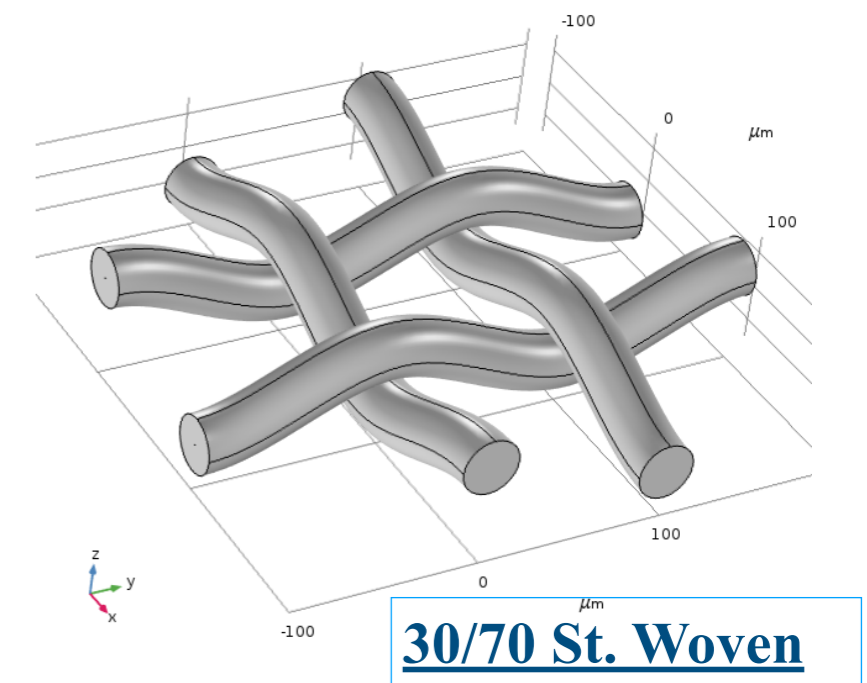
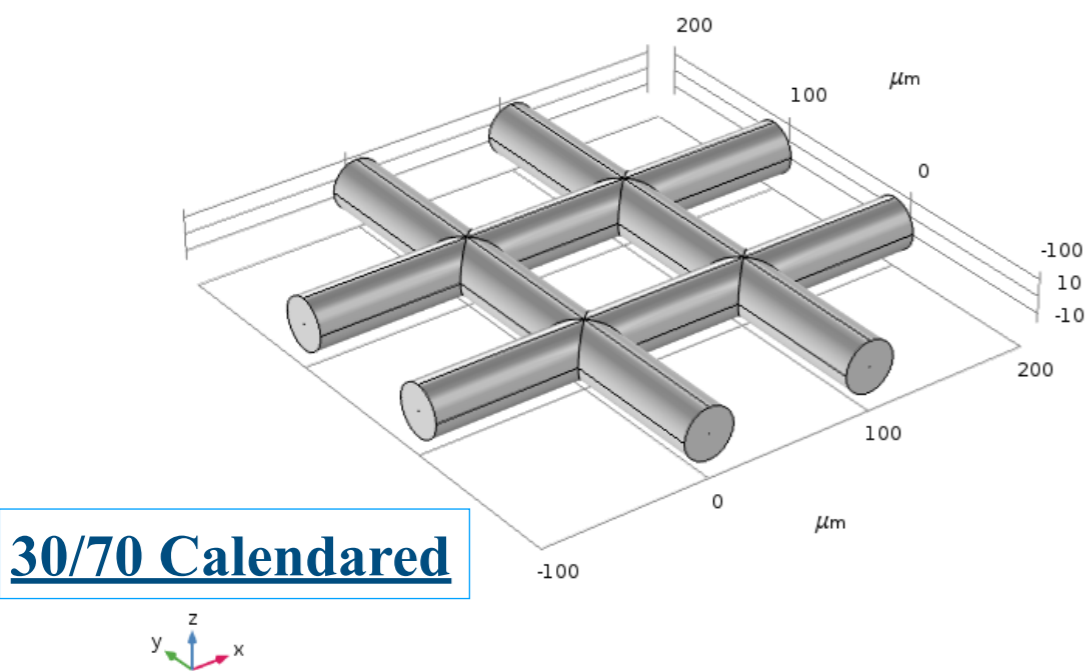
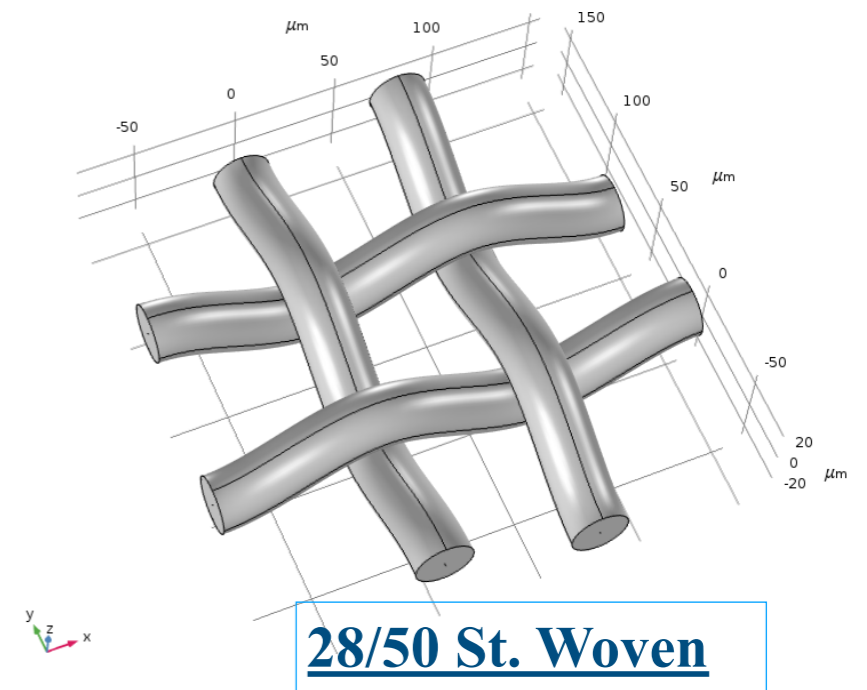
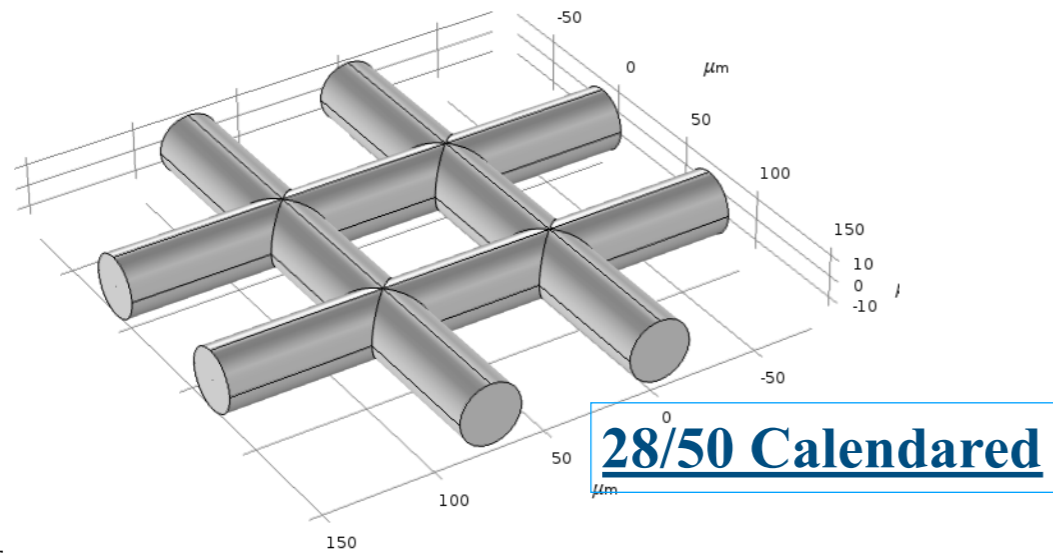
28-50 calendared, mesh voltage - 330 V



Results: compare 18-45 VS 28-50



Field in some other Micromegas (around 30 μm wire diameter) is also studied



to order to generalise, all meshes are set to -540 V for this field study
Amplification gap 128 μm

Calendared

geometry (μm)	Maximum (kV/cm)	Average (kV/cm)	$\epsilon = (\text{max/ave})$
18/45	89.2	~40.5	2.2
22/56	88.3	~40	2.2
25/67	88.5	40	2.2
28/50	79.9	~40	1.9
30/70	84.2	~40	2.1
30/85	88.0	39.5	2.2

symmetric Woven

geometry (μm)	Maximum (kV/cm)	Average (kV/cm)	$\epsilon = (\text{max/ave})$
18/45	112.0	~38.7	2.9
22/56	110.0	~38.0	2.9
25/67	109.0	~37.5	2.9
28/50	104.0	38.2	2.7
30/70	104.0	~37.2	2.8
30/85	106.0	~36.5	2.9

Calendared would be a better choice over woven for HV stability

Conclusion:

- the occurrence and development of spark in 128 μm gap parallel plate is modelled
- dependence of humidity is shown in it
- regions with high electric field in different Micromeas geometry are identified
- a narrow voltage scan is performed to observe spark in 18-45 and 28-50
- influence of geometry is observed primarily; 28-50 and 18-45 show similar behaviour

Many many thanks to

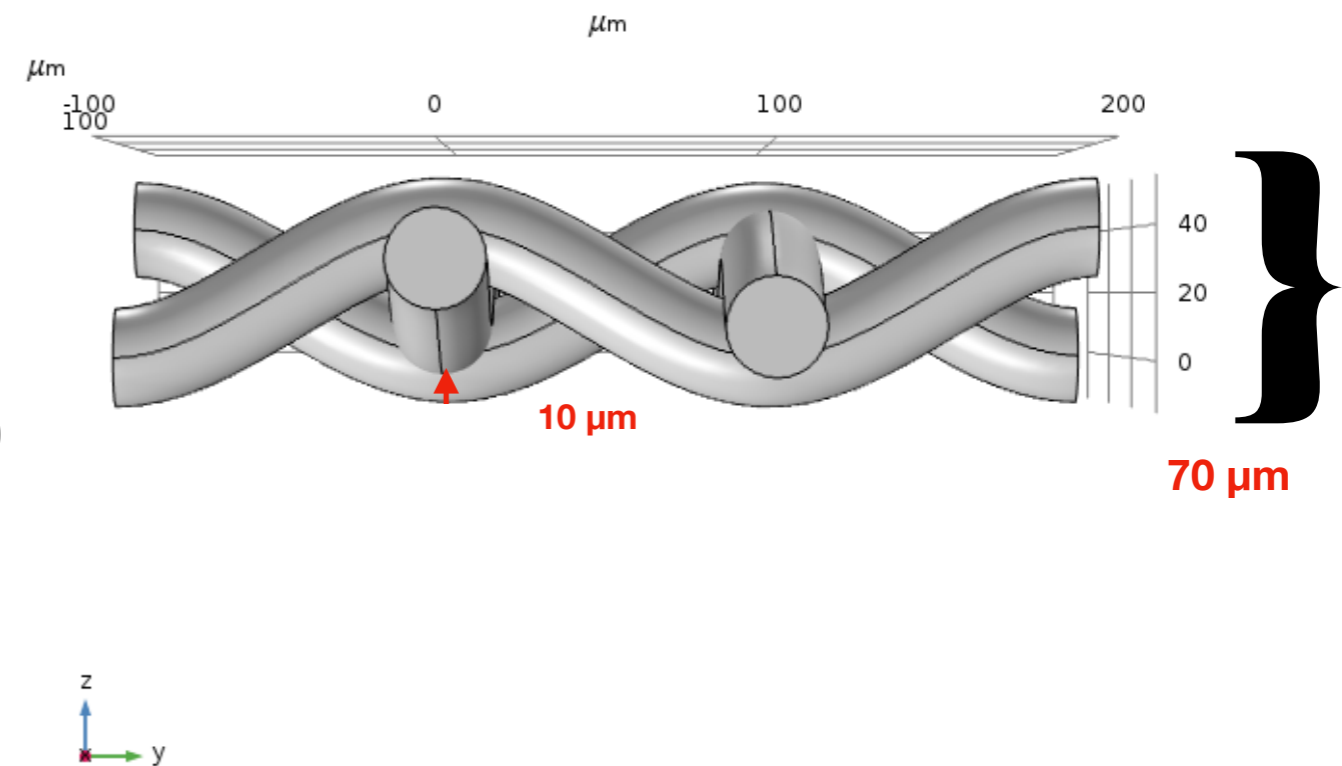
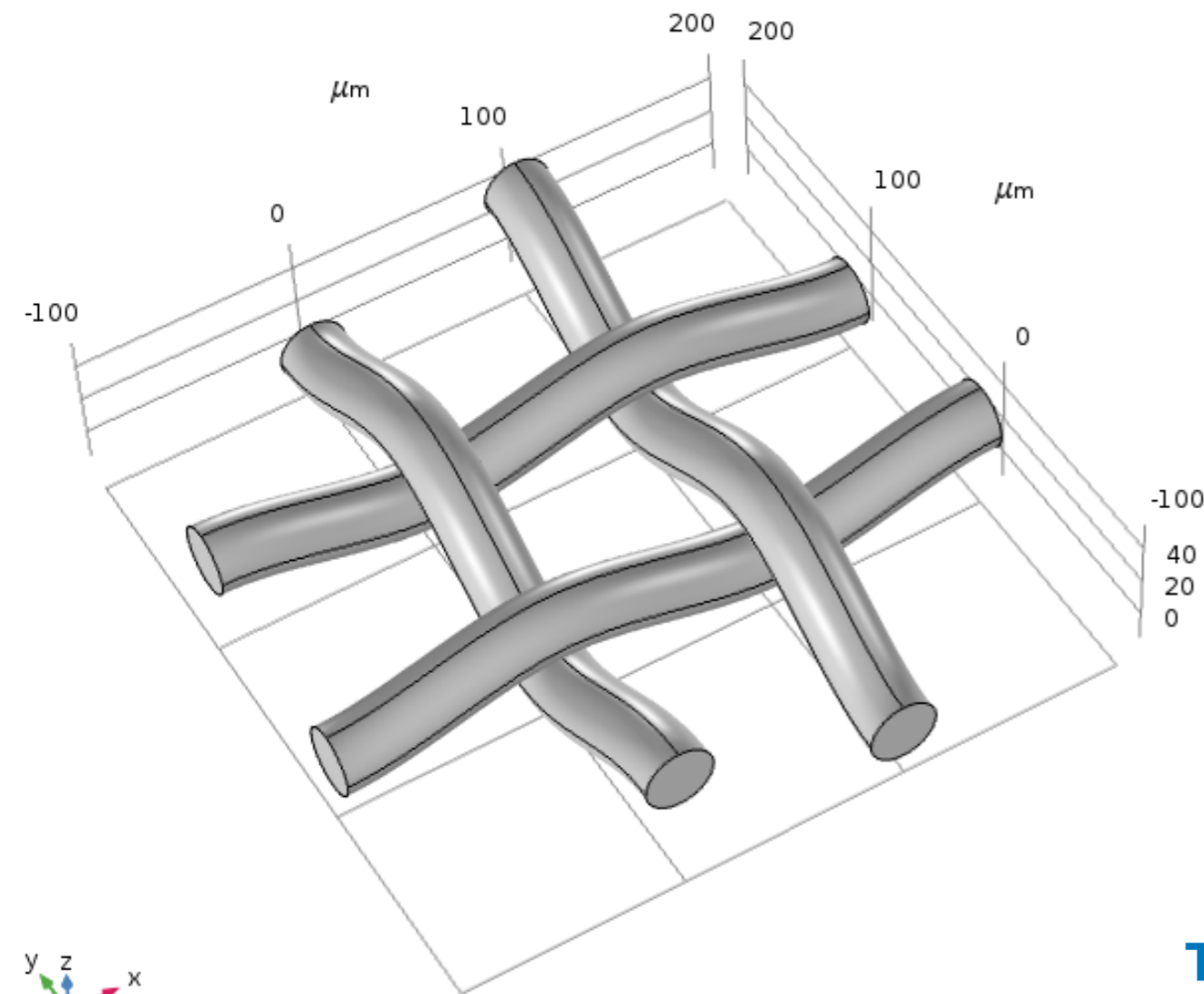
Filippo Resnati

and the RD51 colleagues (specially Leszek, Fabio, Paul, Supratik)

for discussions and encouragement

Backup slides

The weaving is some times not symmetric (mesh thickness)



- Wire diameter 30 μm
- Edge to Edge 70 μm
- Axis to Axis 100 μm

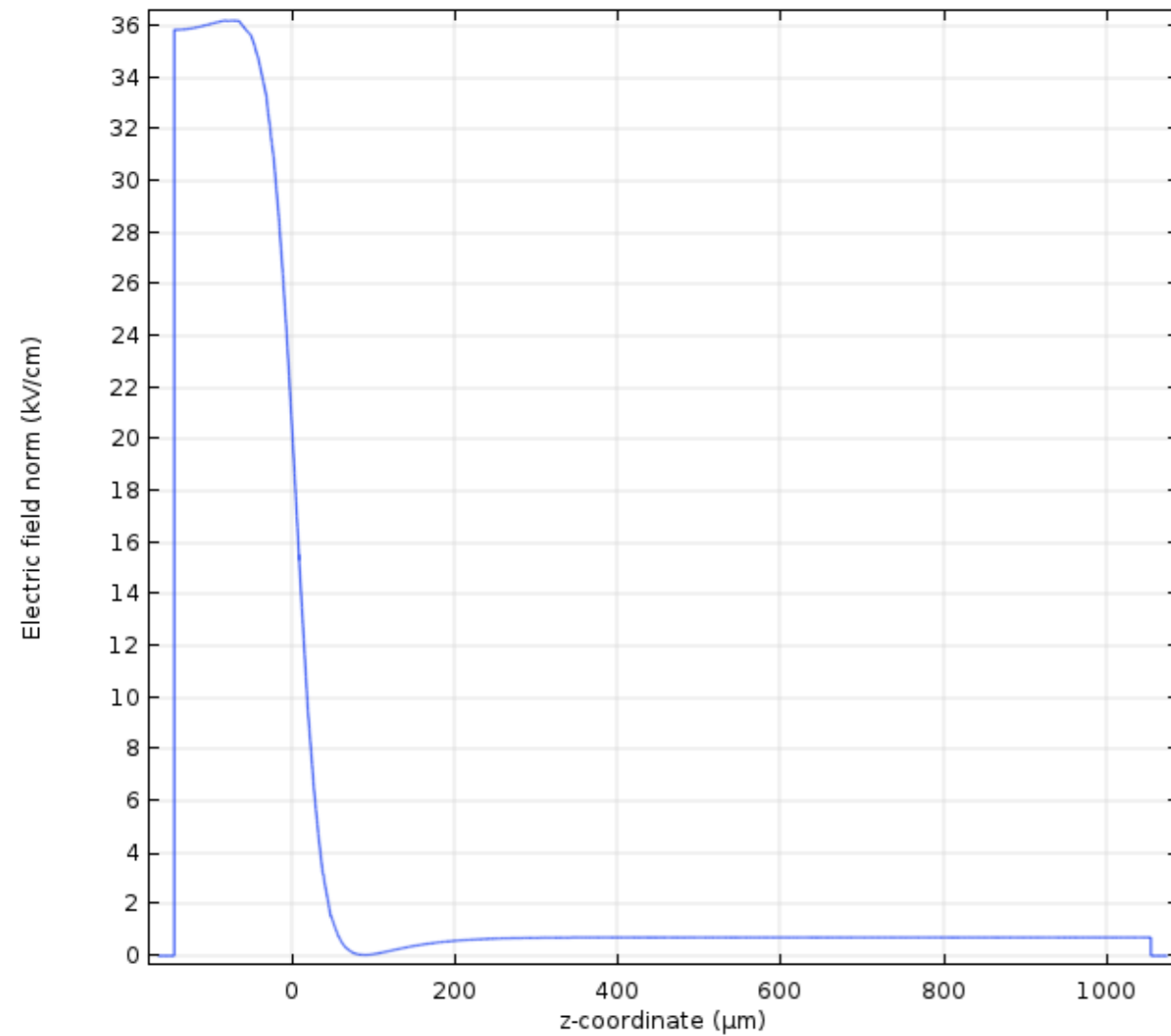
The weaving amplitudes are different by 10 μm

rest of the geometry is same as the last one

The field through the centre of the hole

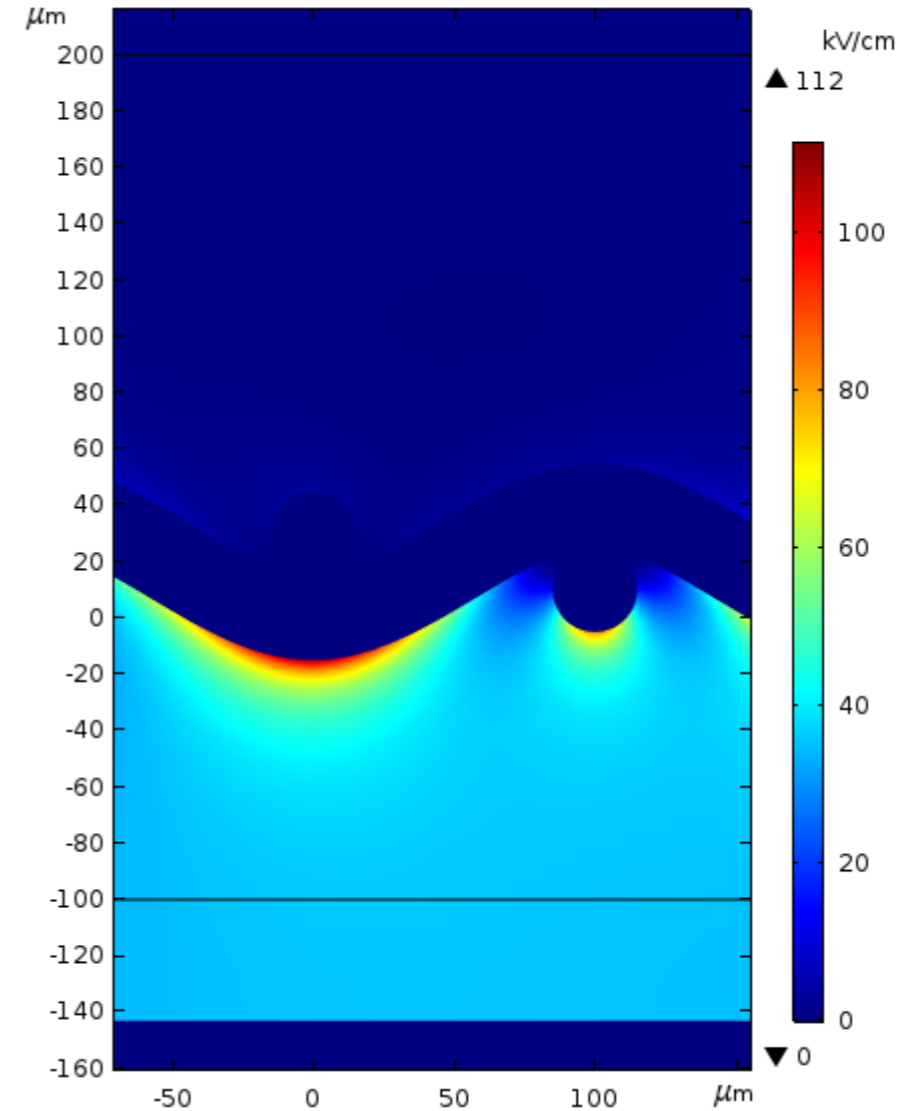
The field contour (on the YZ plane, at X=0)

Line Graph: Electric field norm (kV/cm)



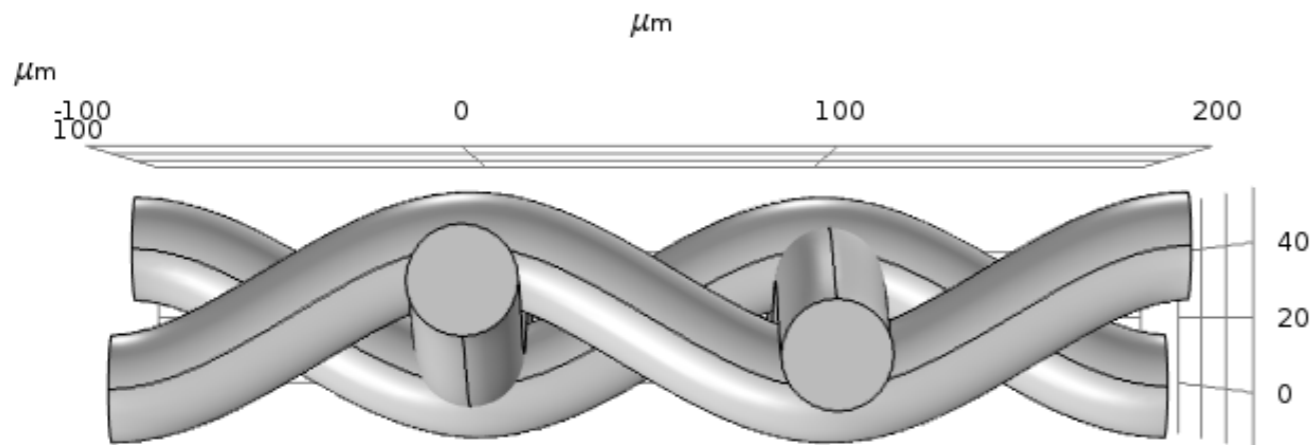
The average field is as expected

Surface: Electric field norm (kV/cm)

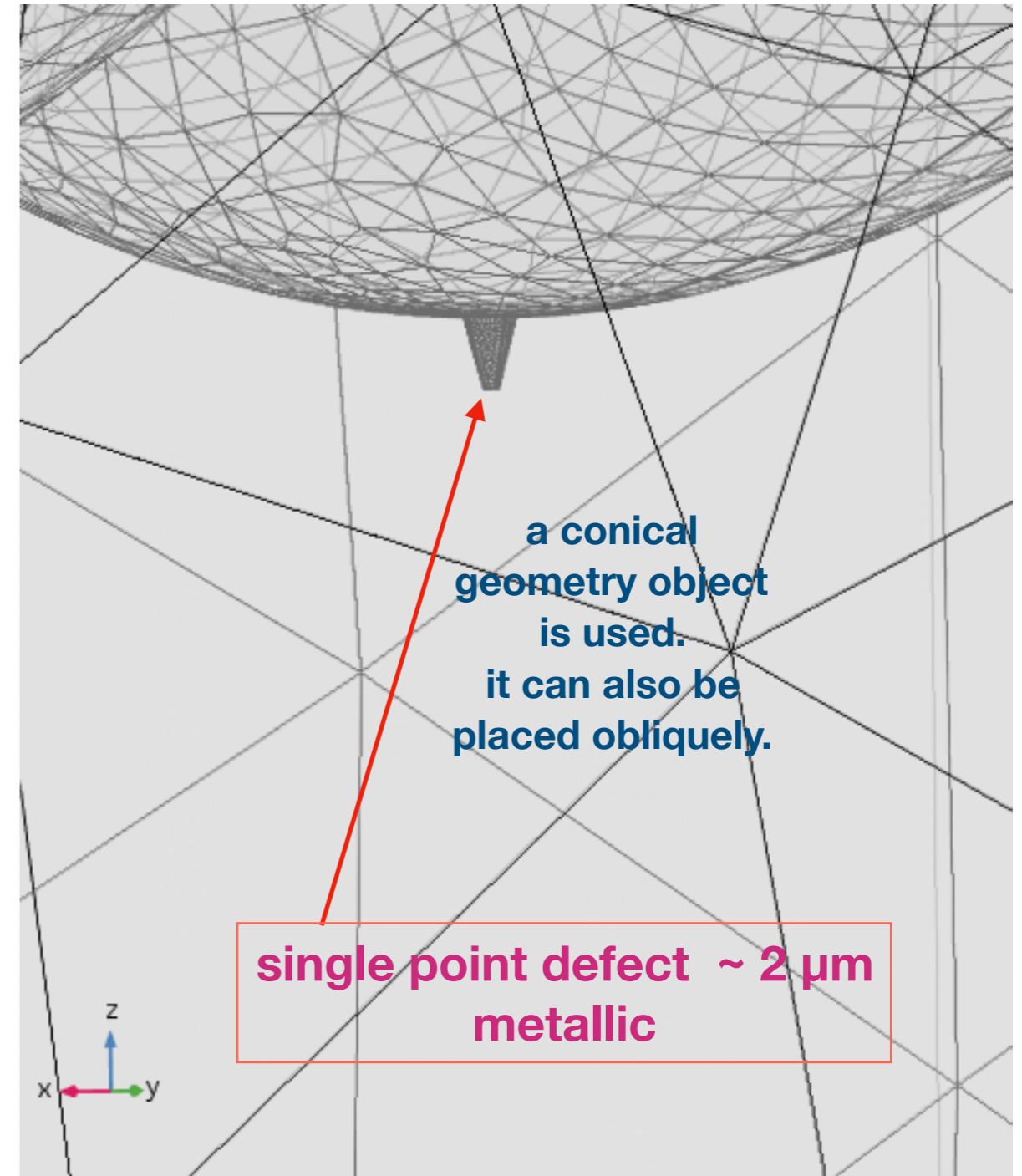


The maximum field is ~ 7% higher than standard woven

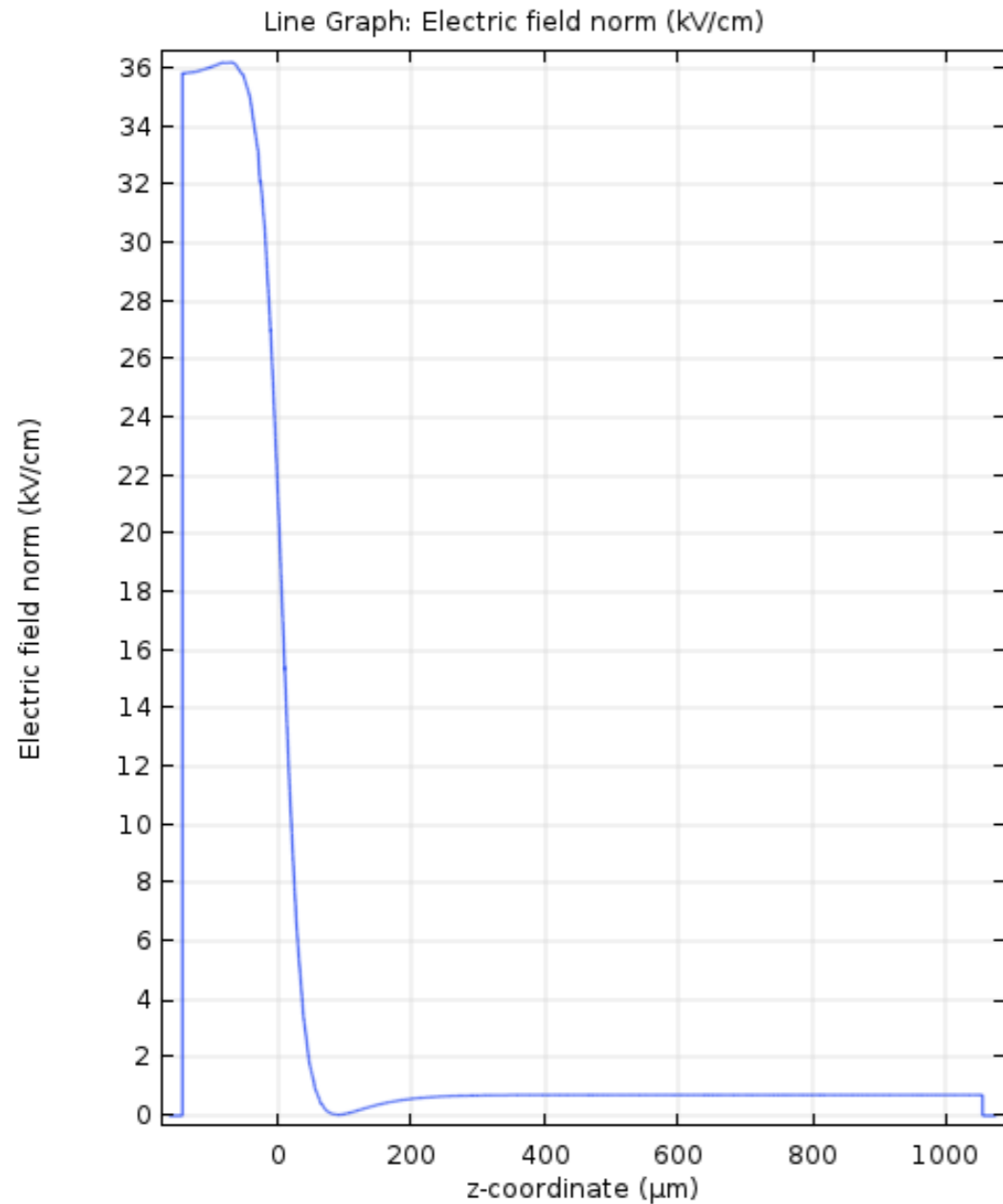
if there is any defect on the mesh surface



- **Wire diameter 30 μm**
- **Edge to Edge 70 μm**
- **Axis to Axis 100 μm**

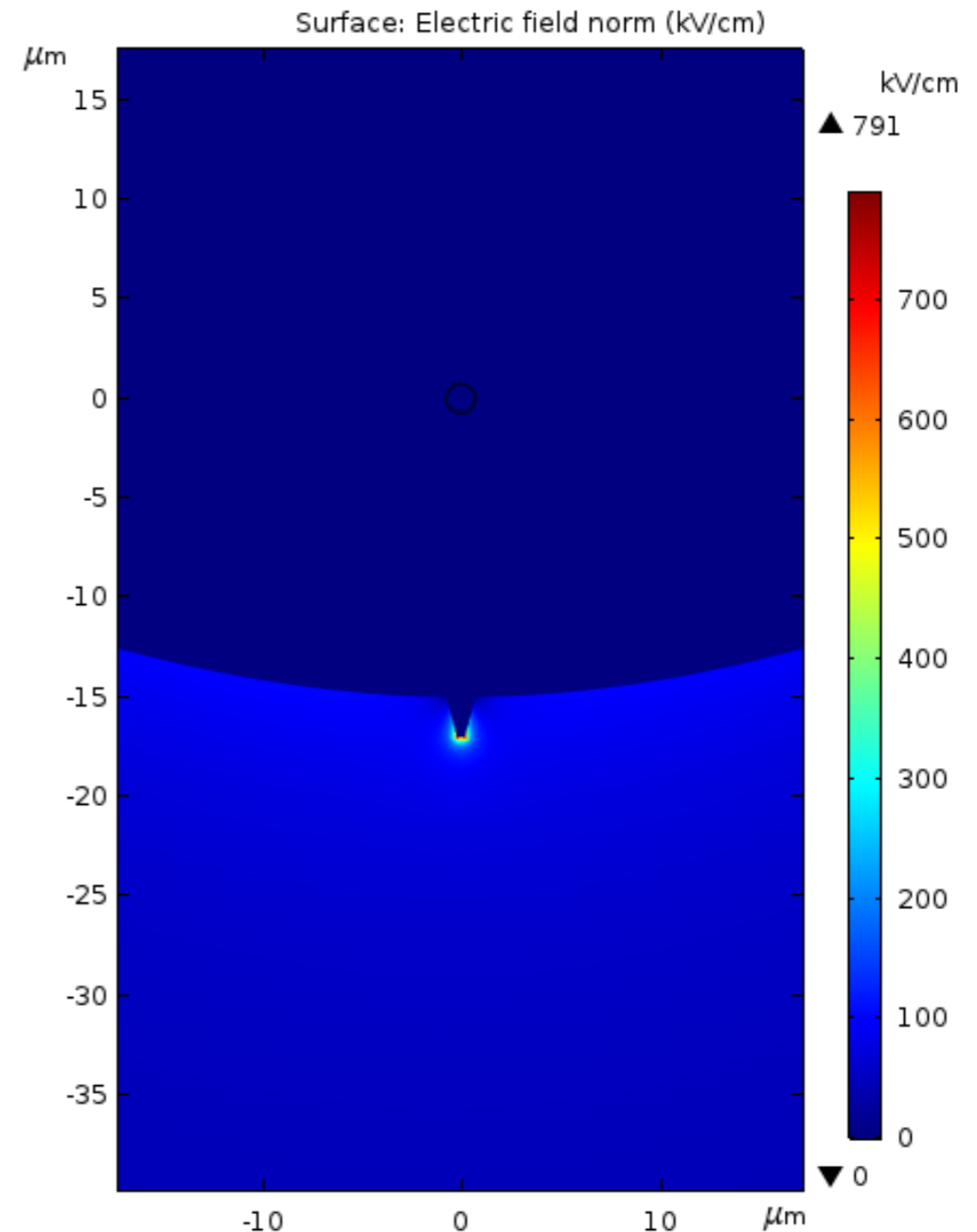


The field through the centre of the hole



this remains as before

The field contour (on the YZ plane, at X=0)



A very high field is
localised around the defect

18-45
mesh= -350 V

